

(12) UK Patent Application (19) GB (11) 2 316 208 (13) A

(43) Date of A Publication 18.02.1998

(21) Application No 9715131.0

(22) Date of Filing 17.07.1997

(30) Priority Data

(31) 08213882	(32) 13.08.1996	(33) JP
08339988	19.12.1996	
09089516	08.04.1997	

(71) Applicant(s)

Fujitsu Limited

(Incorporated in Japan)

1-1 Kamikodanaka 4-chome, Nakahara-ku,
Kawasaki-shi, Kanagawa 211, Japan

(72) Inventor(s)

Kenichi Kawasaki
Masao Nakano
Yasuro Matsuzaki
Naoharu Shinozaki
Yasuharu Sato

(72) and (74) continued overleaf

(51) INT CL⁶

G11C 7/00, H03K 5/13, H03L 7/081

(52) UK CL (Edition P)

G4C C700B5 C700T
H3A AL2DX AT AXE
H3P PPMD
H3T T1P1 T2B3 T2B6 T2T3F T3V

(56) Documents Cited

GB 2304435 A	GB 2251994 A	GB 2246004 A
GB 2243060 A	GB 2129634 A	GB 1338776 A
EP 0647025 A1	EP 0639003 A1	EP 0463641 A2
EP 0445574 A2	EP 0127508 A2	WO 94/29870 A1
US 5610543 A	US 5554949 A	US 5544203 A
US 5528200 A	US 5514990 A	US 5355037 A
US 5287025 A	US 5060145 A	US 4100541 A

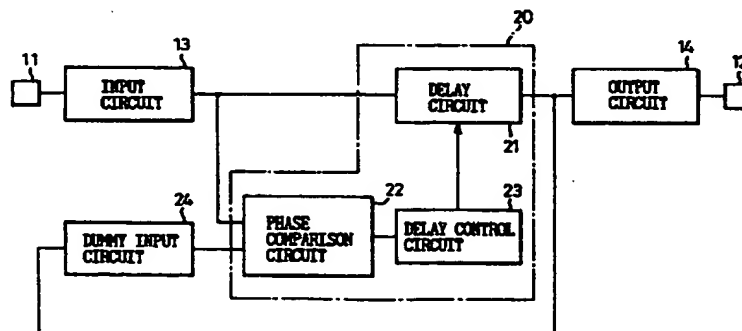
(58) Field of Search

UK CL (Edition P) G4A AFT, G4C C11407T C700BX
C700B4 C700B5 C700T C800T C804, H3A ARR ARX
ASD ASX AXE, H3P PPMD PPMP, H4P PSEX
INT CL⁶ G06F 1/04 1/06 1/10 1/12, G11C 7/00 8/00
8/04 11/407, H03K 5/13 5/135, H03L 7/081, H04L
7/00
Online: WPI

(54) Semiconductor device and digital delay circuit

(57) In a semiconductor device for maintaining the timing of an output signal at a constant phase difference relative to an external clock signal, independent of differences in characteristic, changes in temperature and/or fluctuations in supply voltage, an input circuit 13 receives a clock signal from an external clock 11 and outputs a reference signal, an output circuit 14 receives an output timing signal and outputs an output signal according to the timing of the output timing signal and an output timing control circuit 20 controls the output timing so that the output signal exhibits a given phase relative to the signal from the external clock 11. The output timing control circuit 20 includes a delay circuit 21, a phase comparison circuit 22 and a delay control circuit 23 for specifying the magnitude of a delay to be produced by the delay circuit 21. A dummy input circuit 24 produces a delay of the same magnitude as that of the input circuit 13, and receives as input the output timing signal from the delay circuit 21 and supplies an output to the phase comparison circuit 22. Further aspects relate to inputting or outputting data synchronously (Figs 3 and 82), a digital delay circuit and a digital delay circuit including a shift register (fig 41). Embodiments of timing control circuits are described (Figs 10, 29, 34, 40, 48, 49, 54, 56, 57, 65, 86, 88, and 90). The delay control 23 may use an up/down counter (526, Fig 41 and 531, Fig 54). The timing control circuits may be used with synchronous semiconductor memory circuits.

Fig.6



Best Available Copy

GB 2 316 208 A

(72) cont

Masao Taguchi
Koichi Nishimura
Hiroko Douchi
Terumasa Kitahara
Yoshihiro Takemae
Yoshinori Okajima

(74) Agent and/or Address for Service

Haseltine Lake & Co
Imperial House, 15-19 Kingsway, LONDON, WC2B 6UD,
United Kingdom

Fig. 1

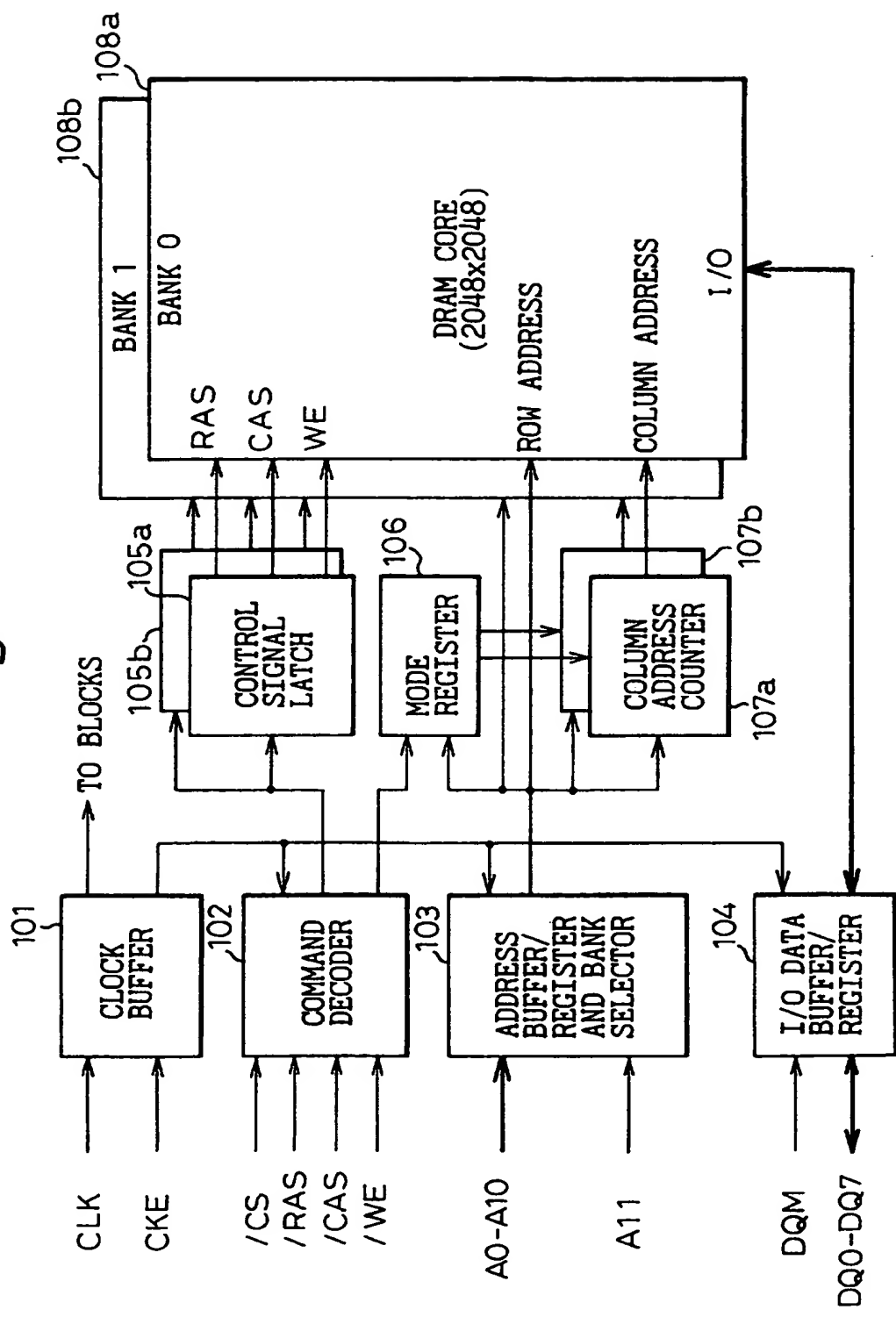


Fig.2

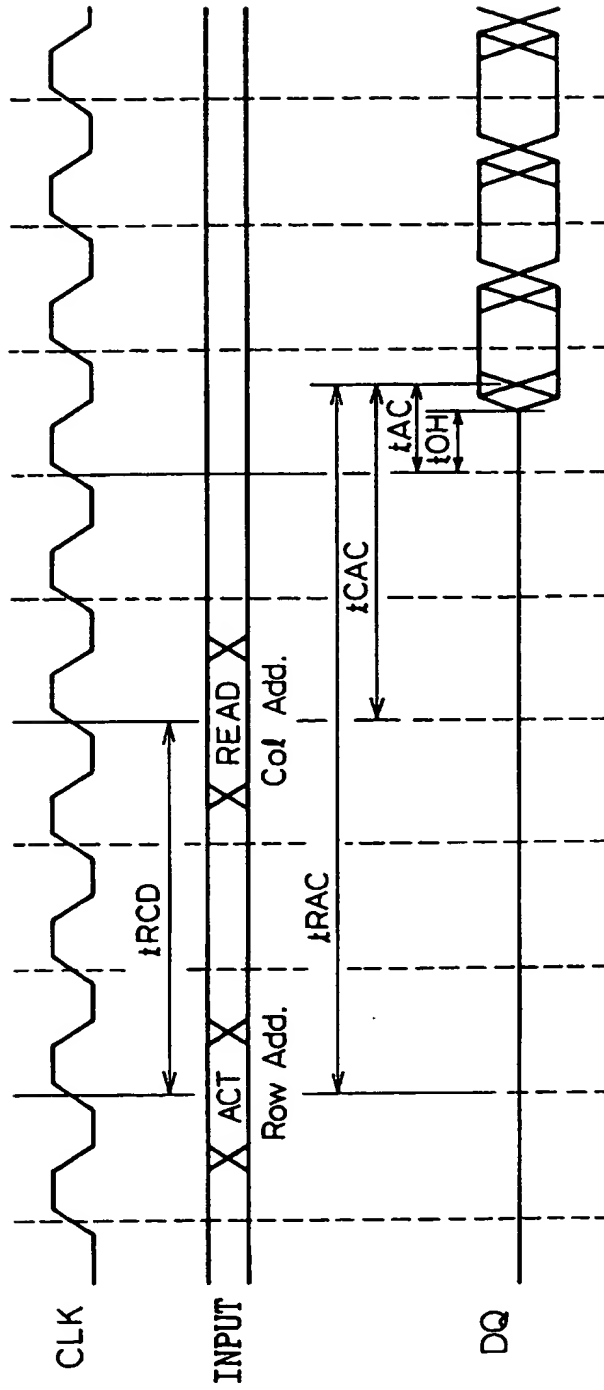


Fig. 3

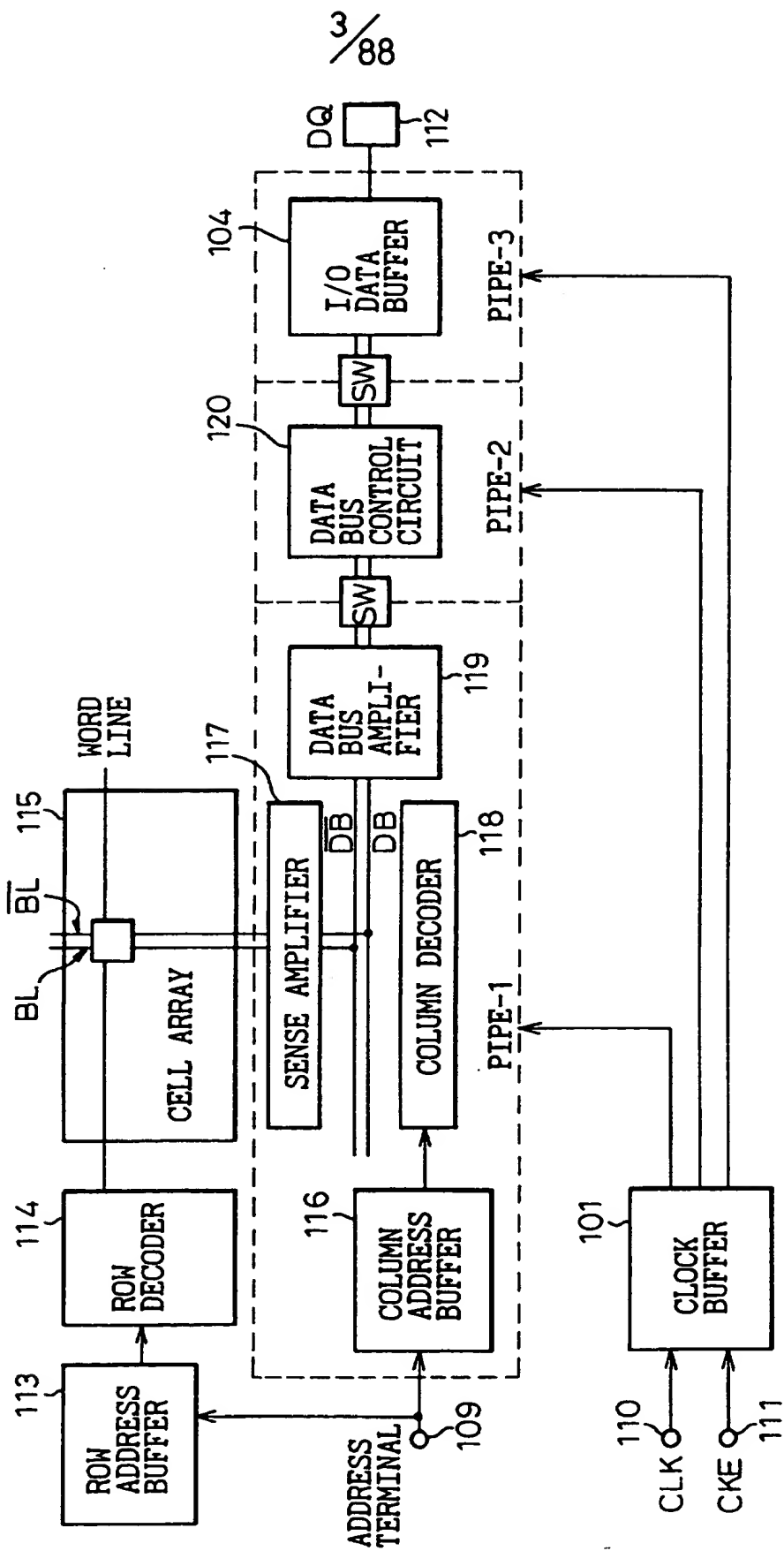


Fig.4

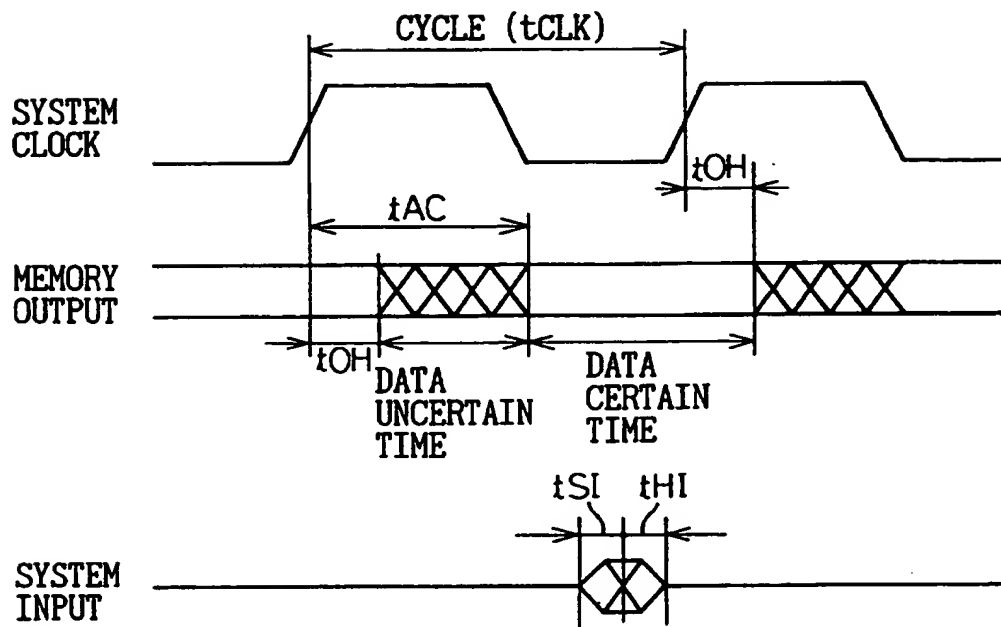


Fig.5A

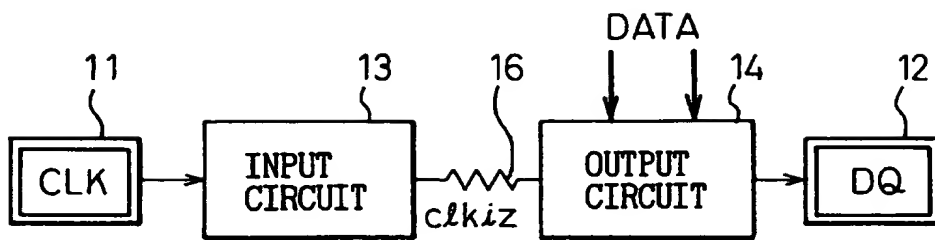


Fig.5B

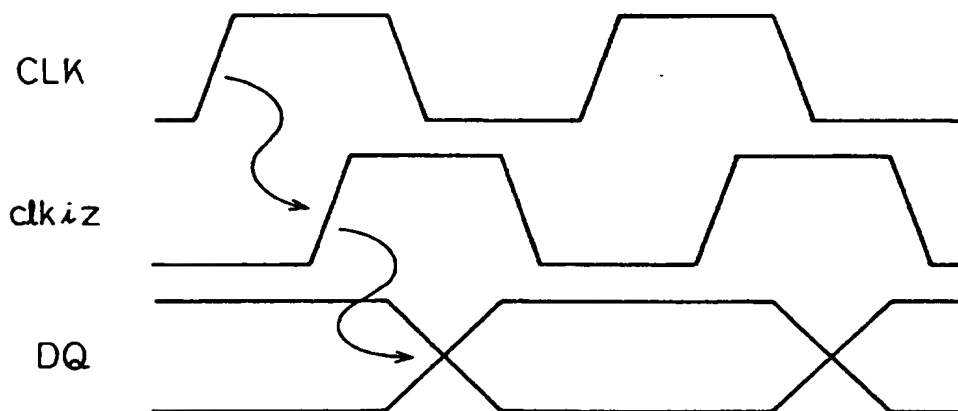


Fig. 6

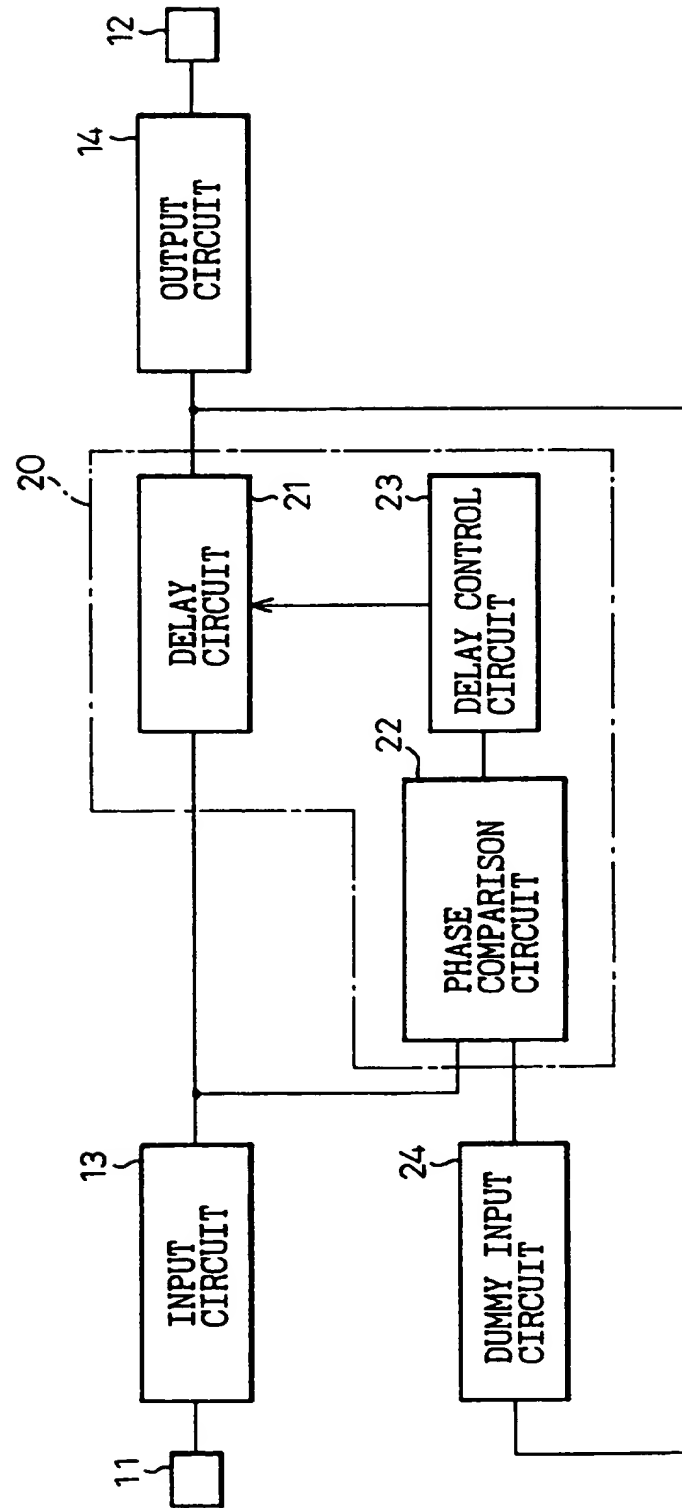


Fig.7

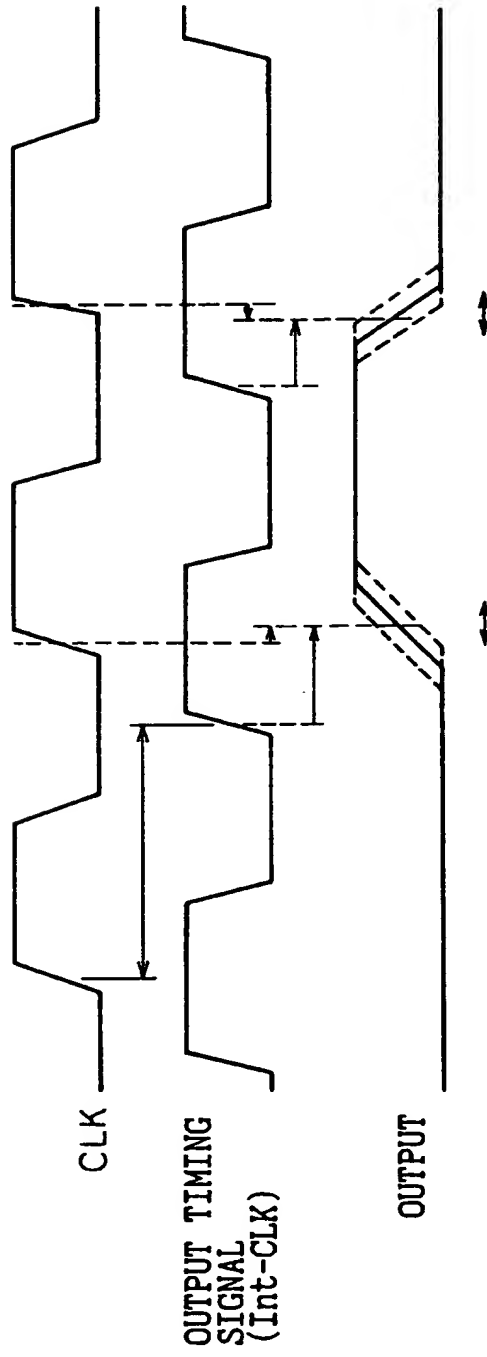
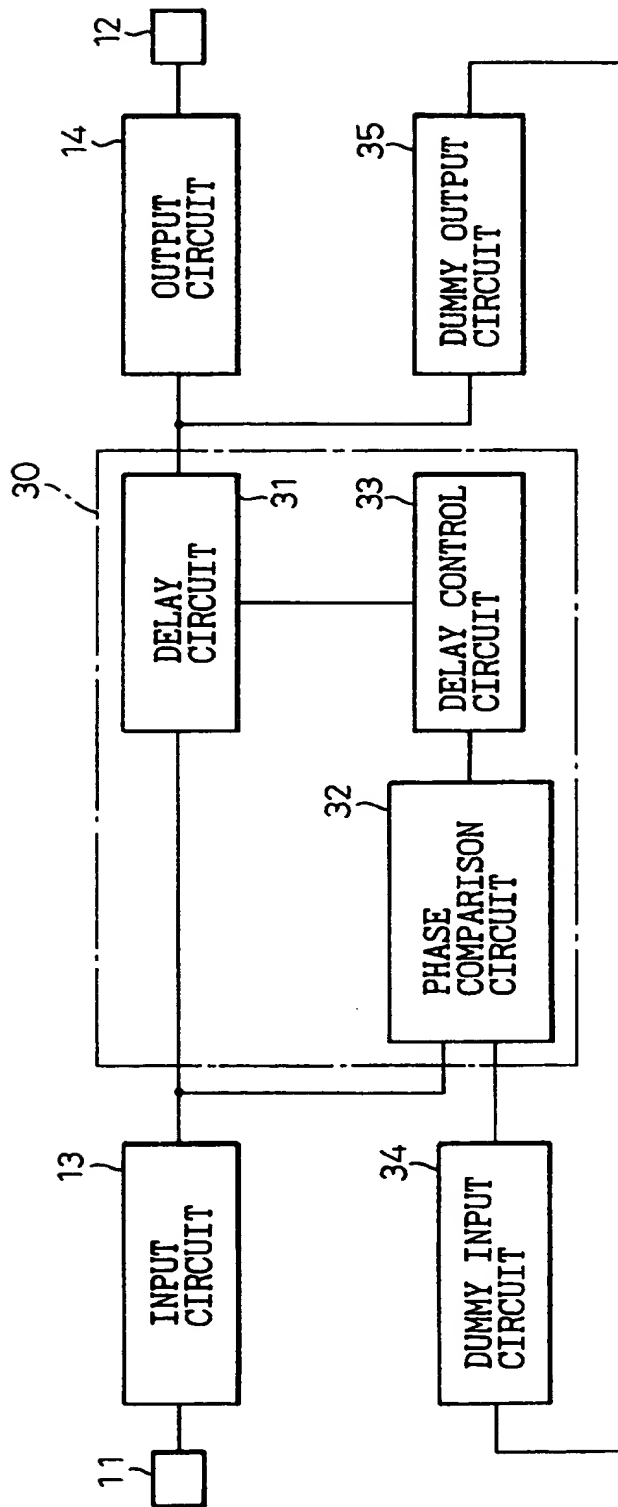


Fig. 8



9. 9. 1. 1.

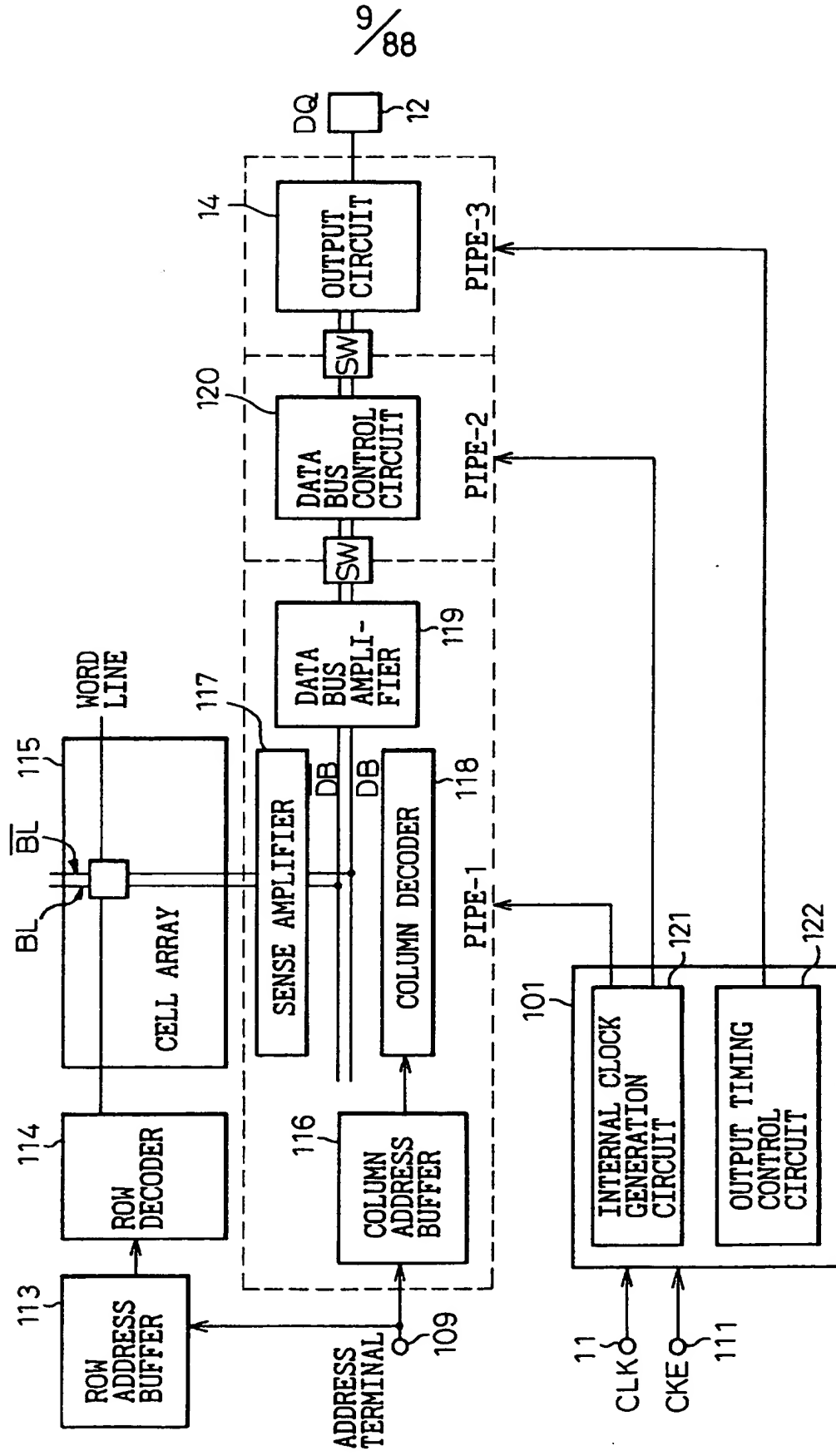


Fig.10

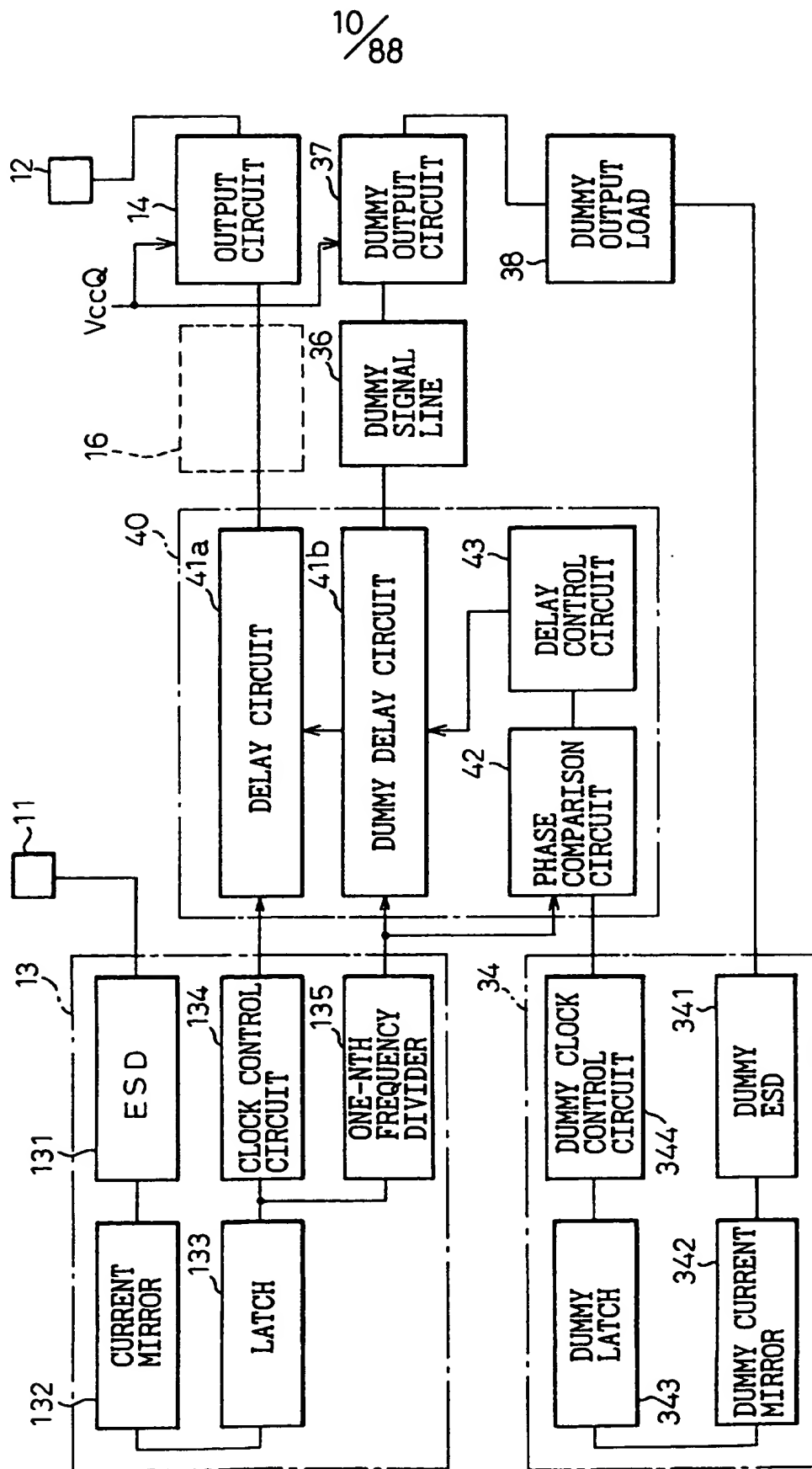


Fig.11A

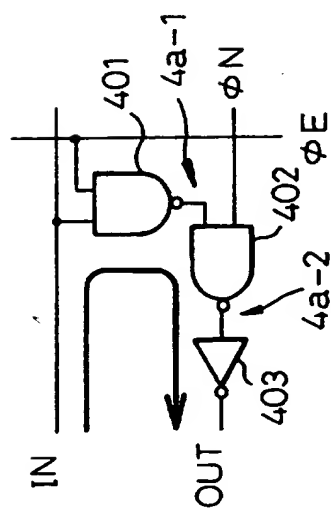


Fig.11B

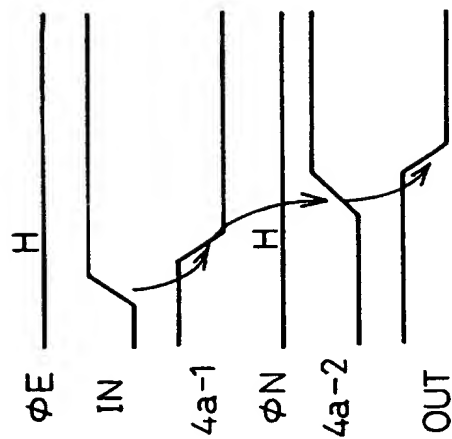


Fig.11C

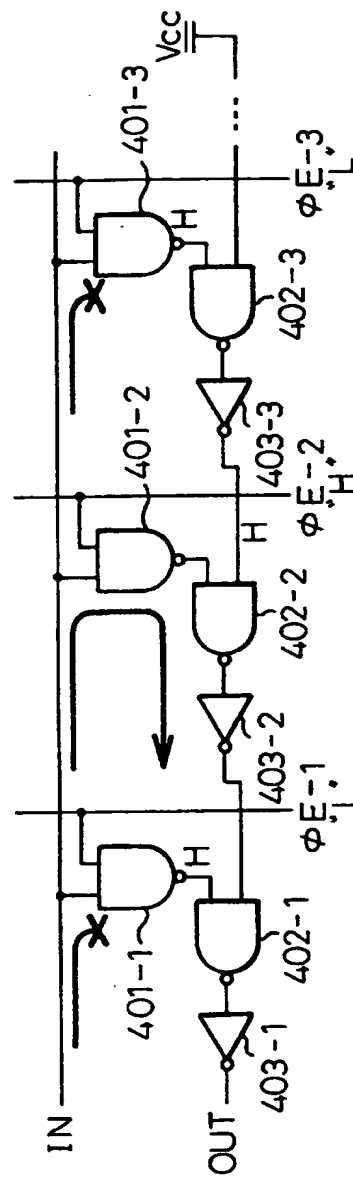


Fig. 12

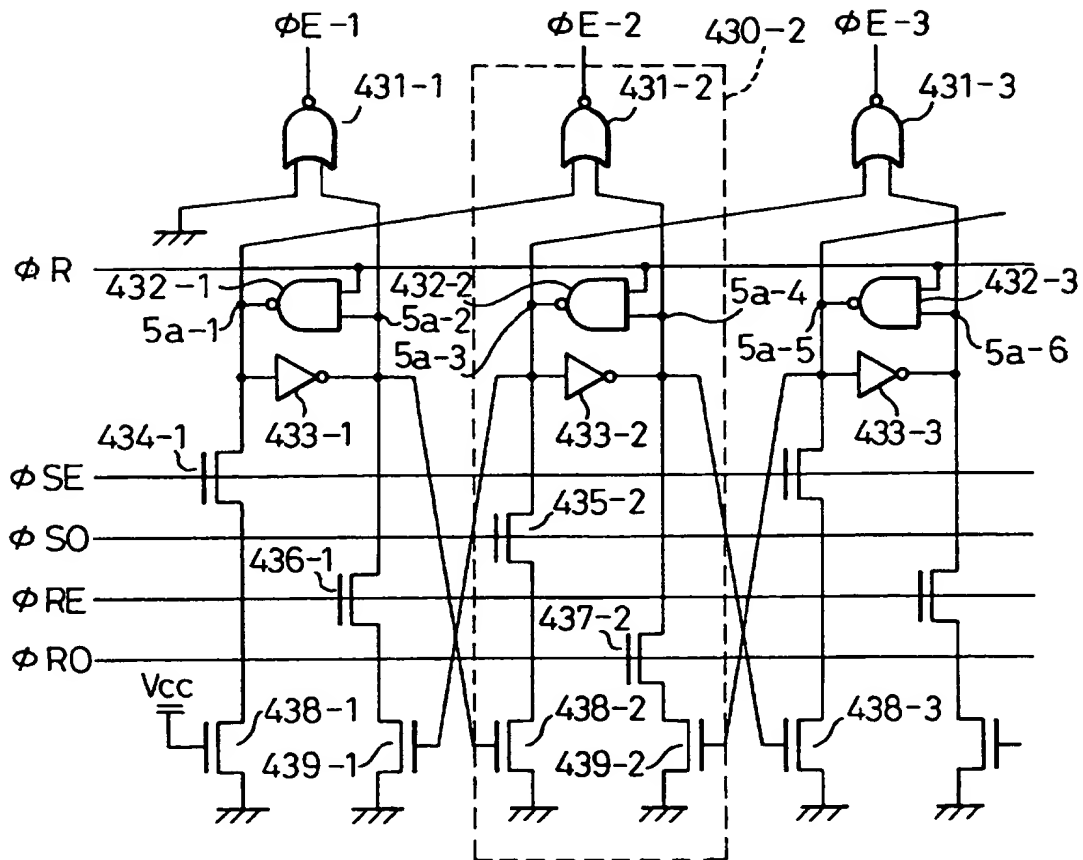


Fig.13

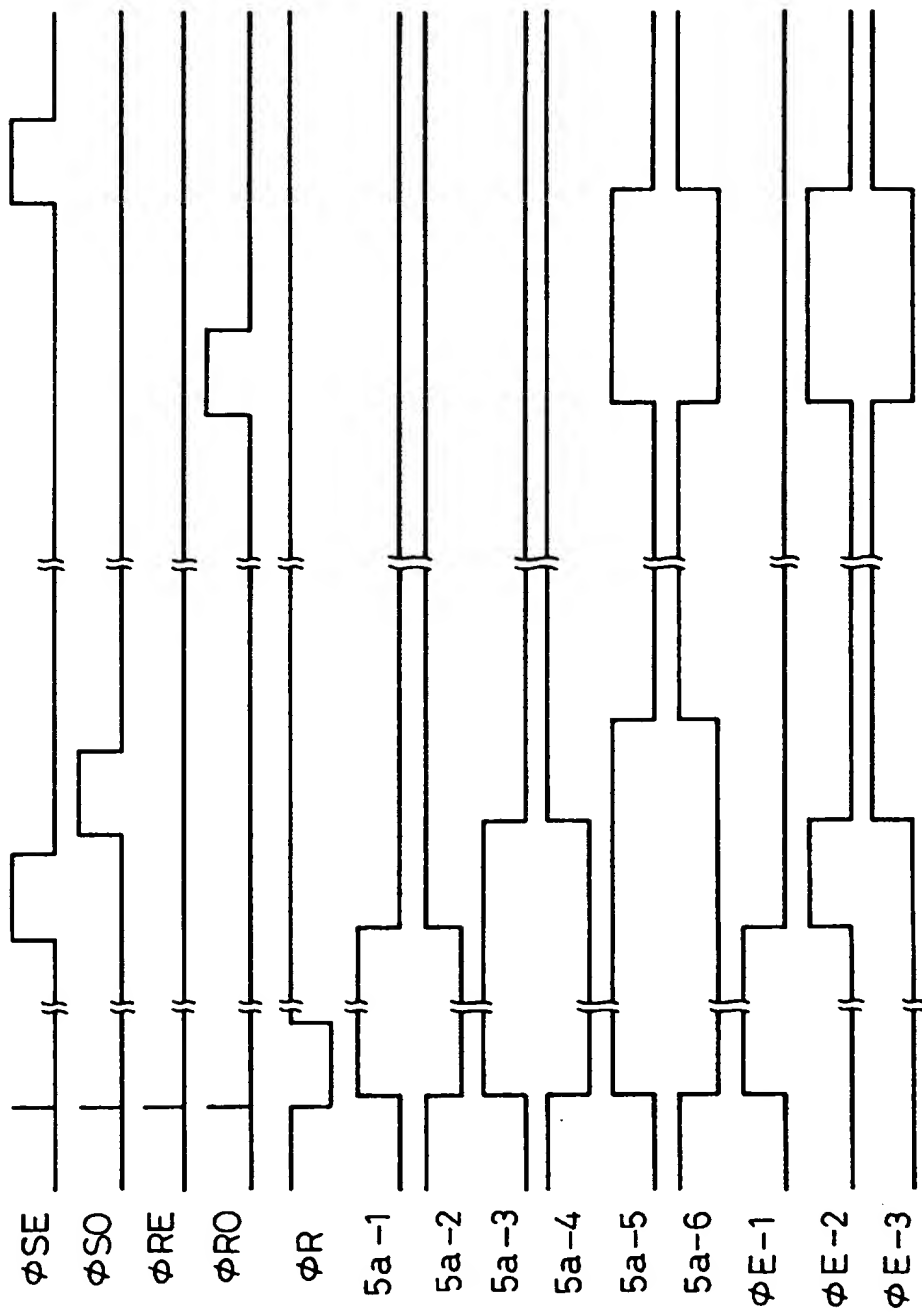


Fig.14

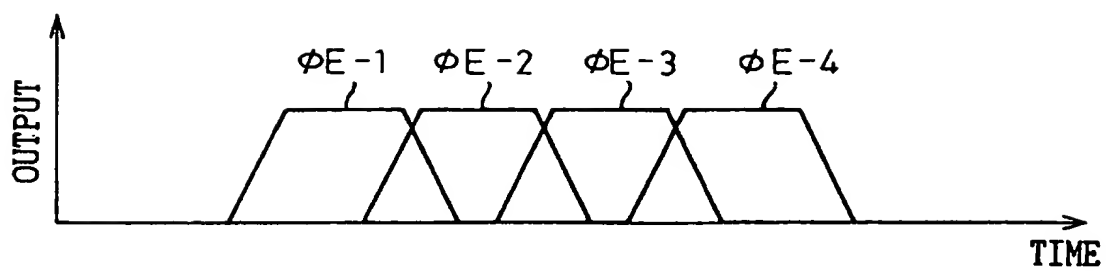


Fig.15

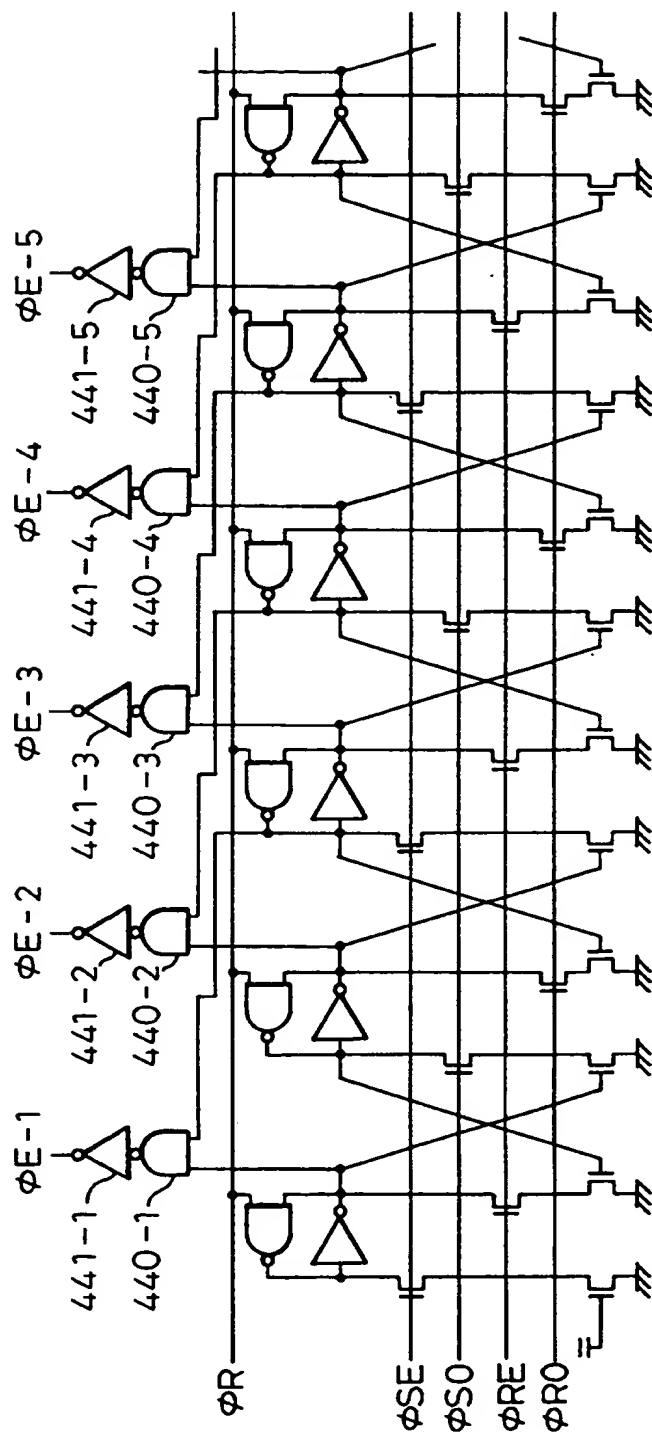


Fig.16

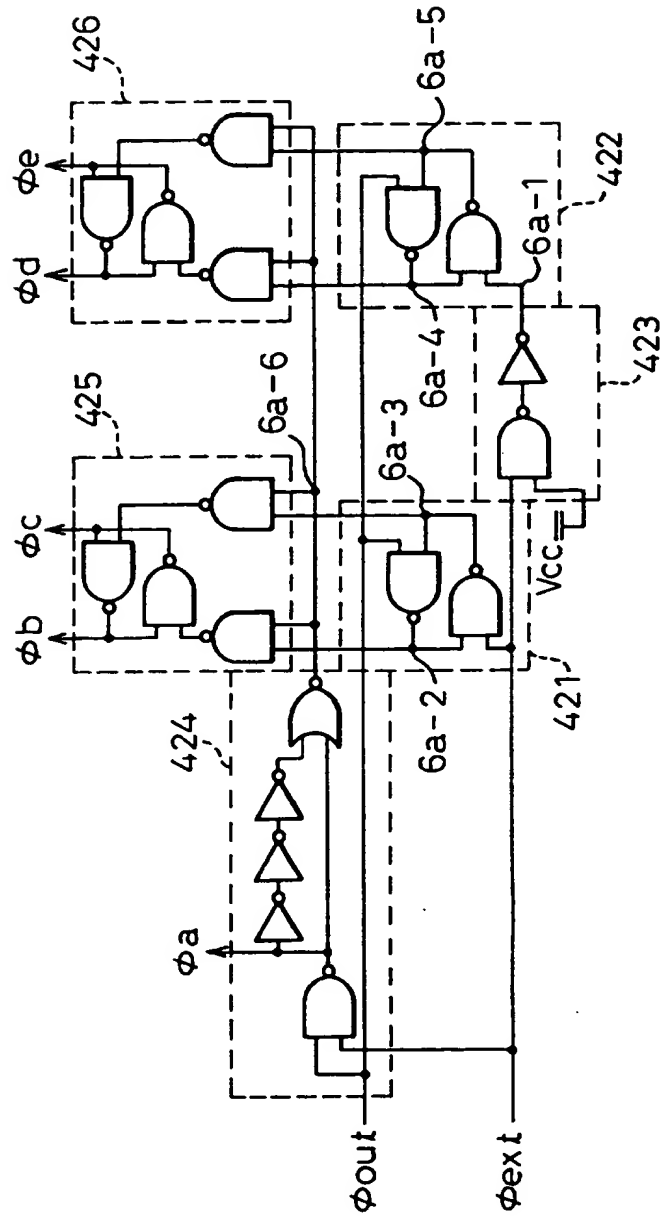


Fig.17C

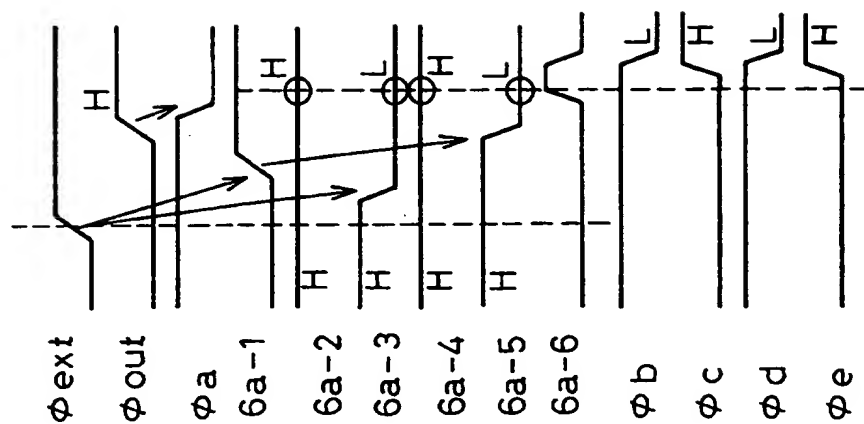


Fig.17B

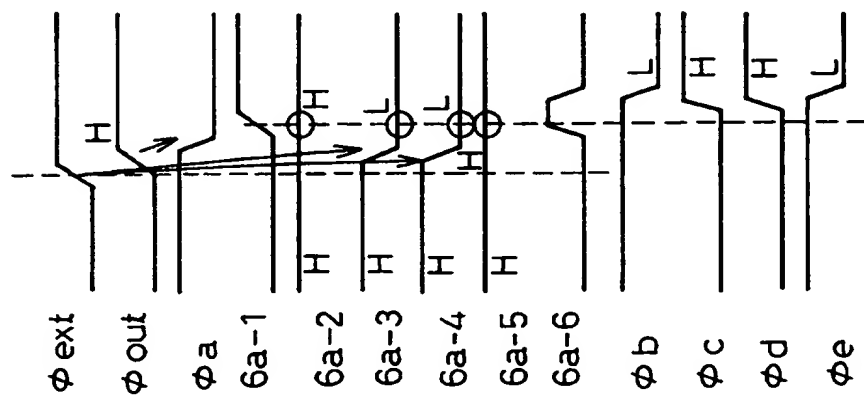


Fig.17A

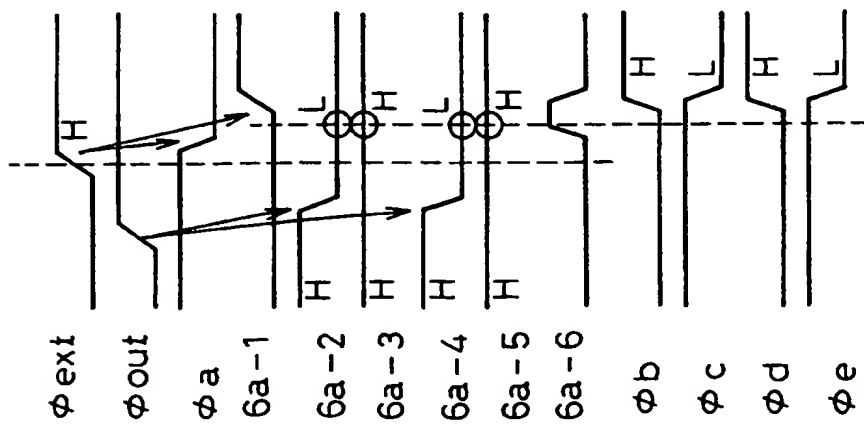


Fig.19

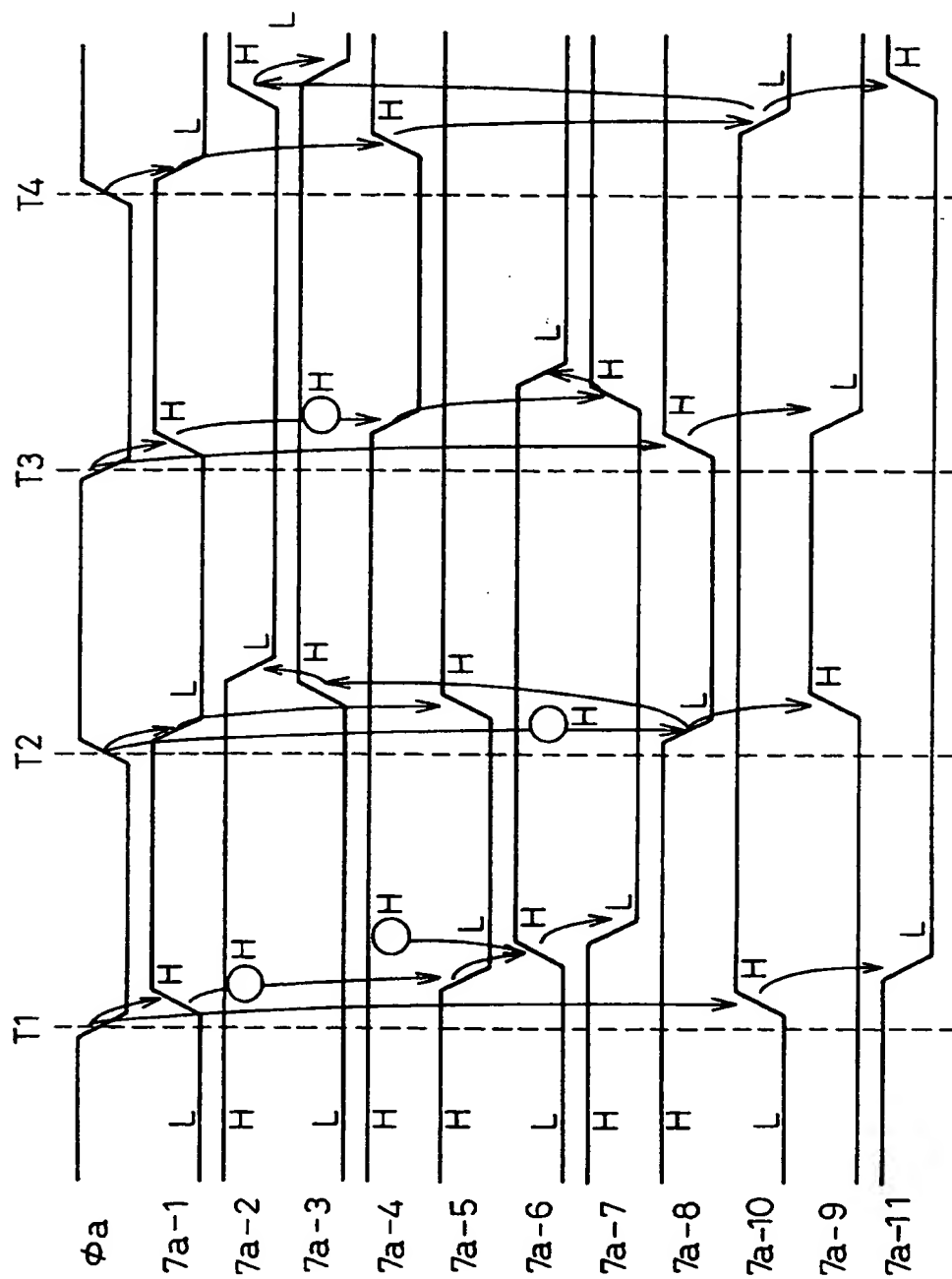


Fig. 20

$\phi b = H'$, $\phi d = H''$, $\phi c = L''$, $\phi e = L'$

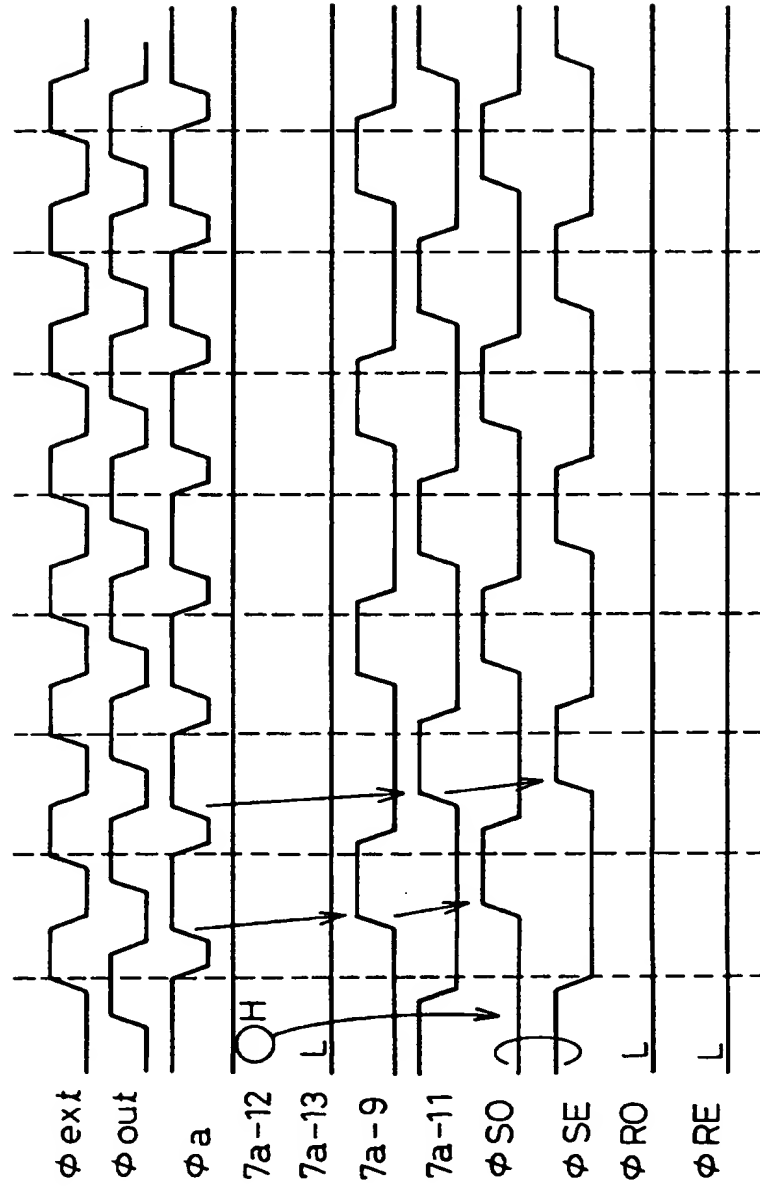


Fig.21

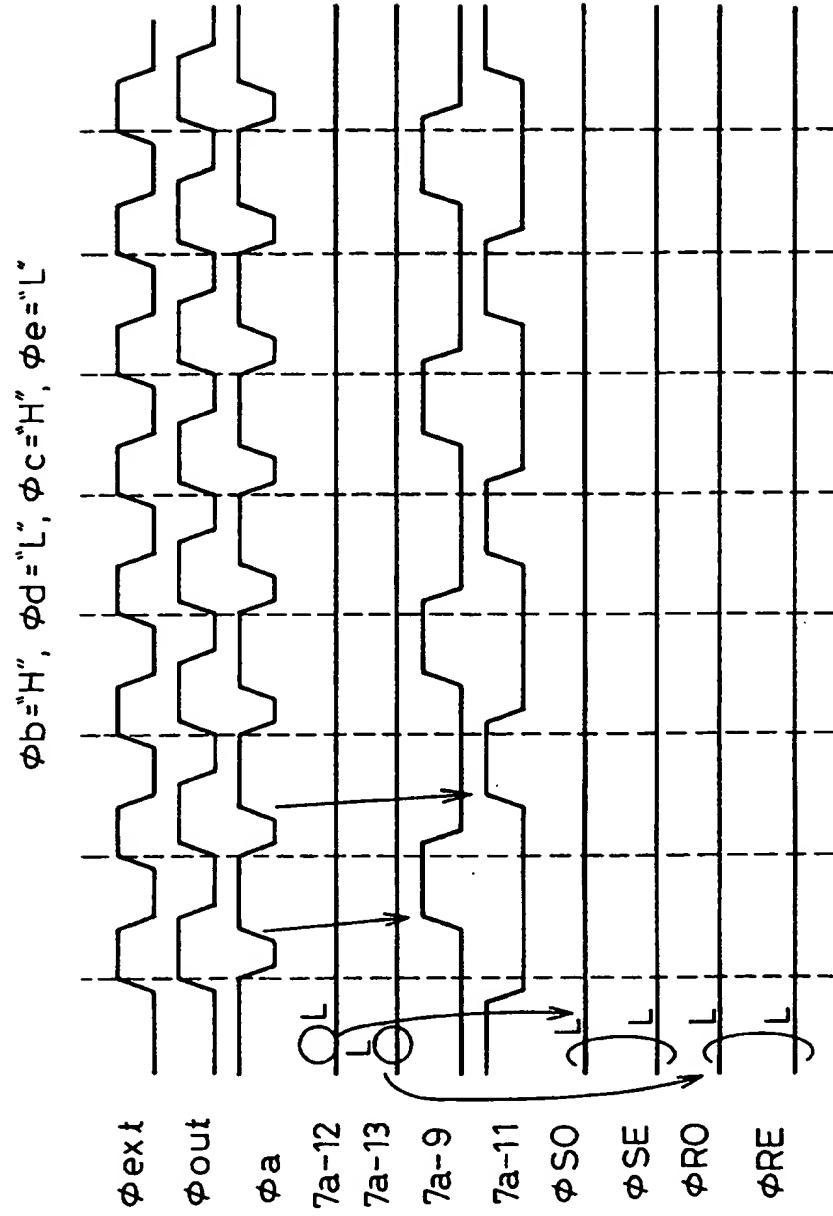


Fig.22

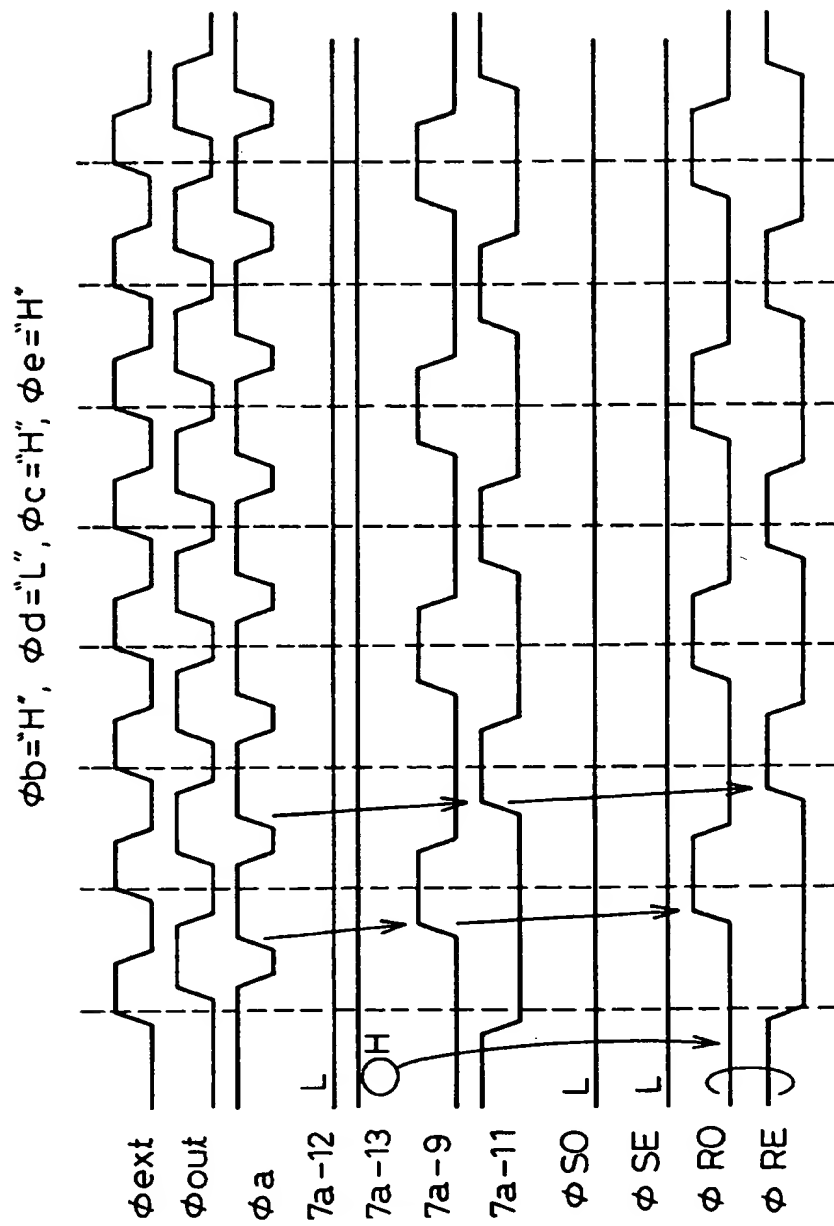


Fig.23

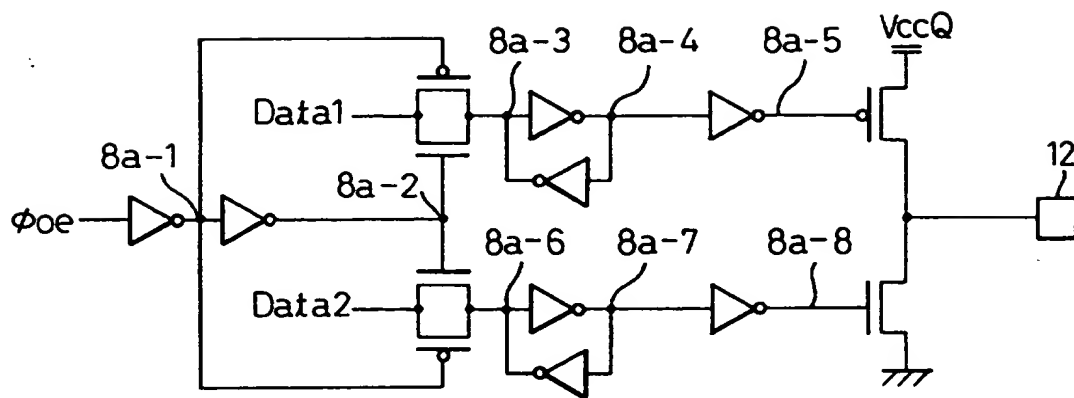


Fig. 24

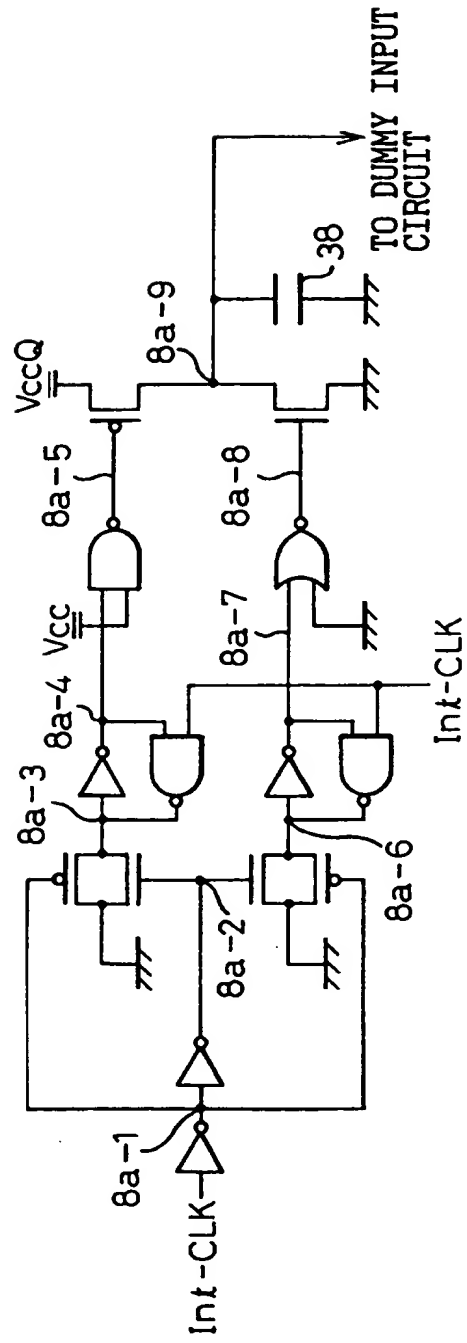


Fig.25A

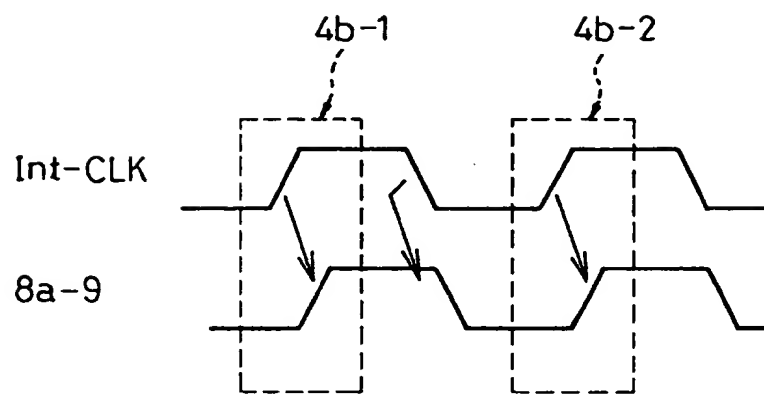


Fig.25B

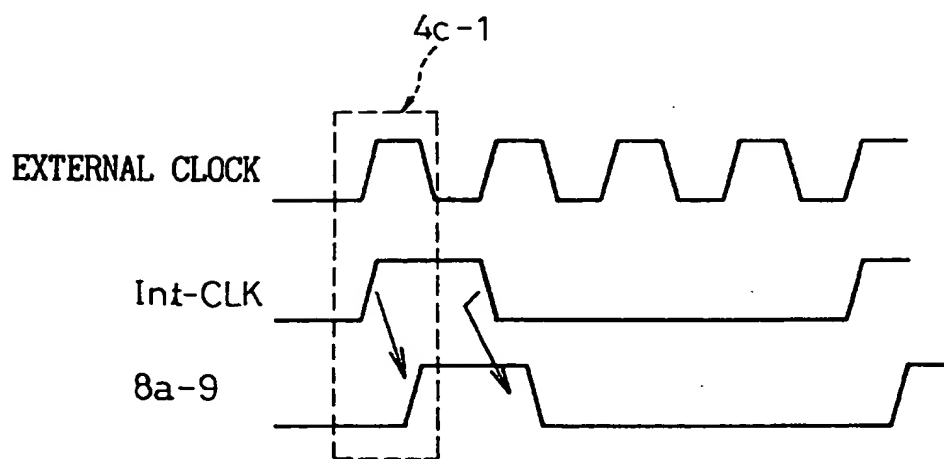


Fig. 26

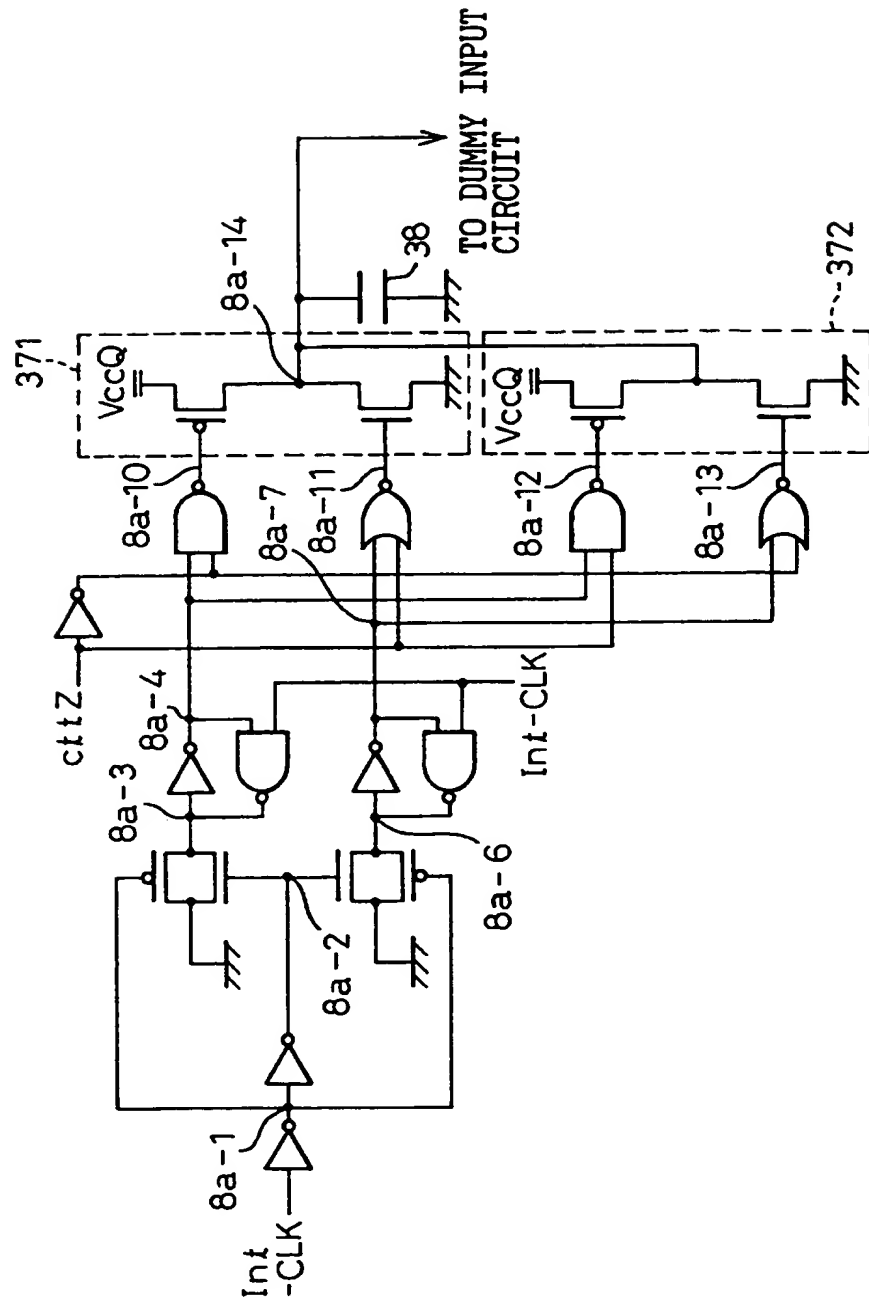


Fig. 27

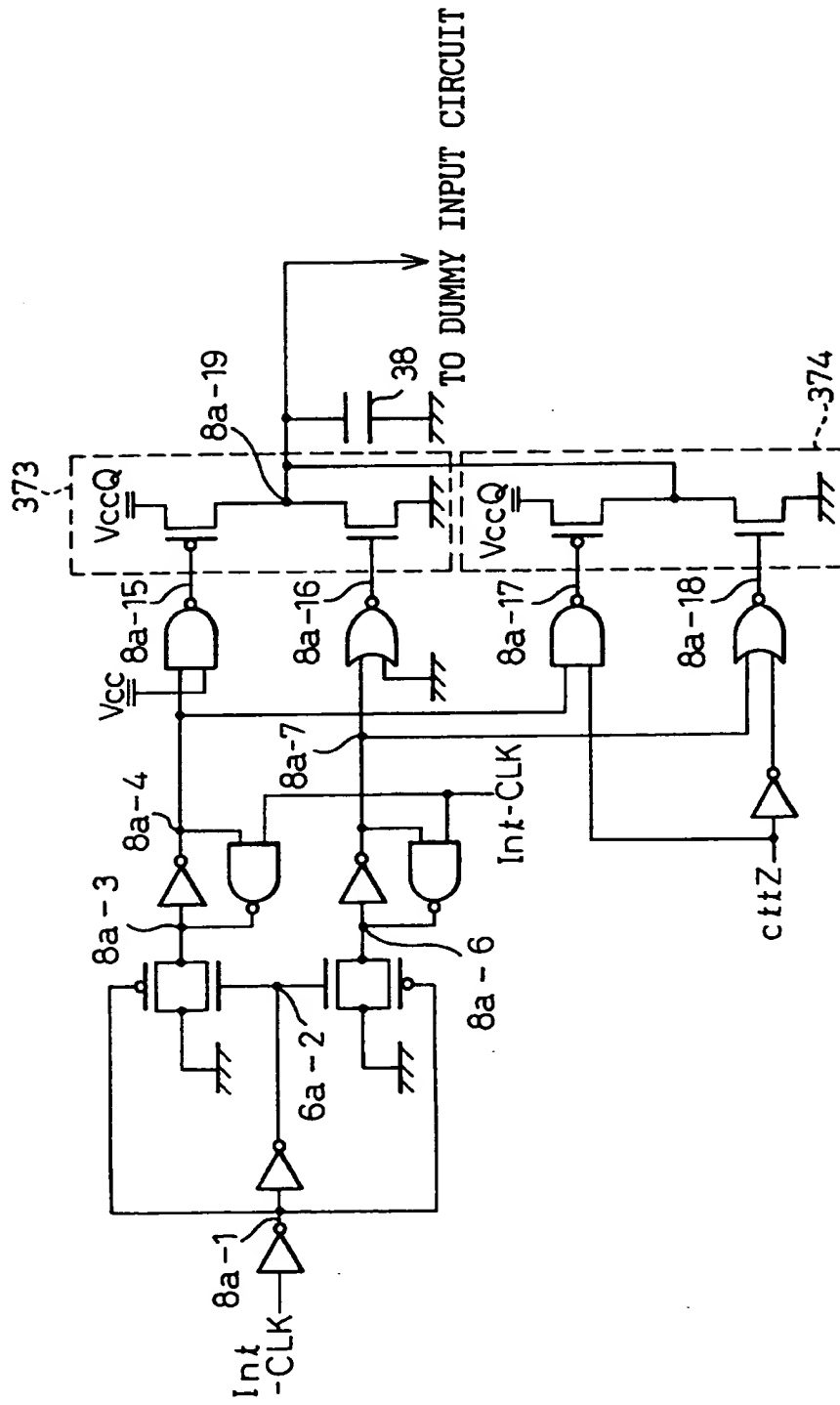


Fig. 29

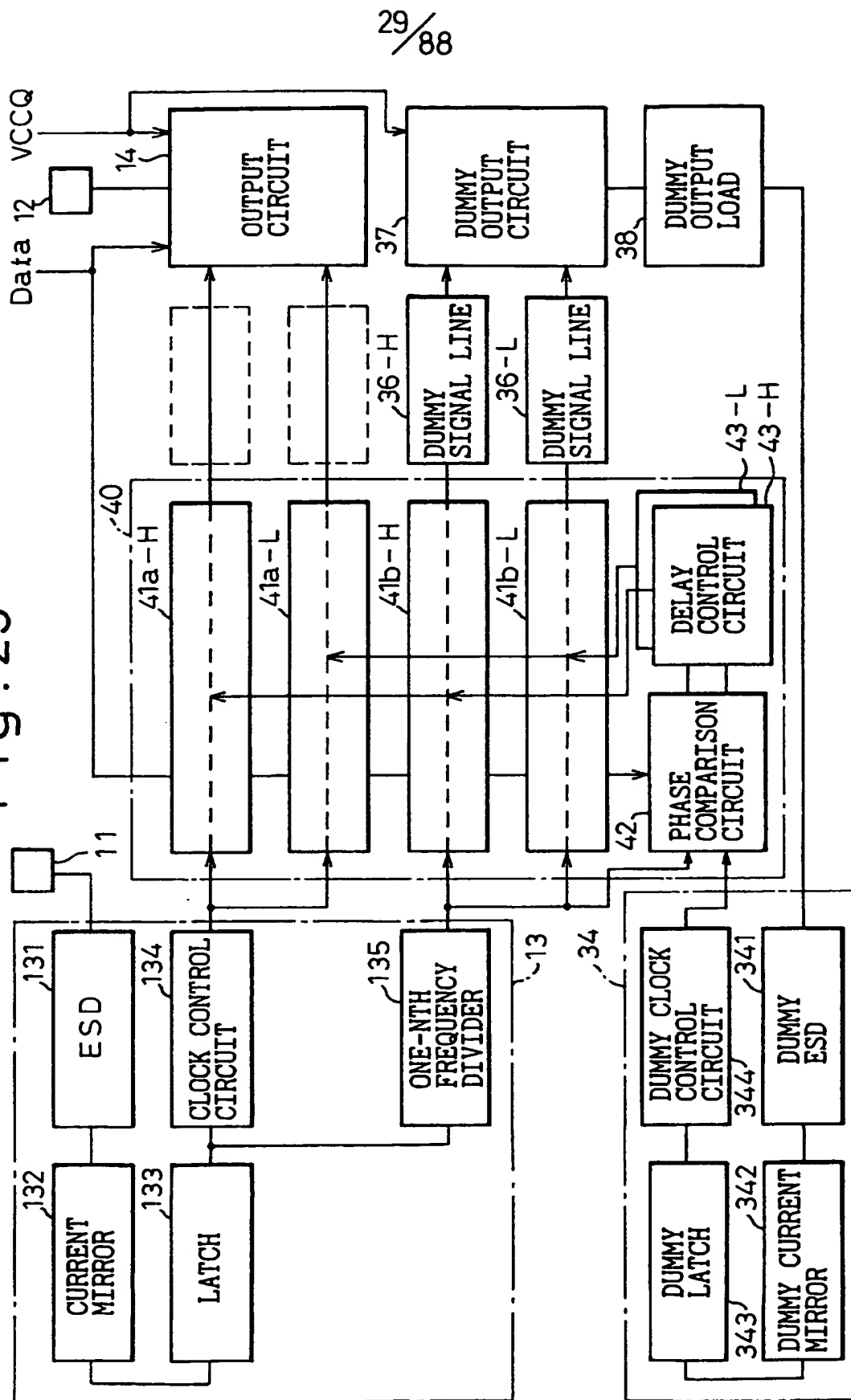


Fig. 30

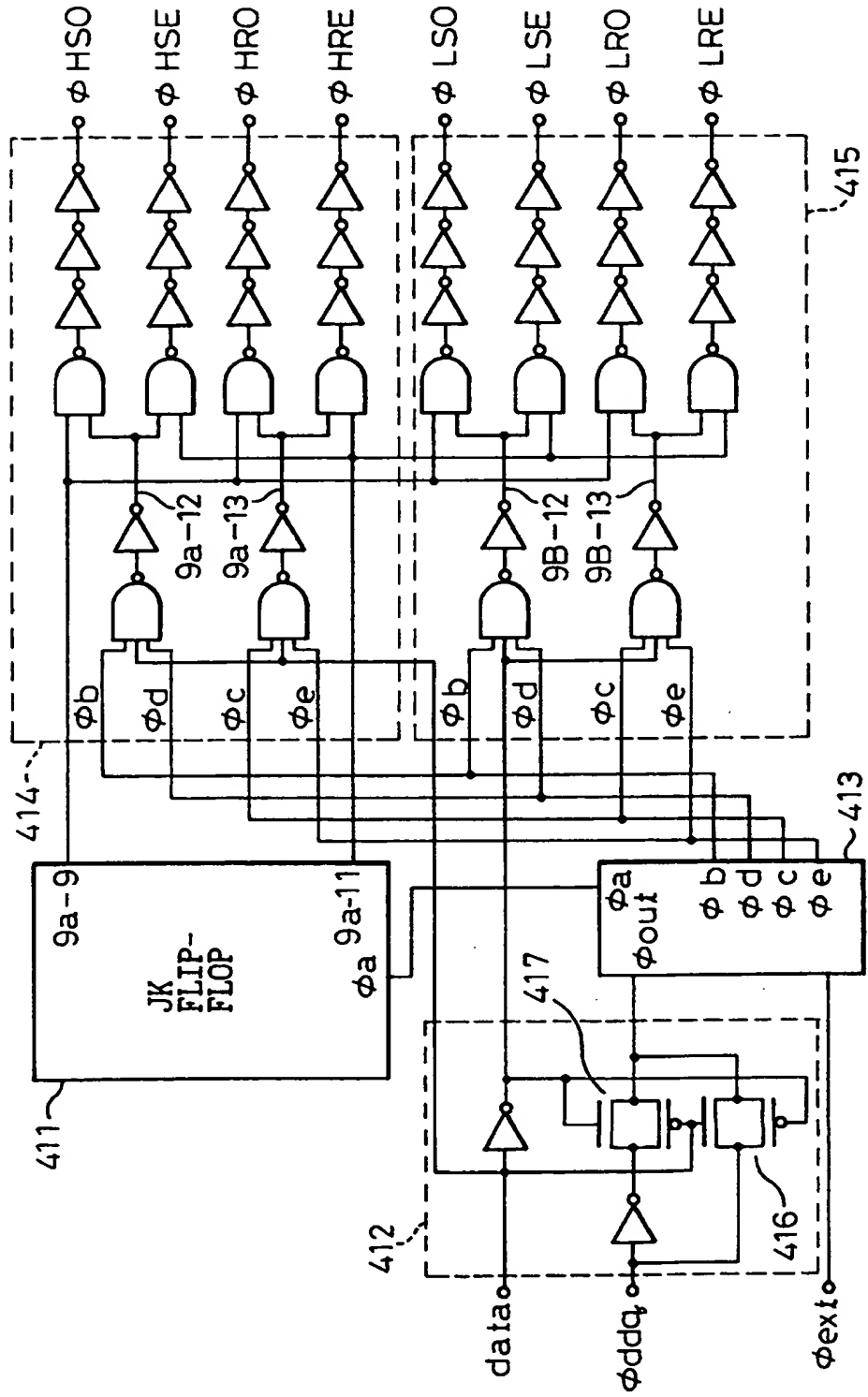


Fig. 31

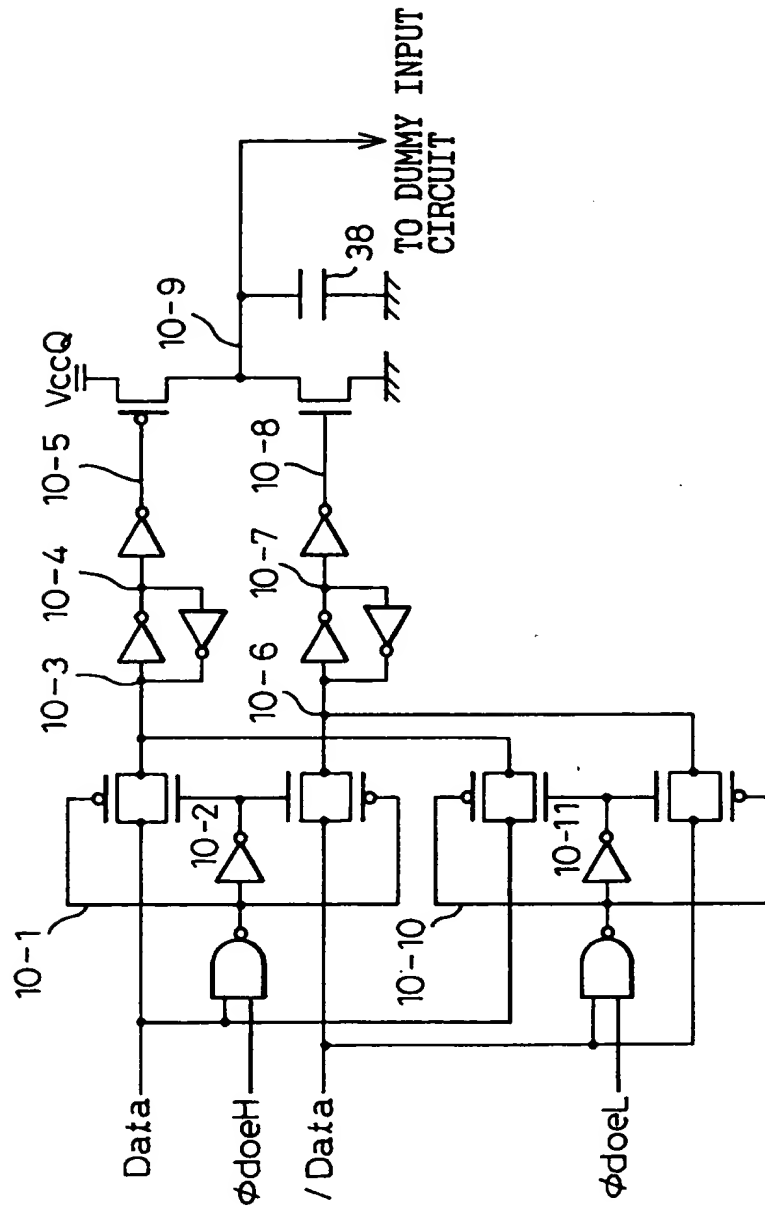


Fig.32

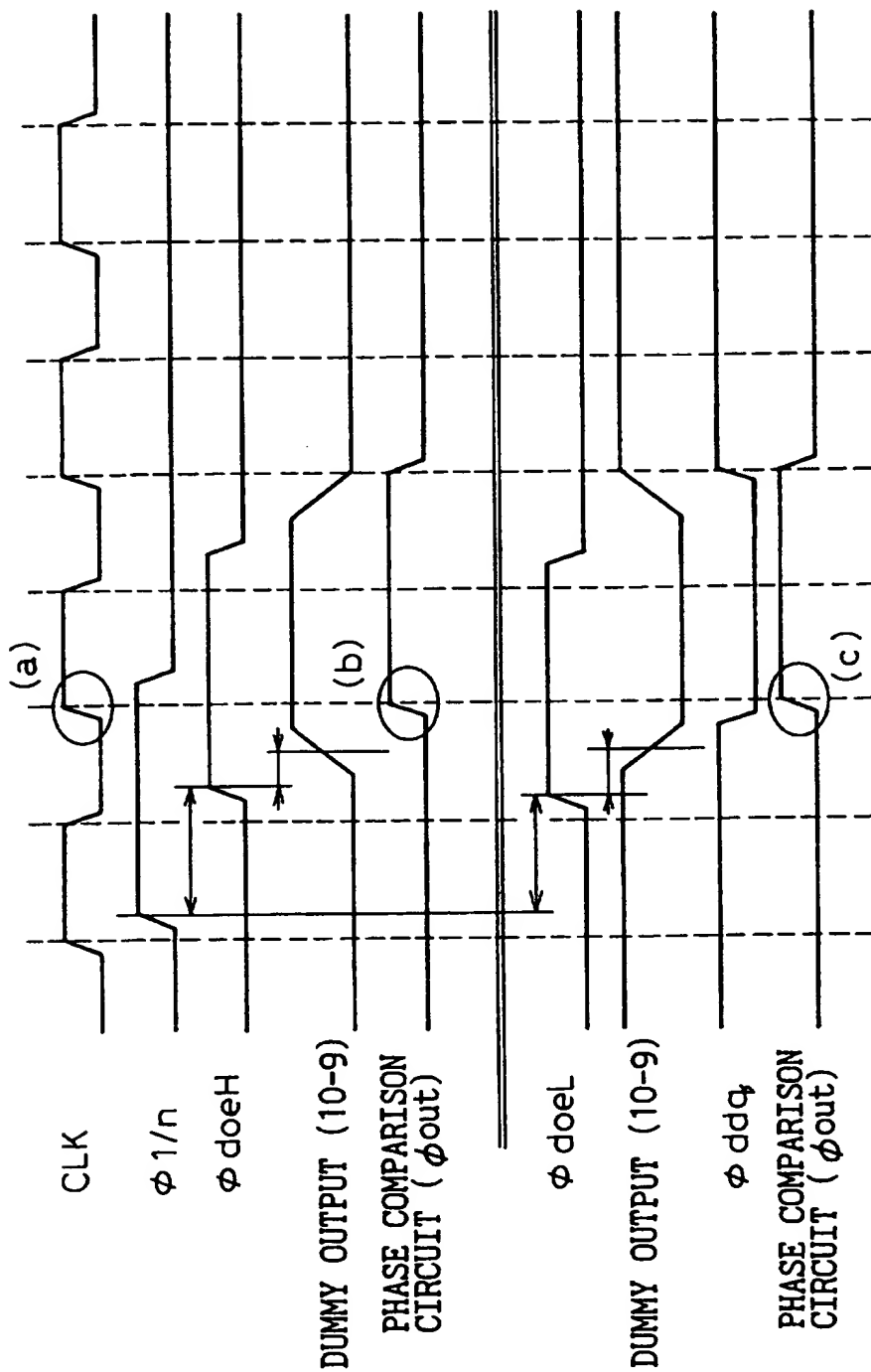


Fig. 33

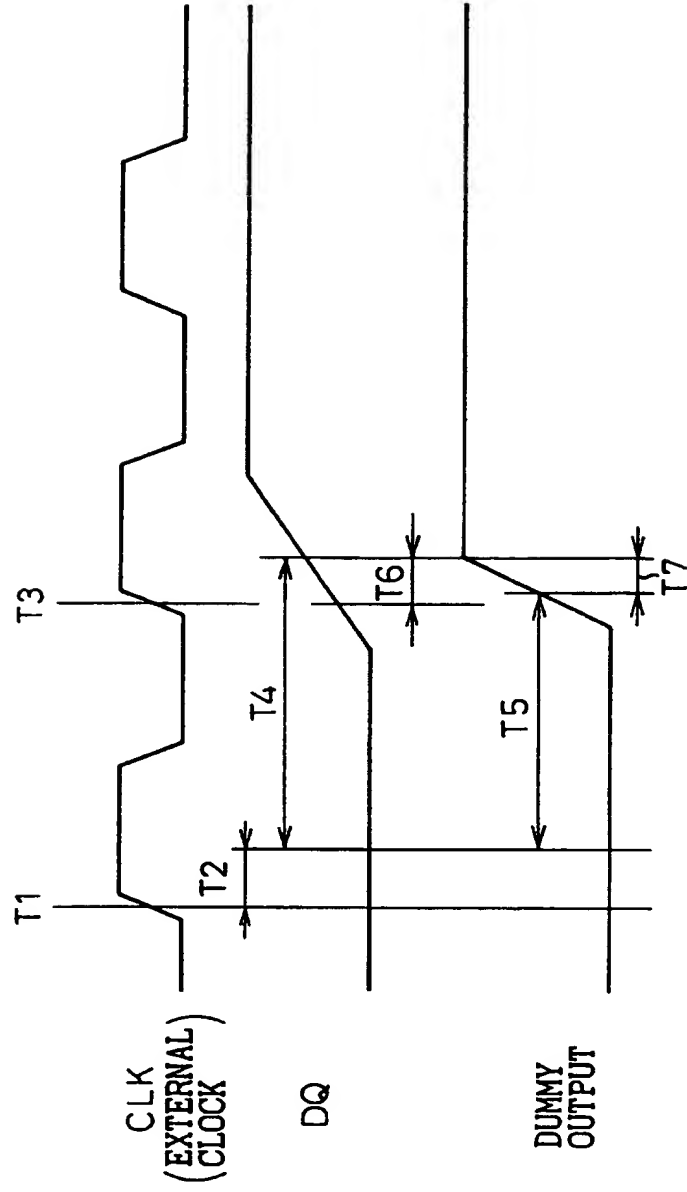


Fig. 34

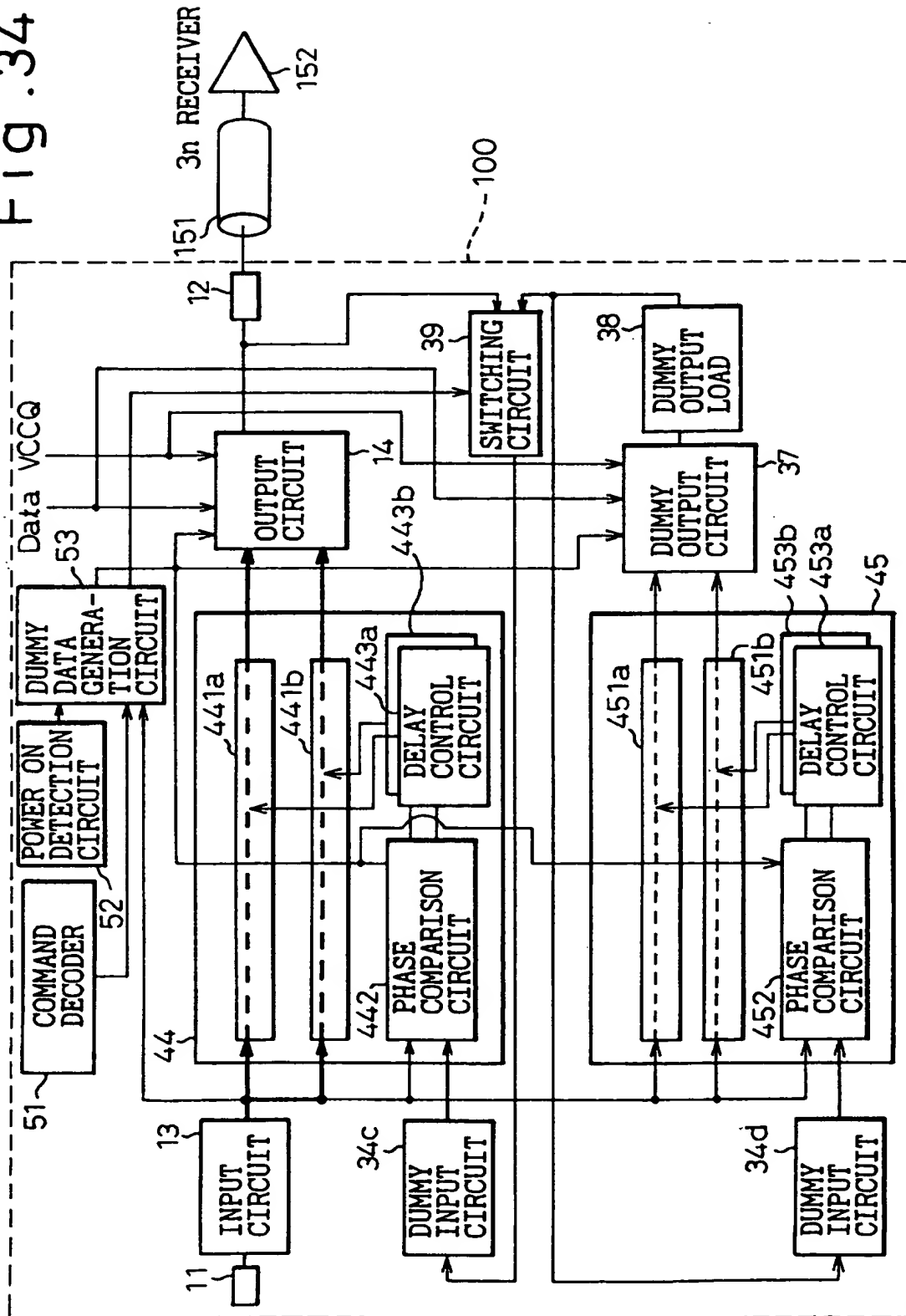


Fig.35

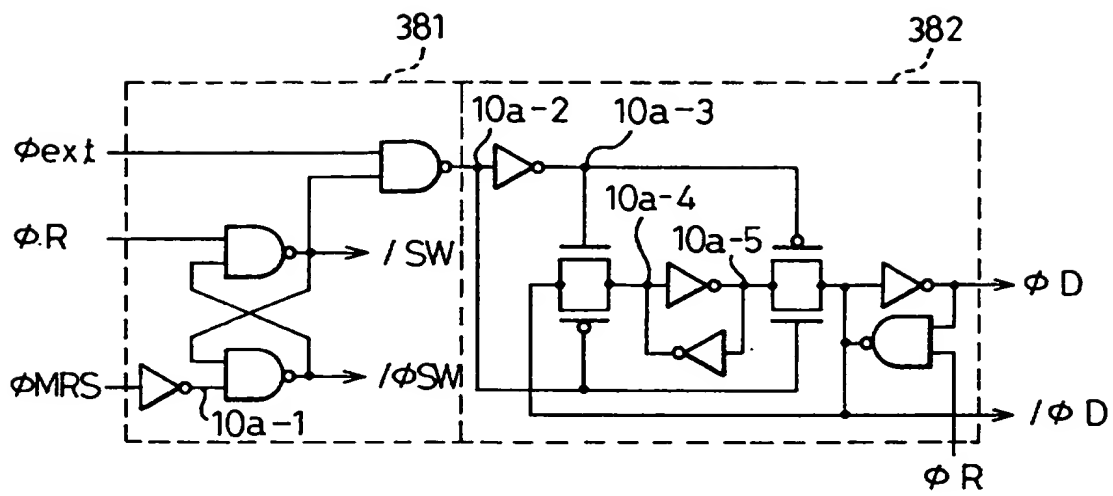


Fig. 36

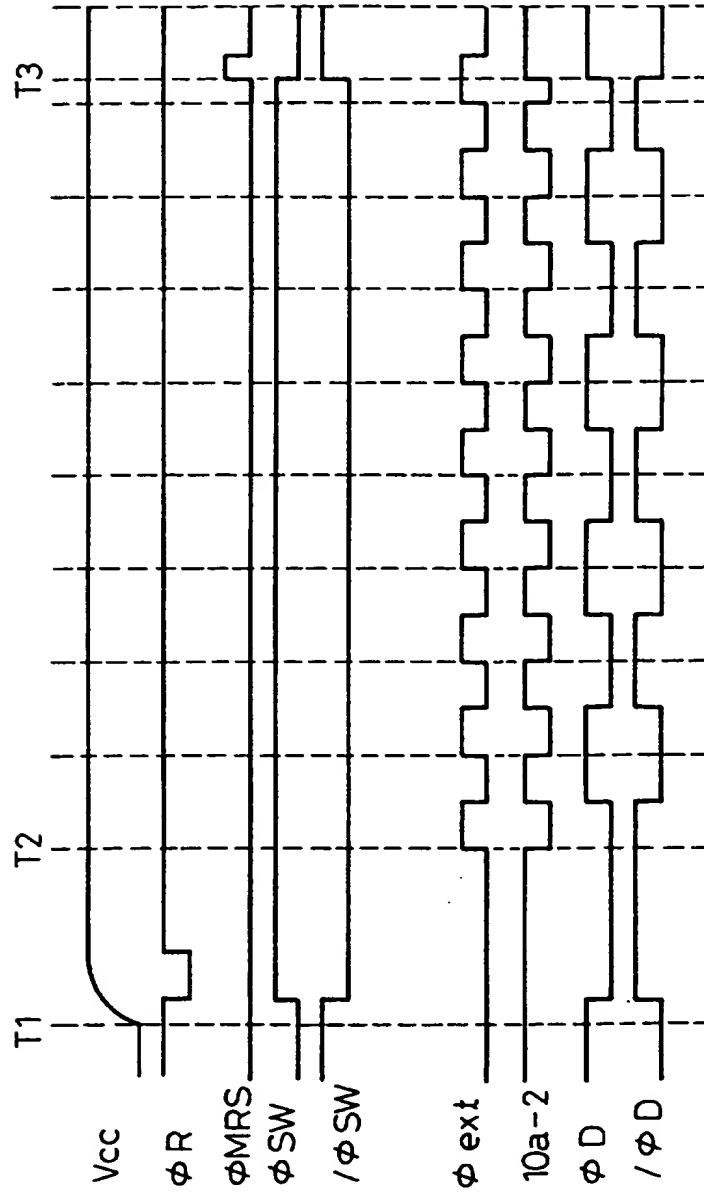


Fig. 37

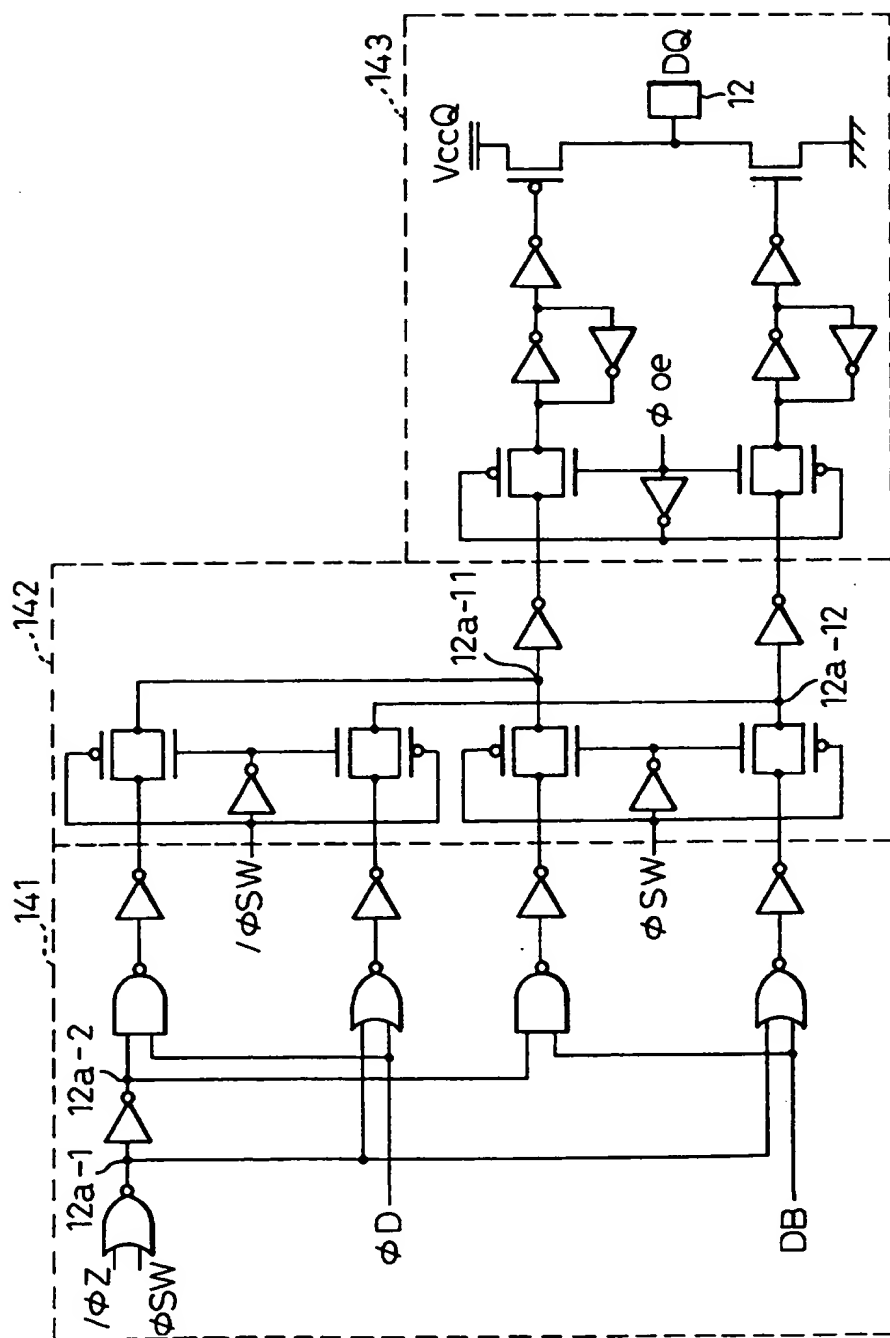


Fig. 38

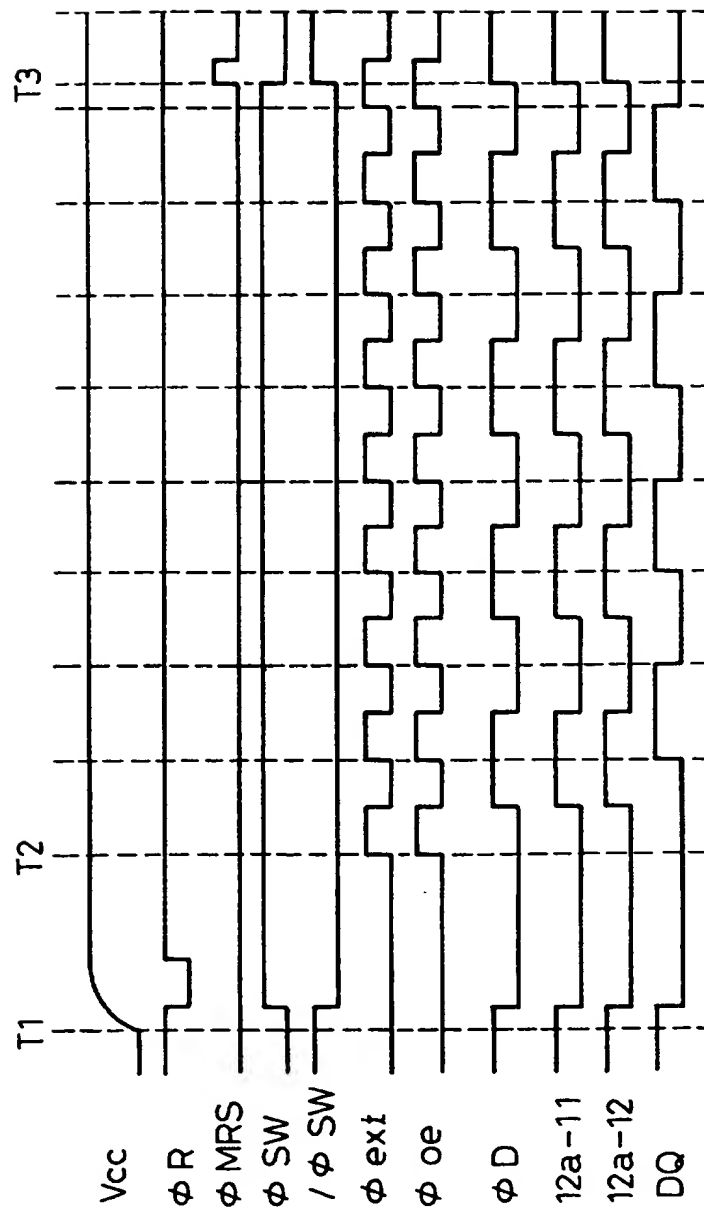


Fig. 39

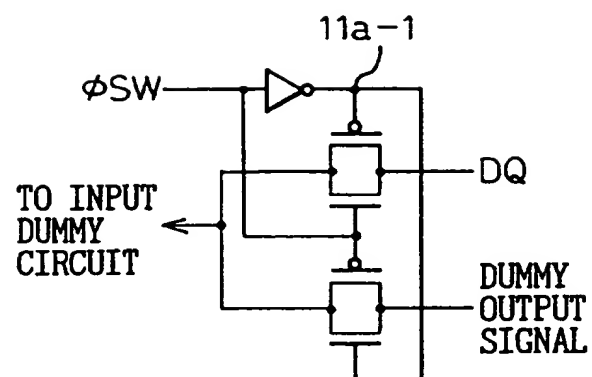


Fig. 40

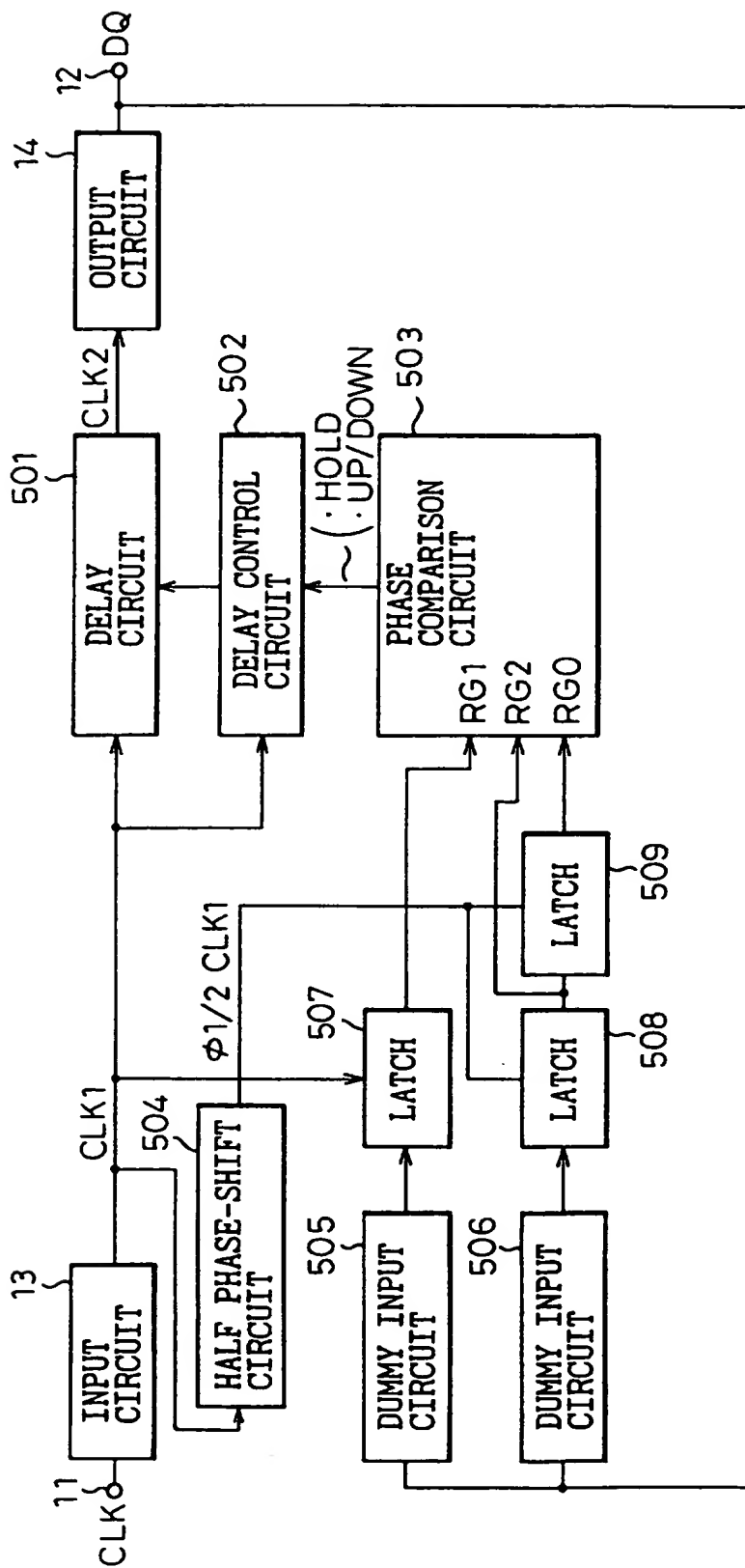


Fig. 41

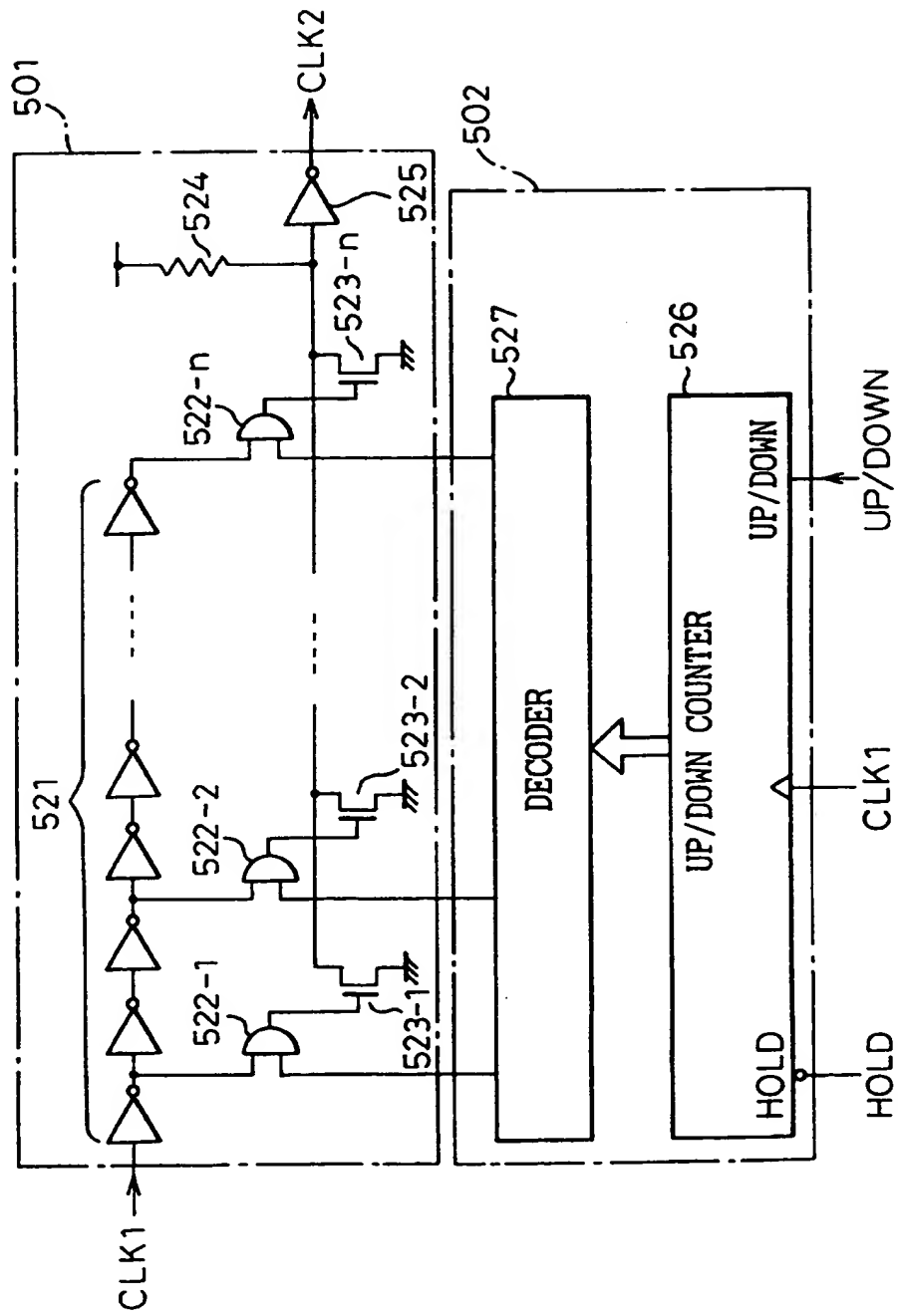


Fig. 43

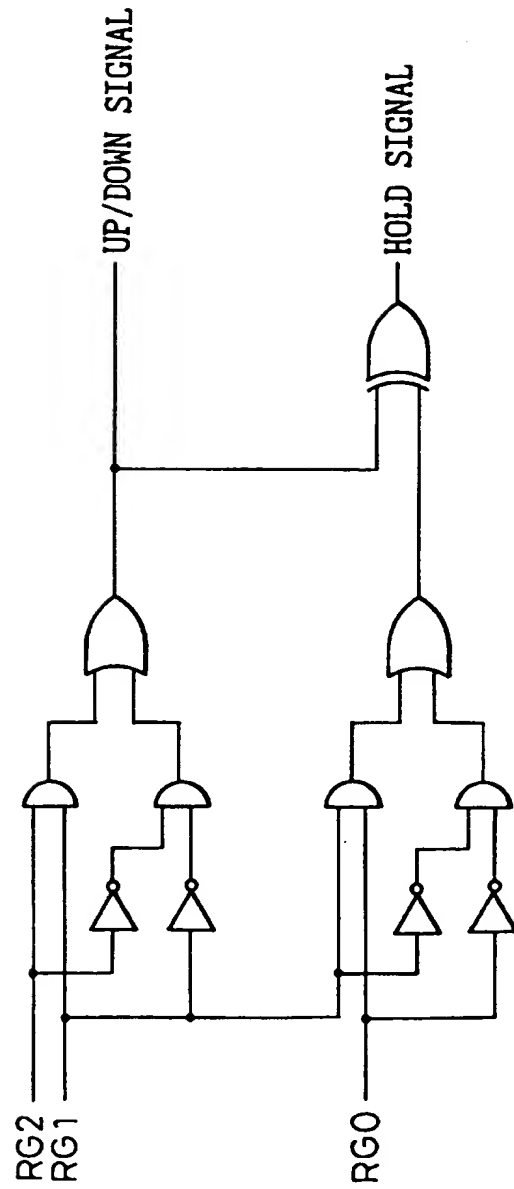


Fig. 44

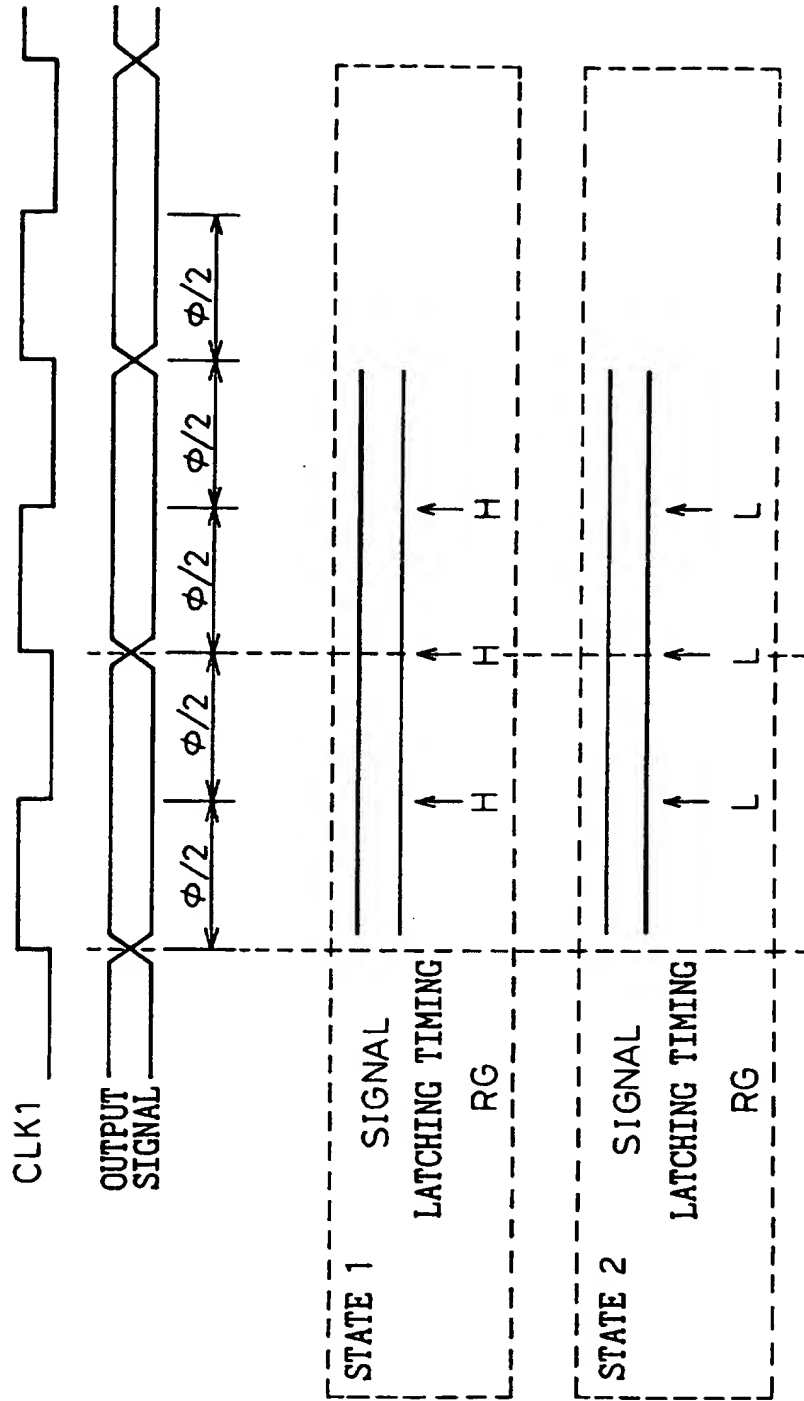


Fig .45

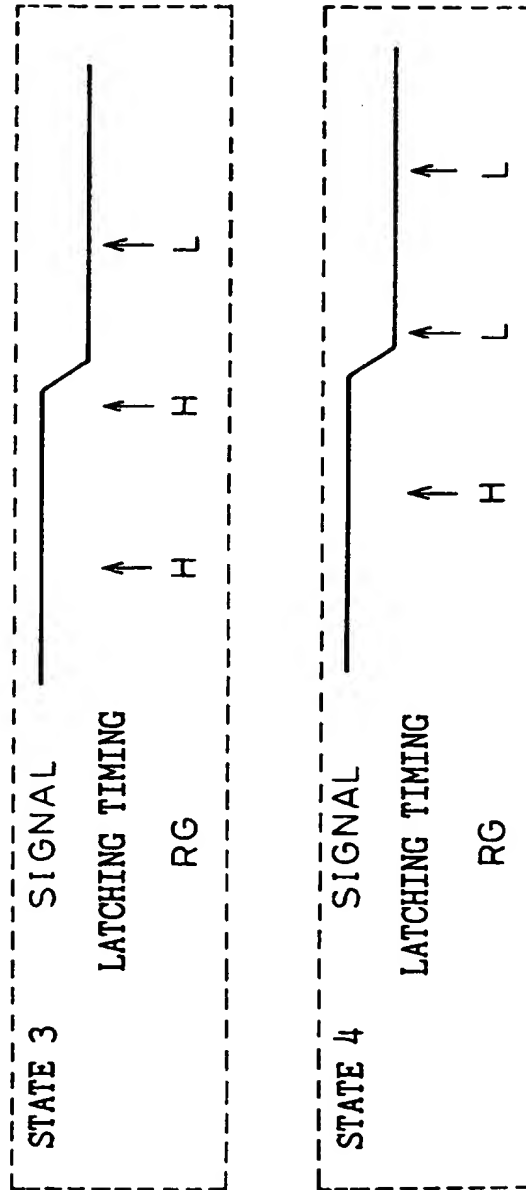


Fig. 46

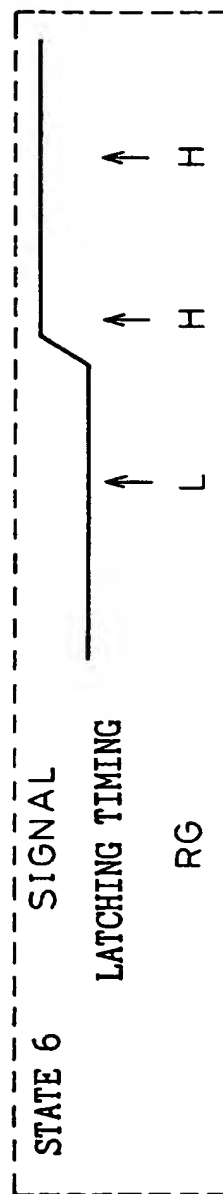
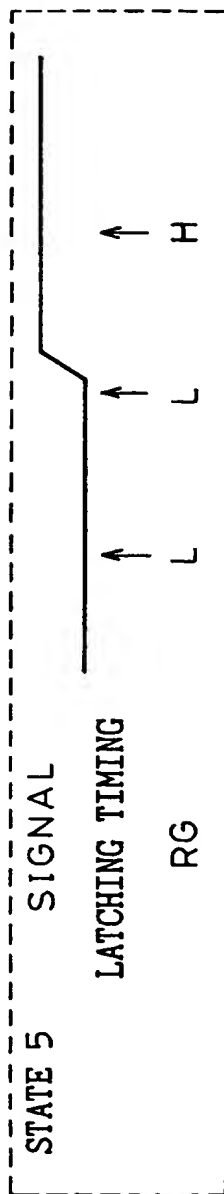


Fig.47

STATE	RG0	RG1	RG2	UP/DOWN	HOLD	OPERATION
1	H	H	H	H	L	NO CHANGE
2	L	L	L	H	L	
3	H	H	L	L	H	DELAY IS DECREASED.
4	H	L	L	H	H	DELAY IS INCREASED.
5	L	L	H	L	H	DELAY IS DECREASED.
6	L	H	H	H	H	DELAY IS INCREASED.

Fig. 48

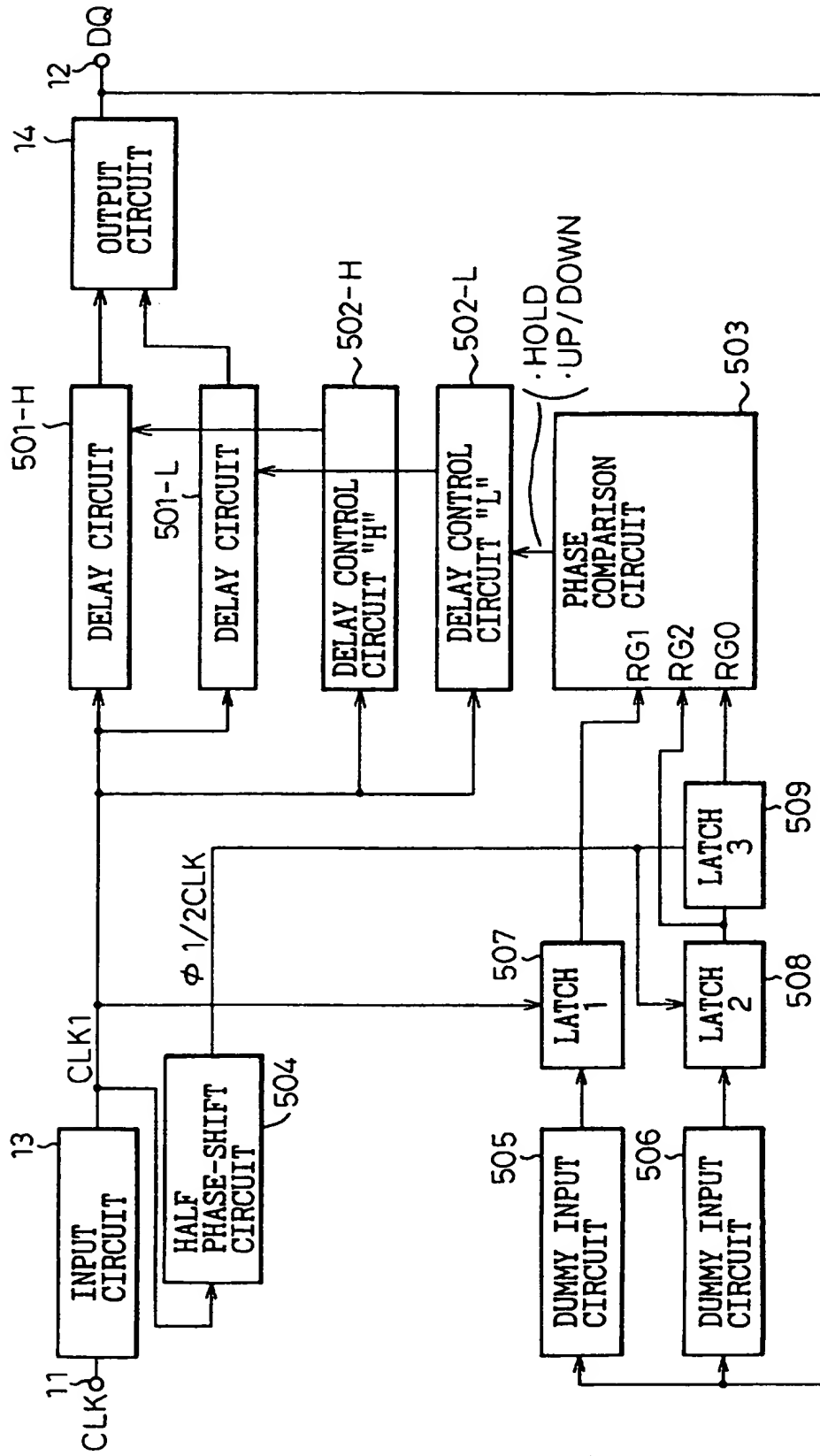


Fig. 49

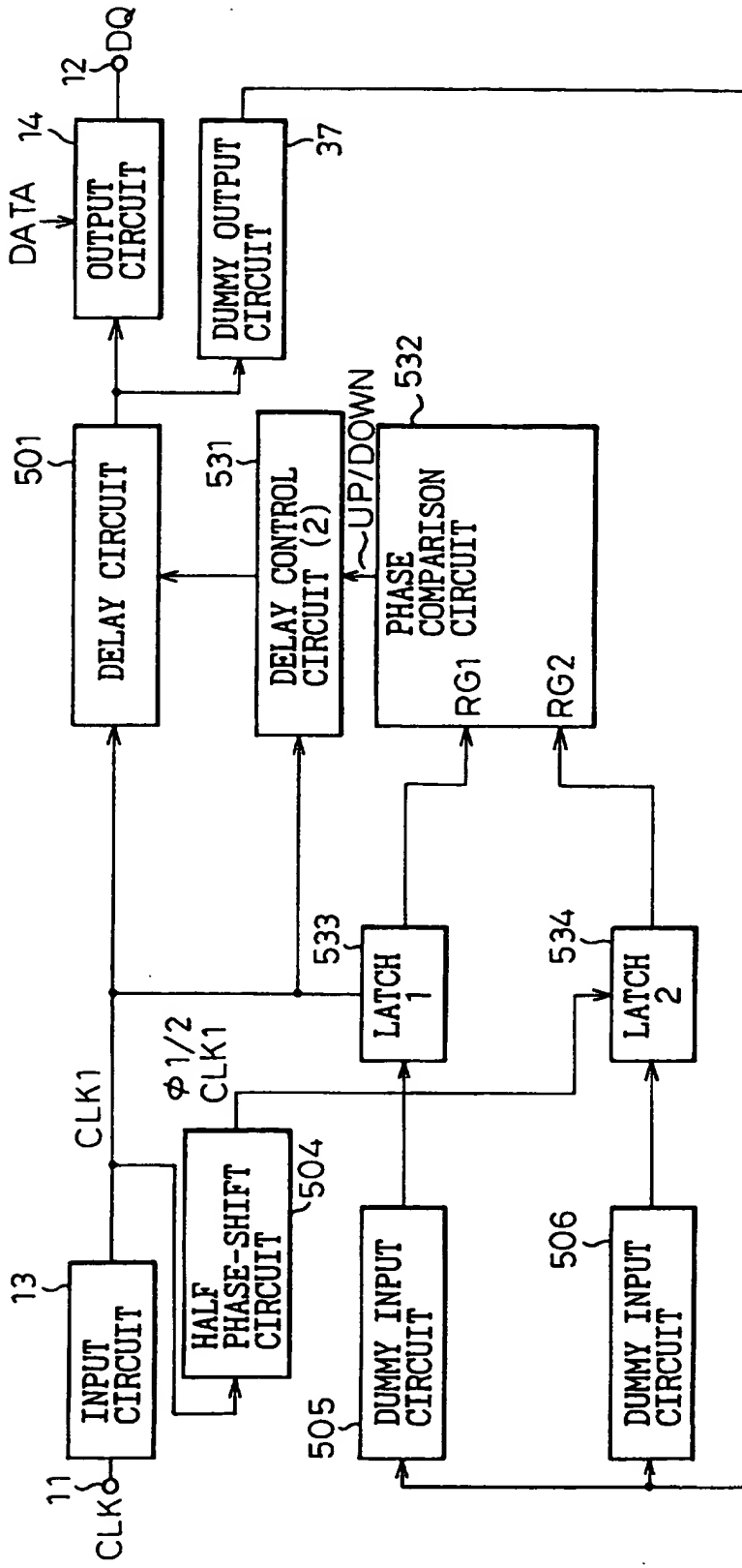


Fig. 50

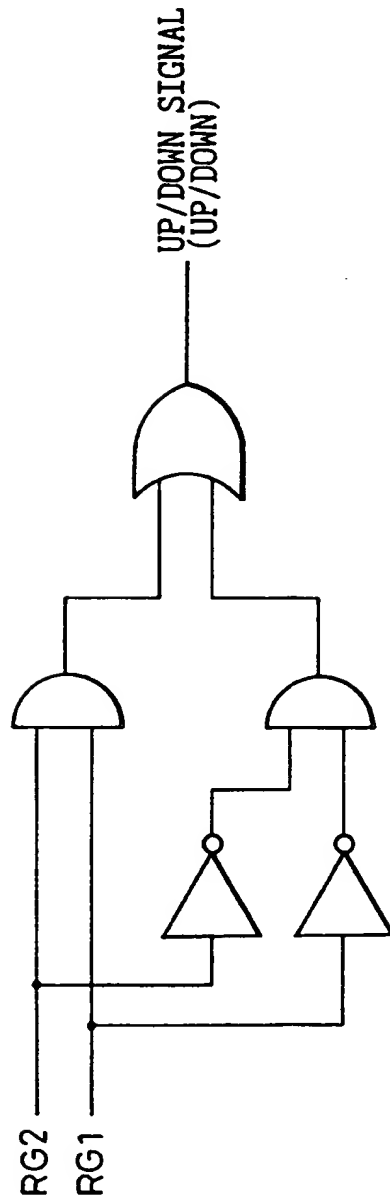


Fig. 51A

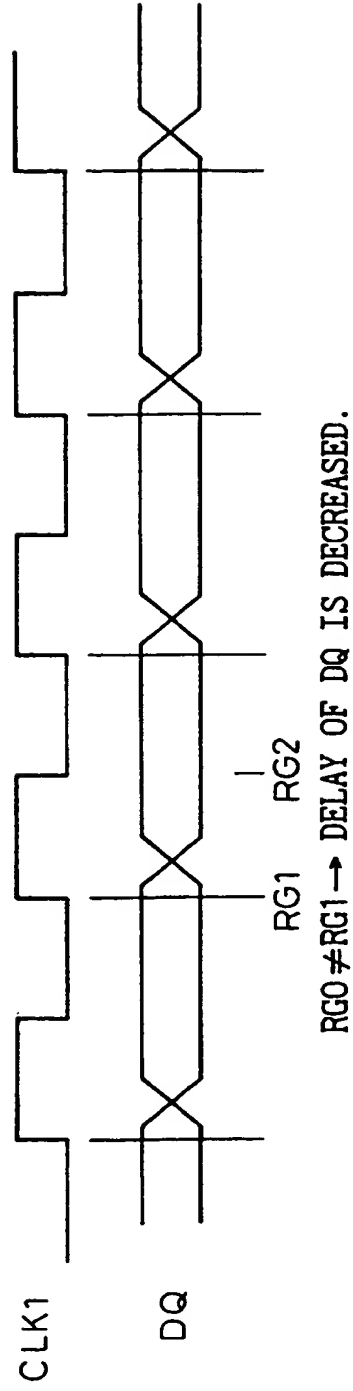


Fig. 51B

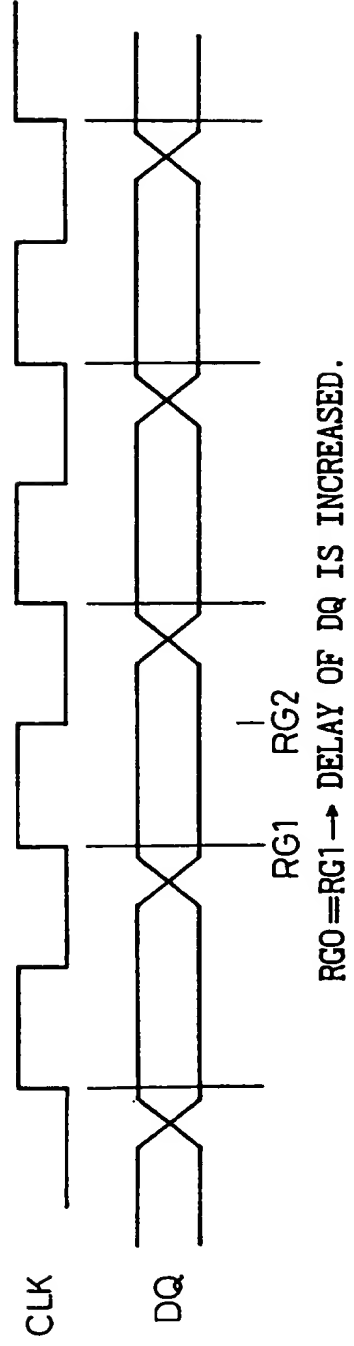


Fig.52

RG1	RG2	UP/DOWN SIGNAL	OPERATION
L	L	H	DELAY IS INCREASED.
H	H	H	
L	H	L	DELAY IS DECREASED.
H	L	L	

Fig.53

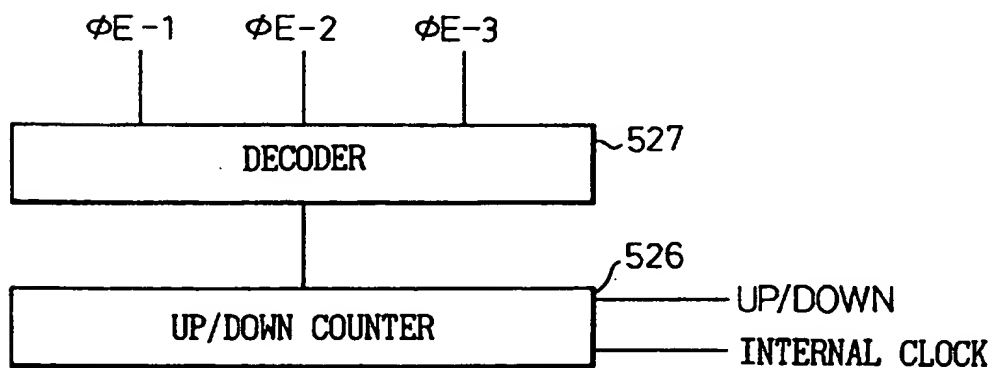


Fig. 54

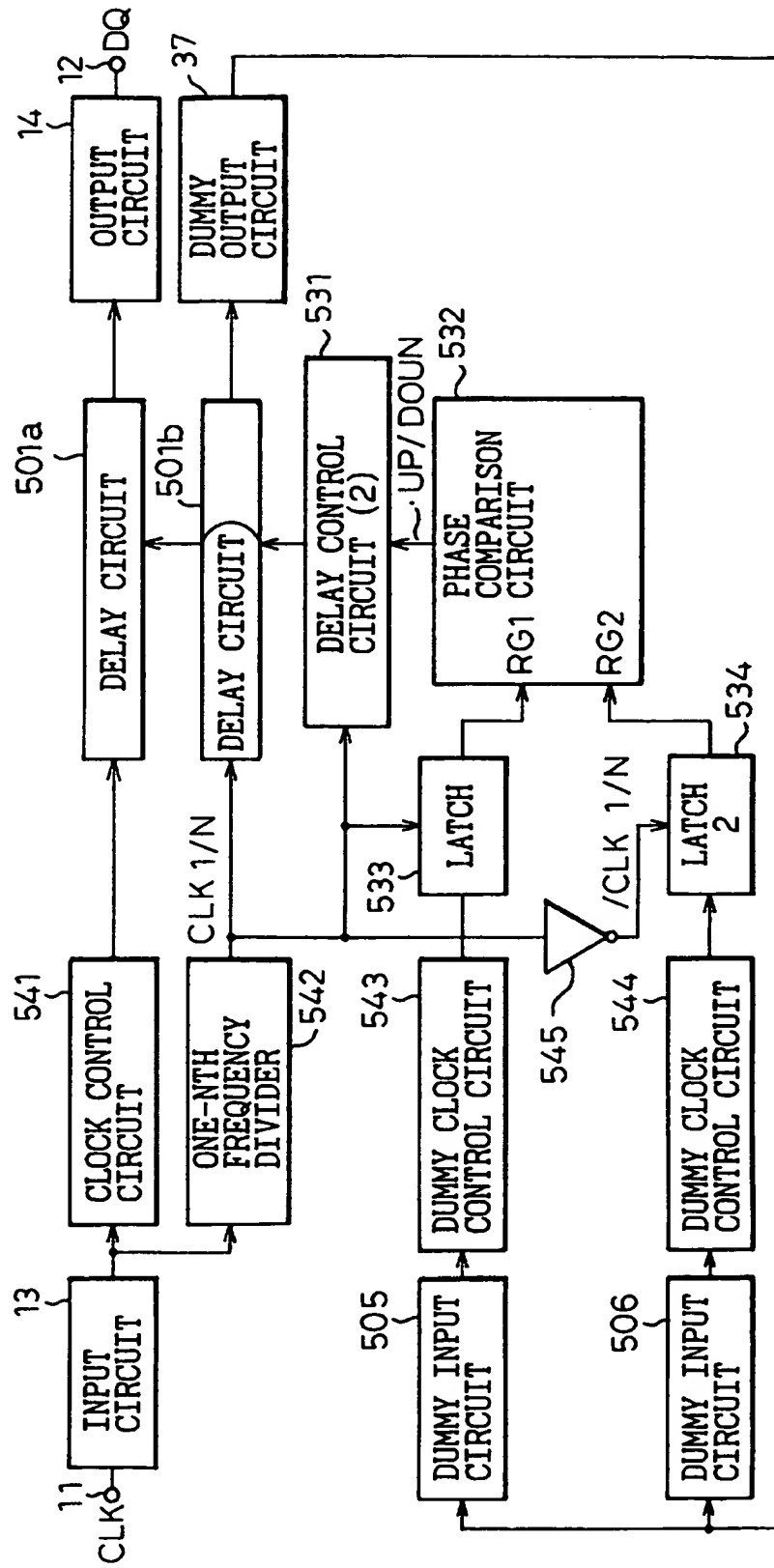


Fig.55

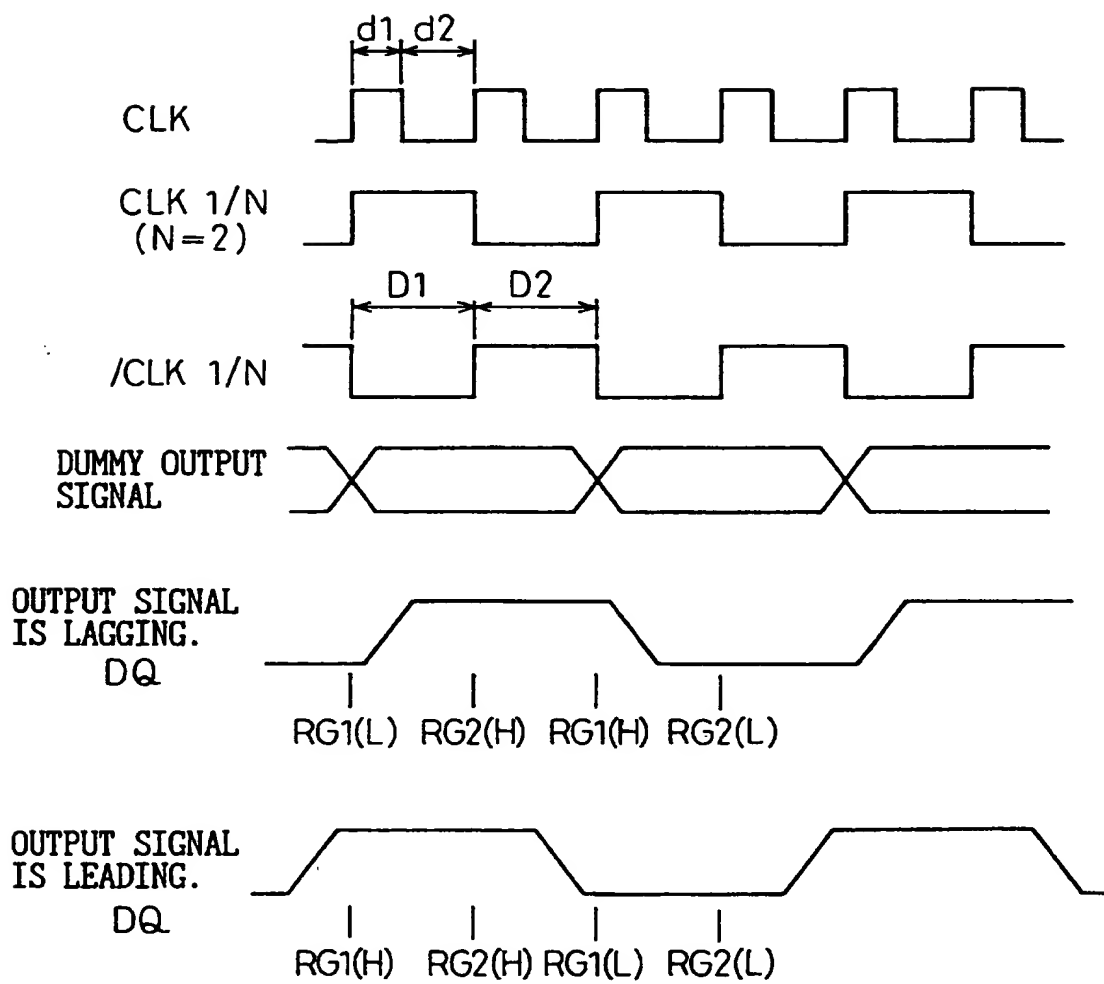


Fig. 56

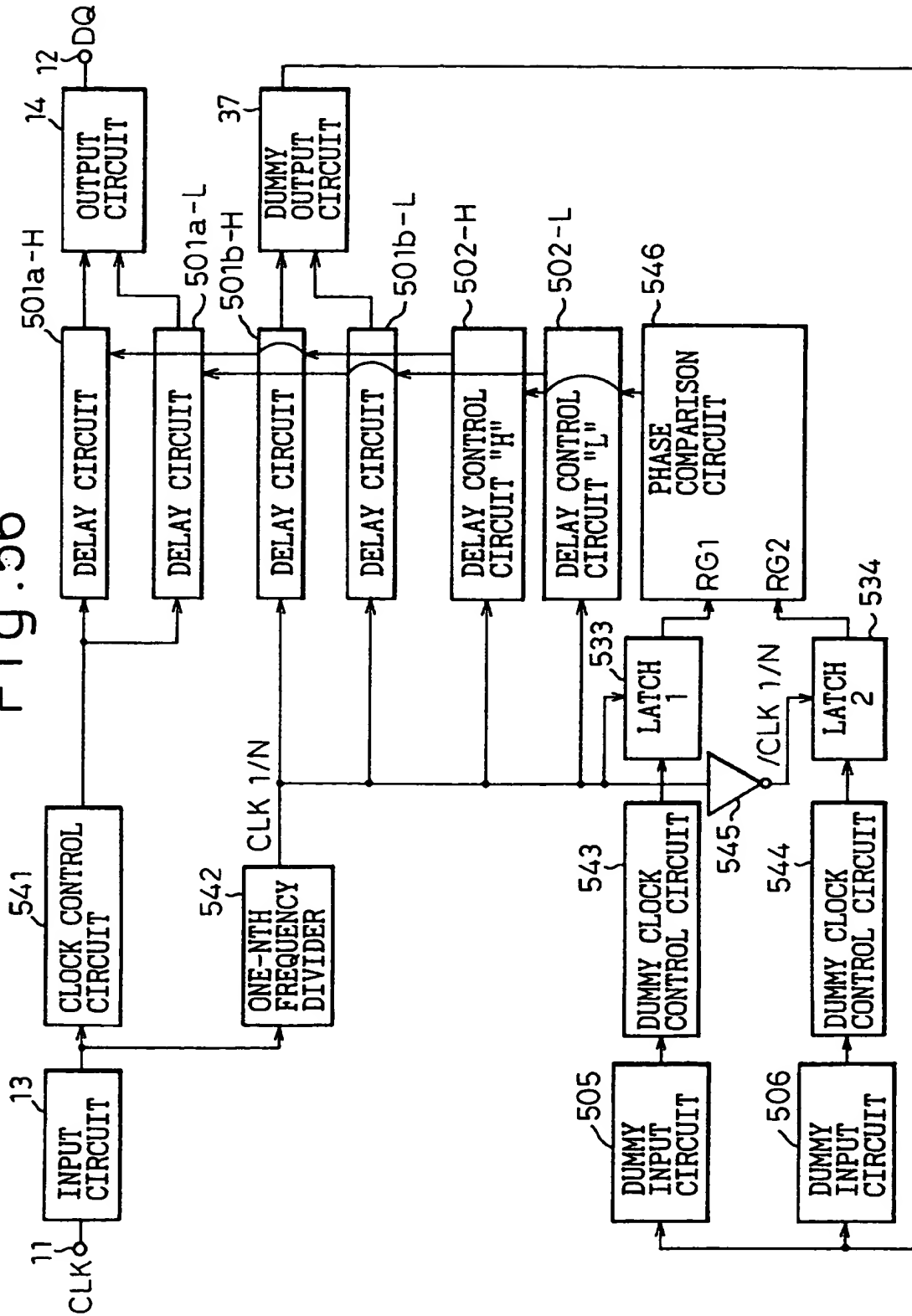


Fig. 57

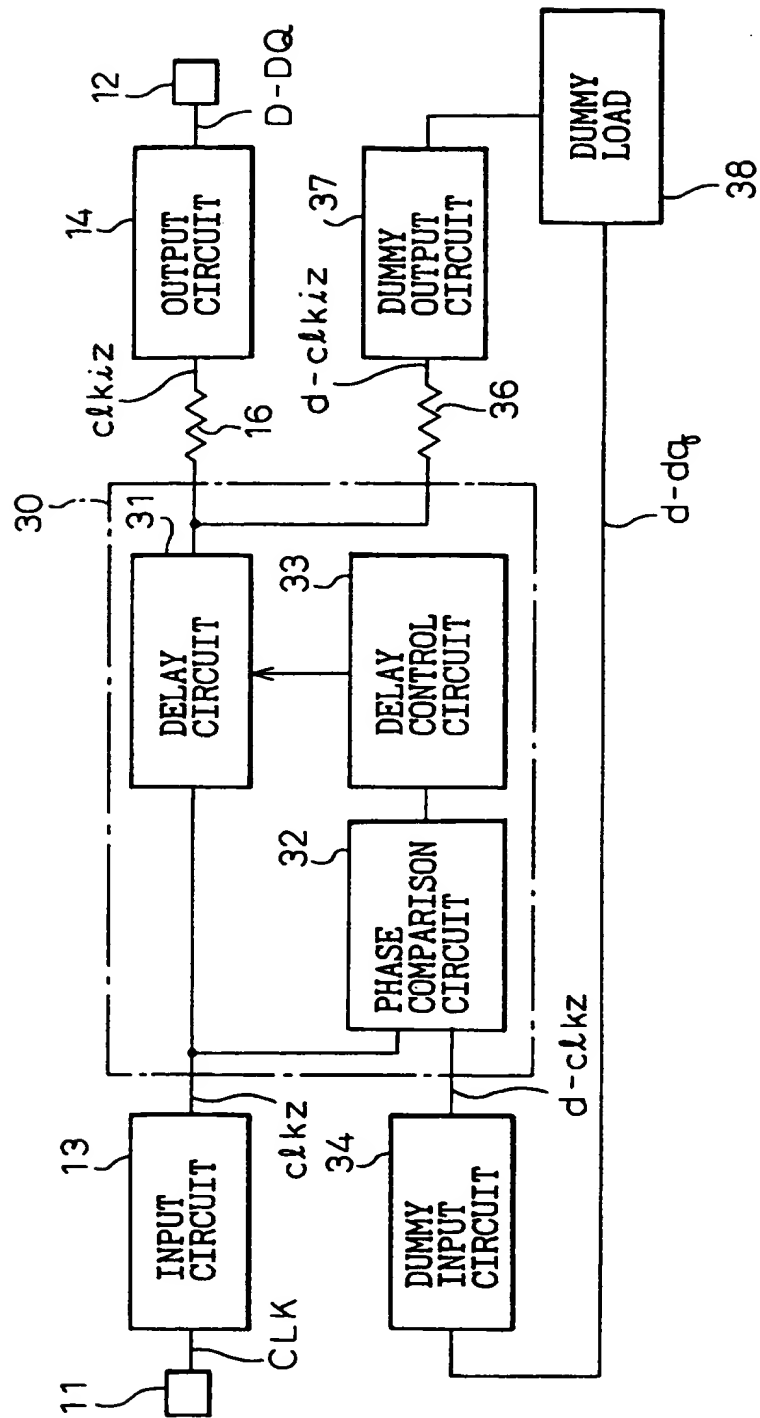


Fig .58

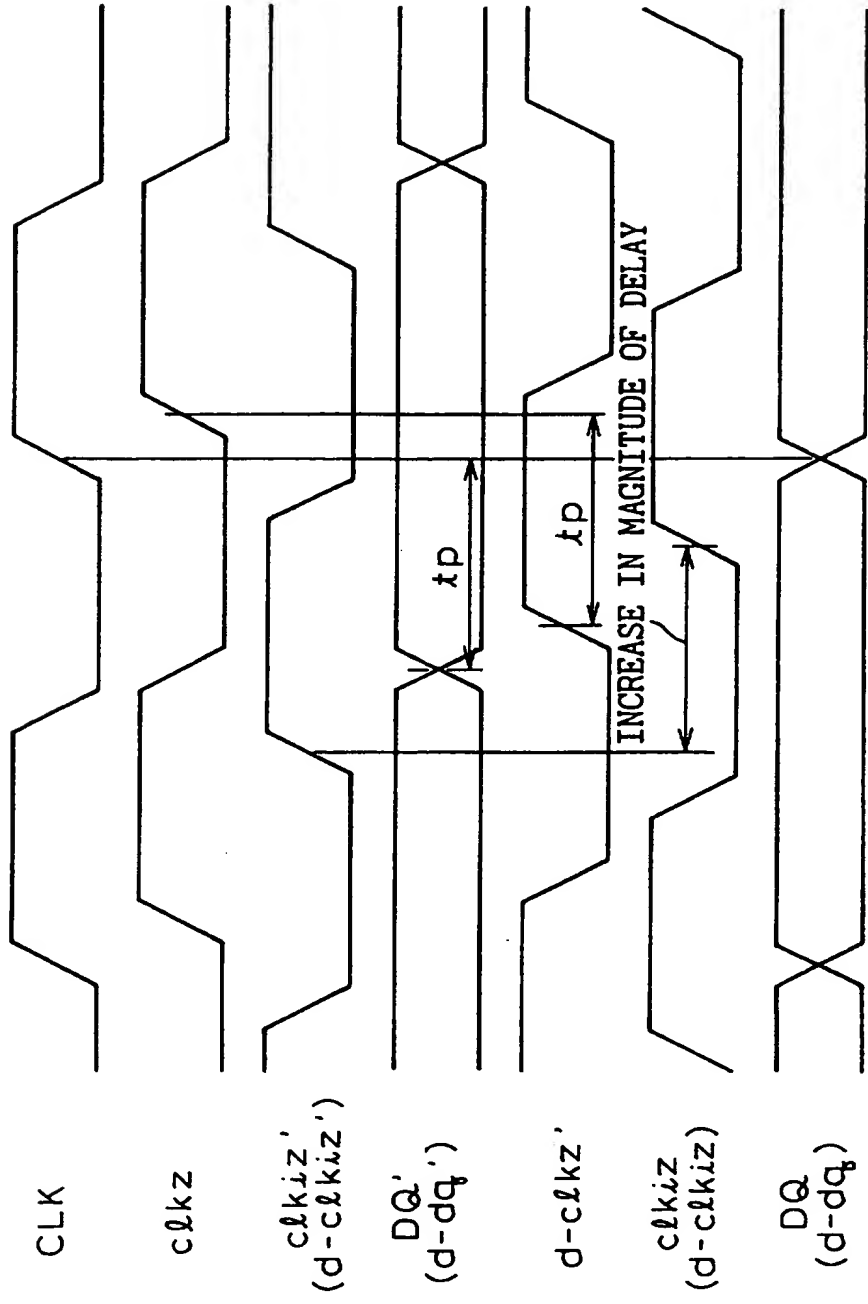


Fig. 59

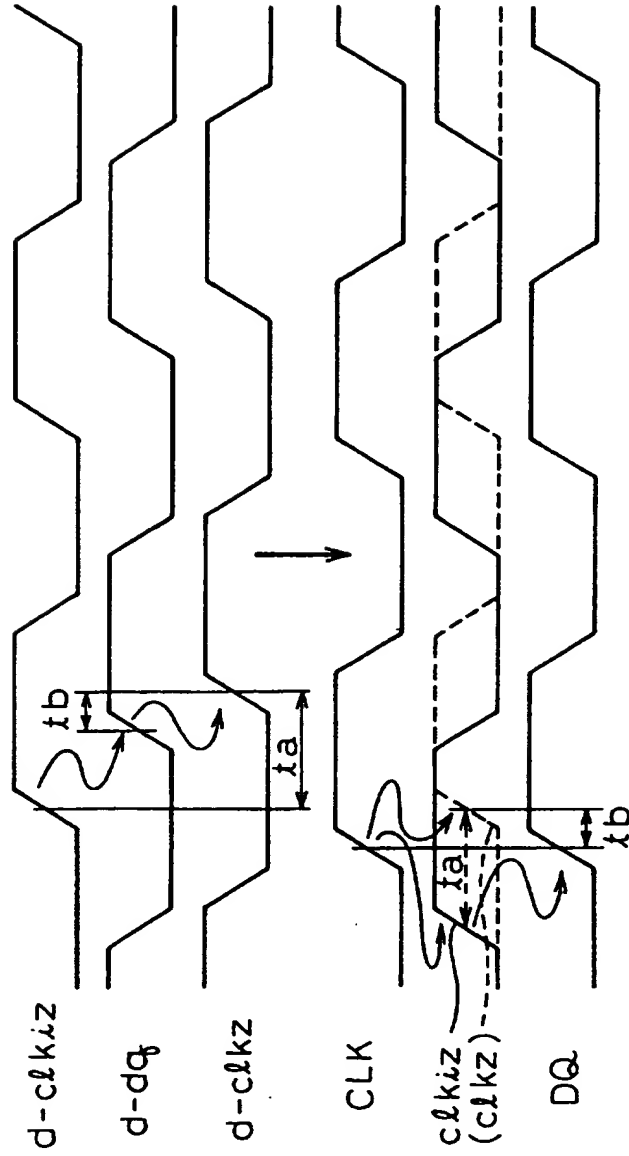


Fig. 60

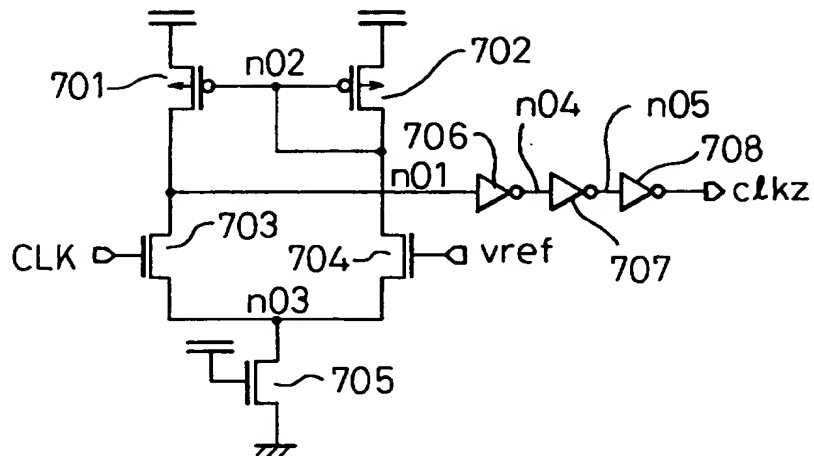


Fig.61A

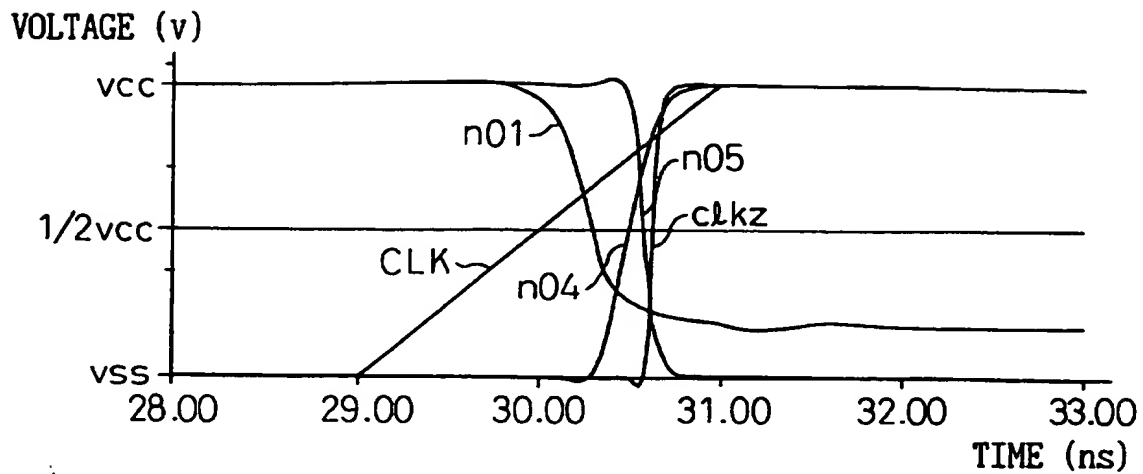


Fig.61B

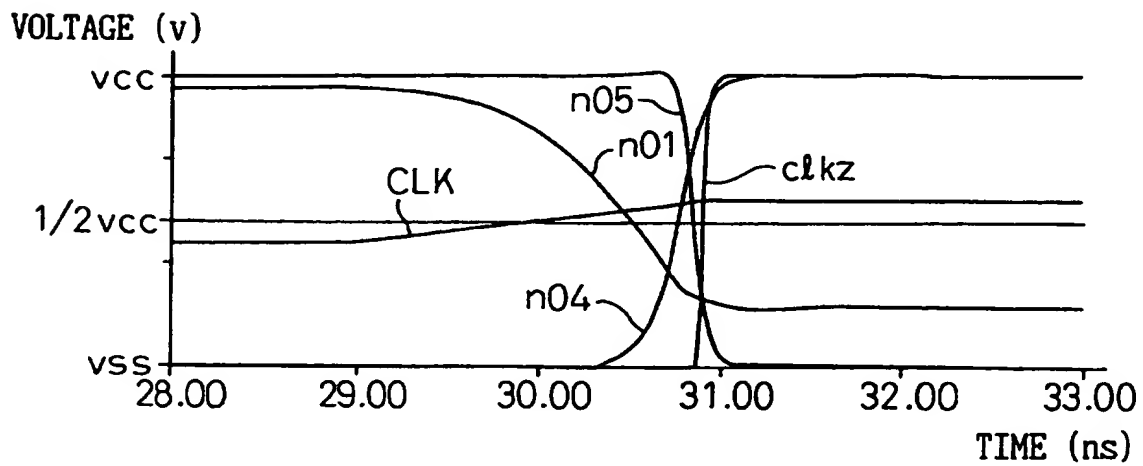


Fig.62

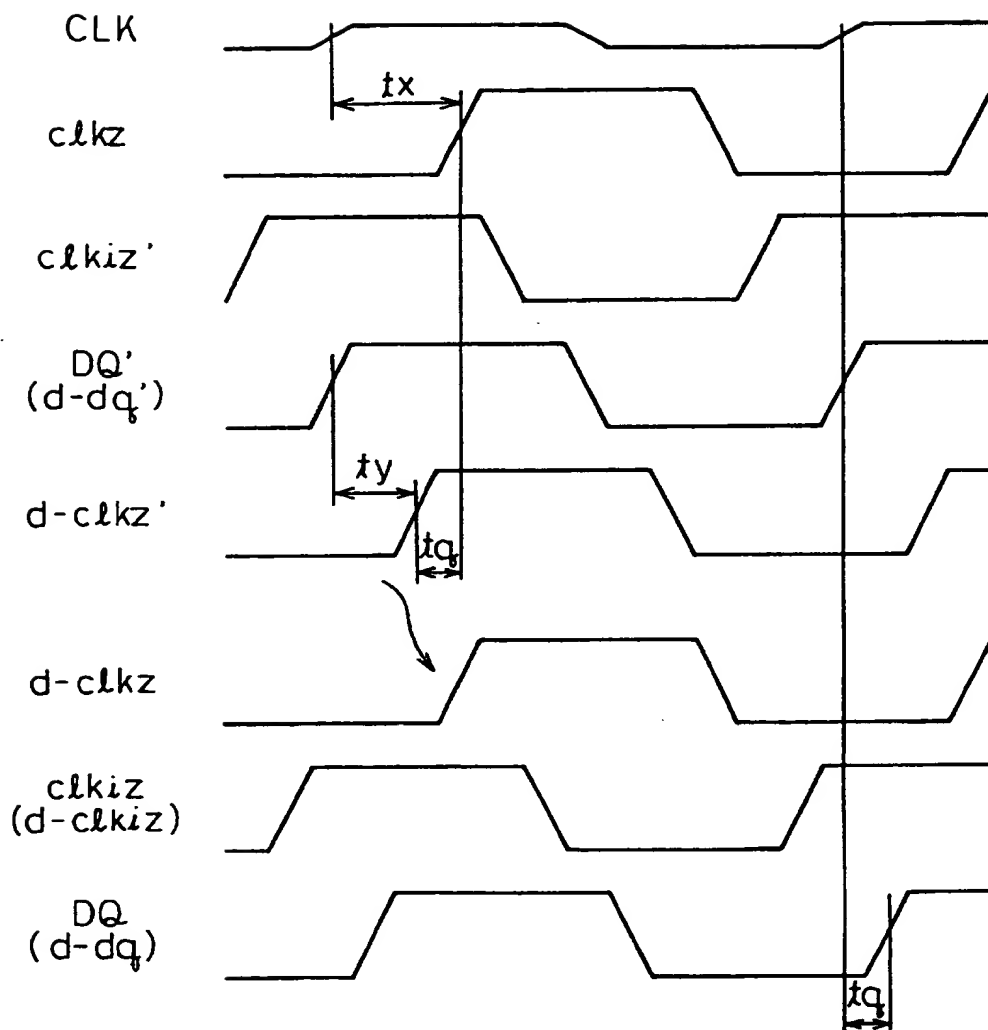


Fig. 63

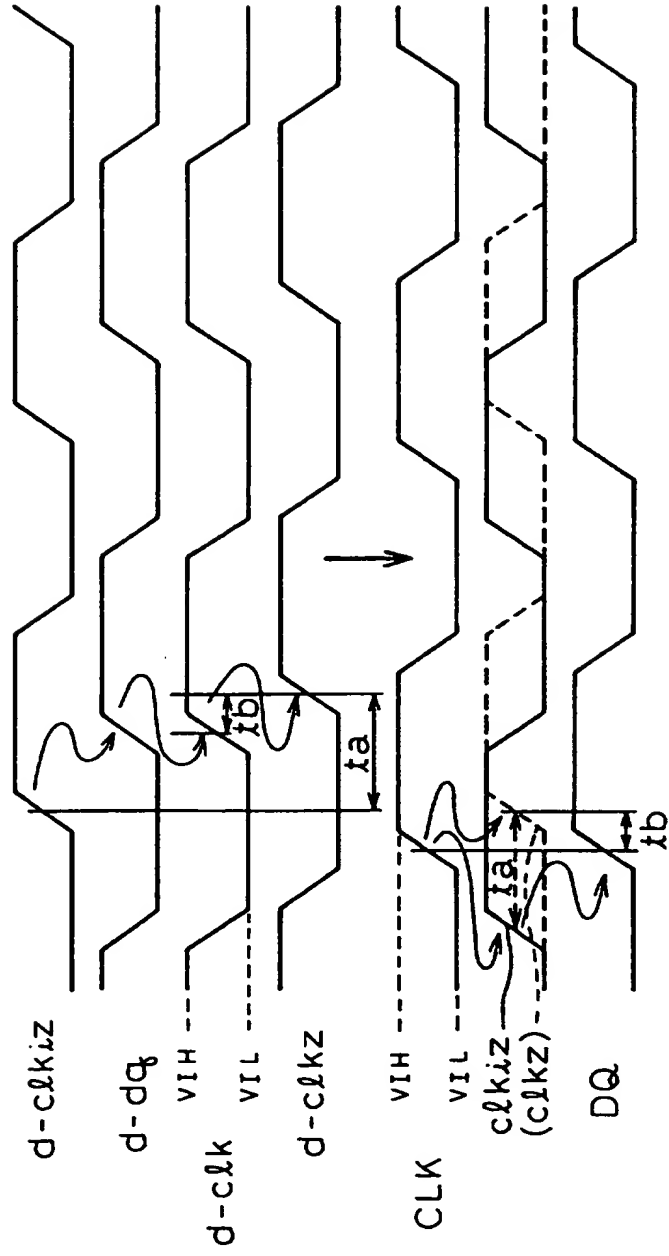


Fig. 64

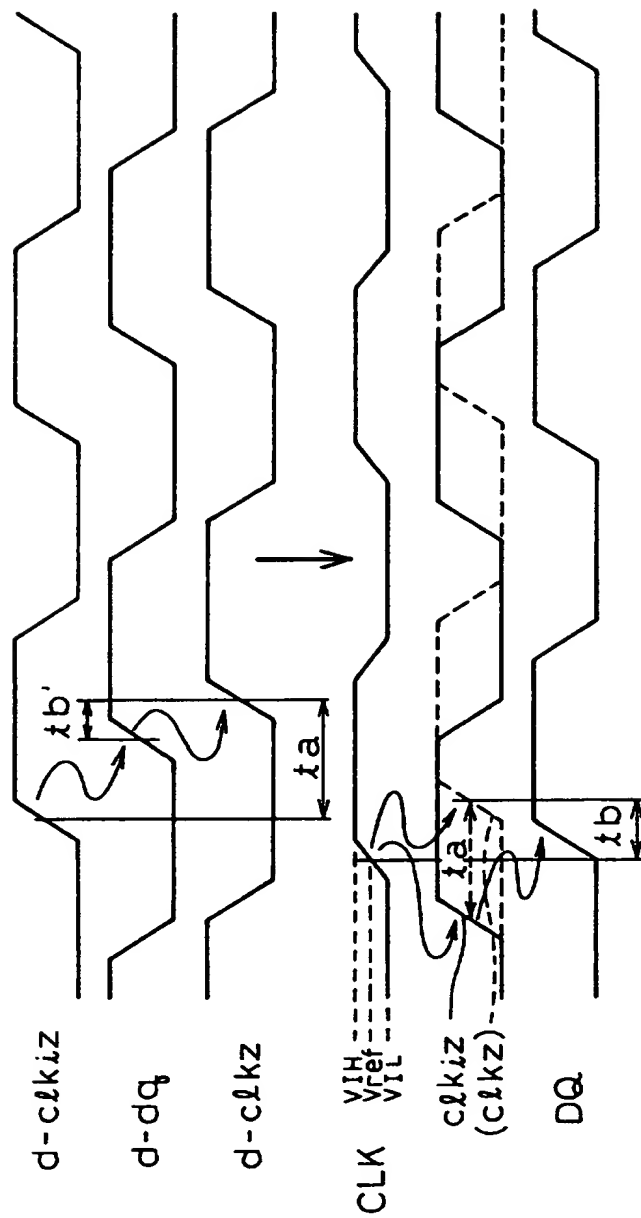


Fig. 65

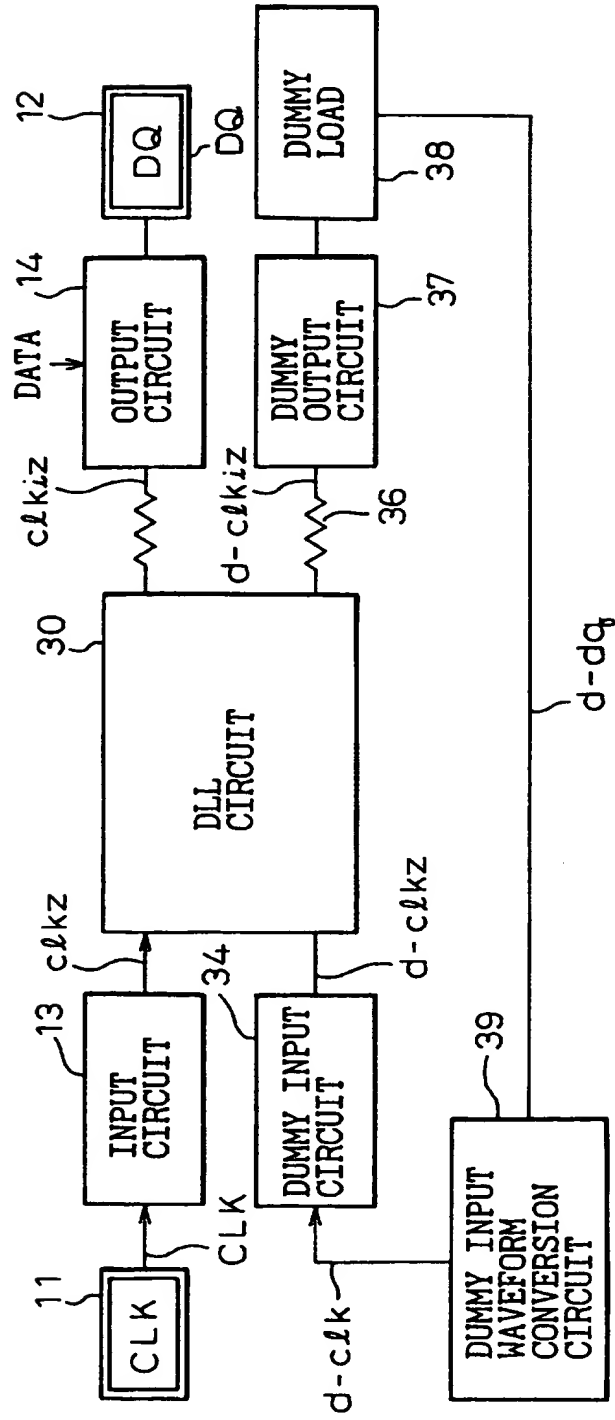


Fig. 66

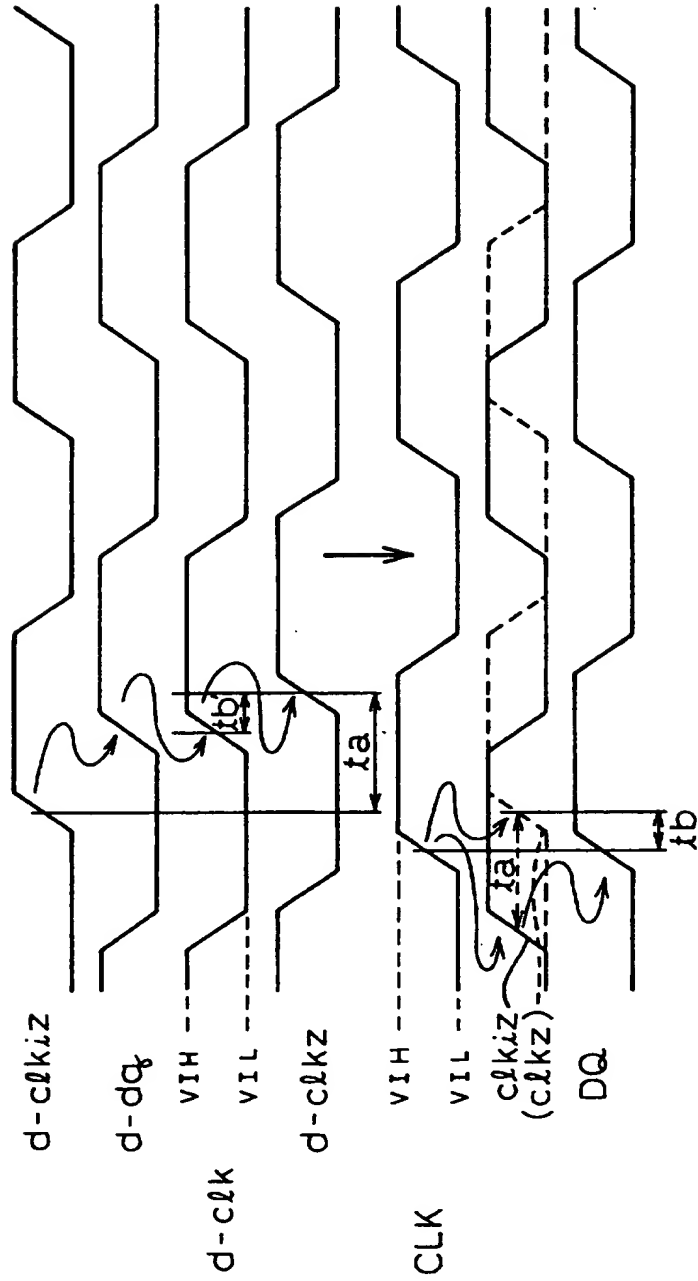


Fig. 67

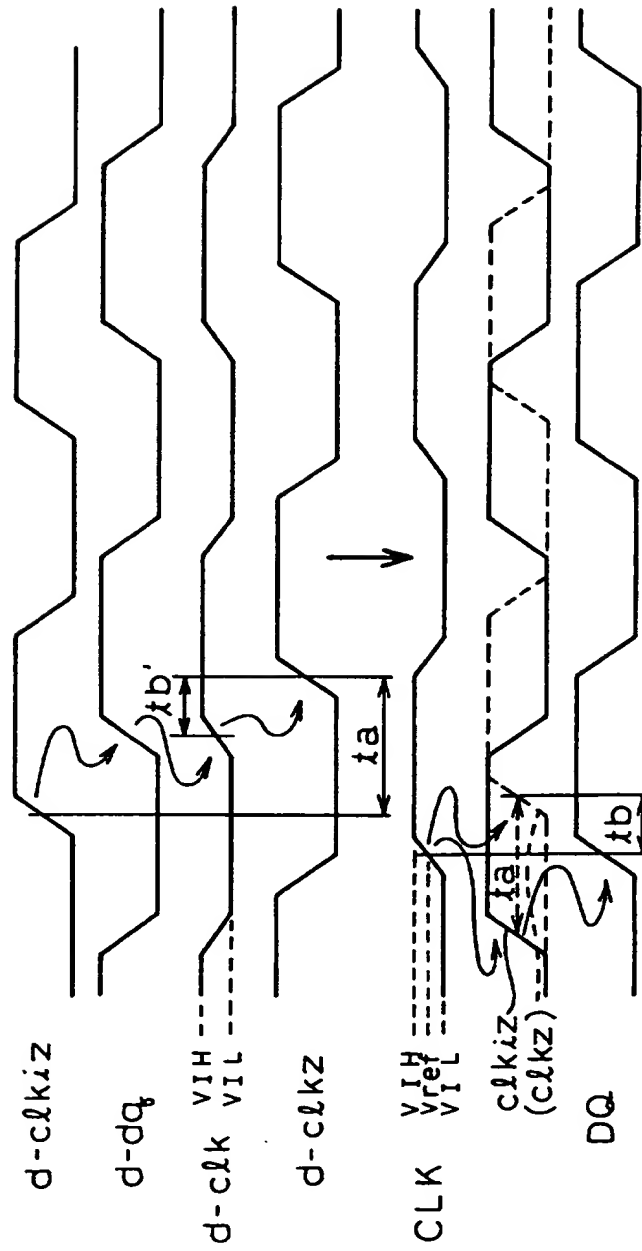


Fig.68A

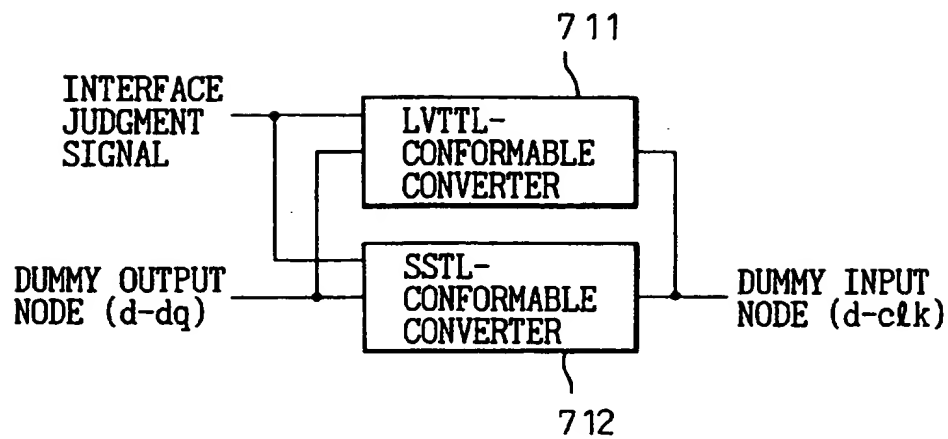


Fig.68B

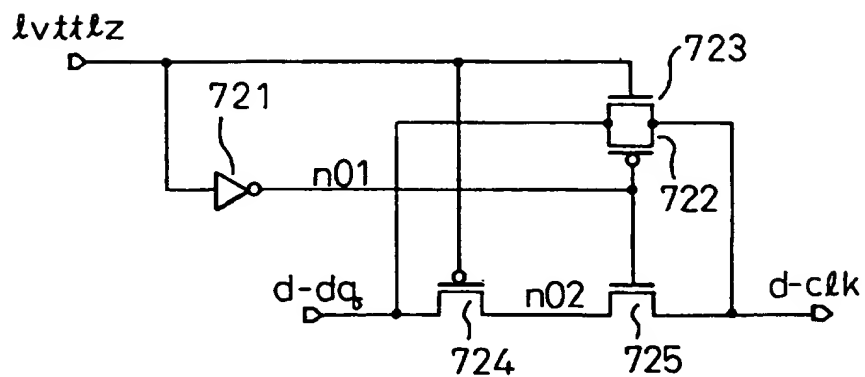


Fig.69

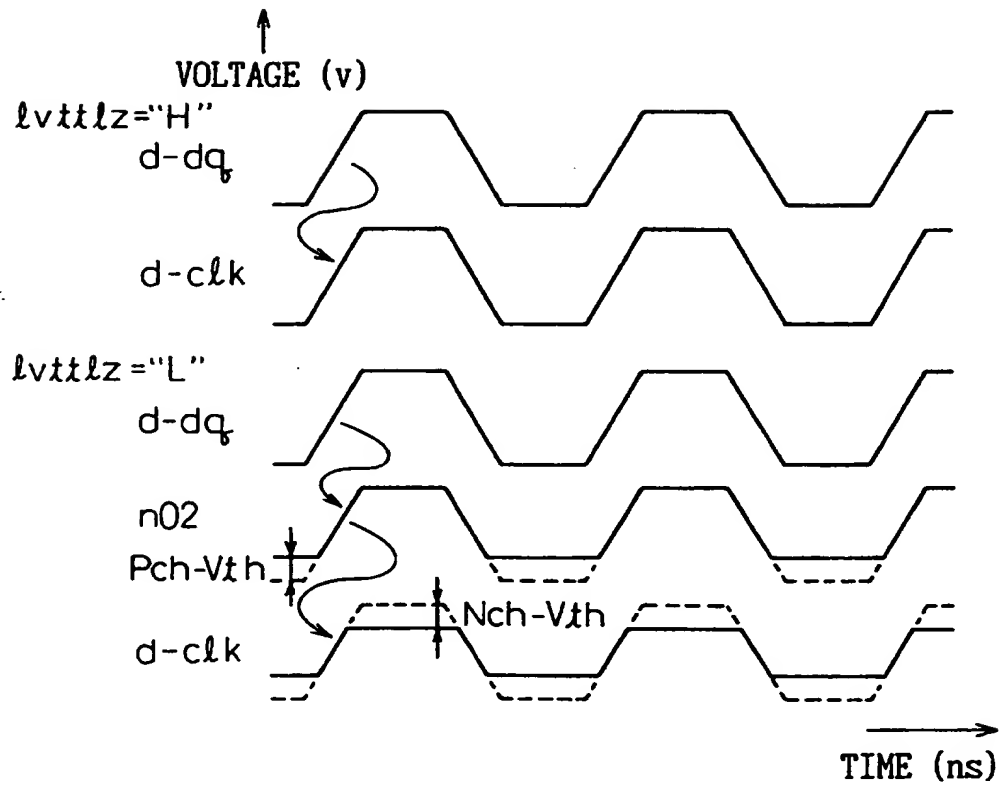


Fig.70

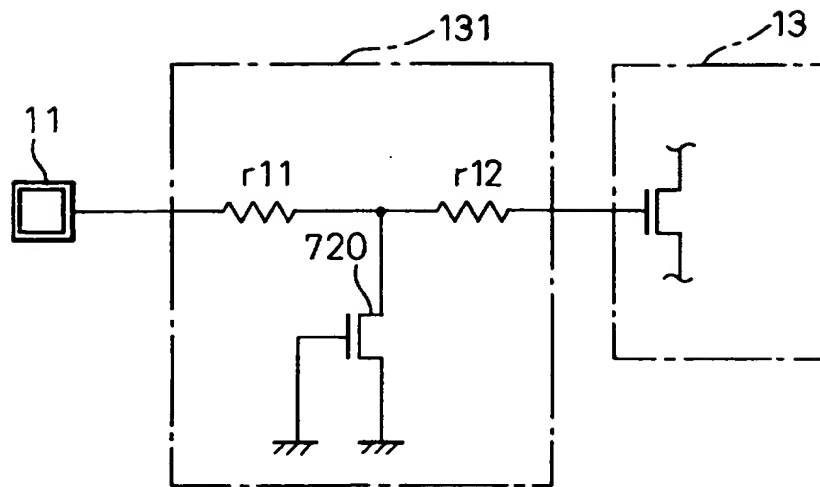


Fig.71

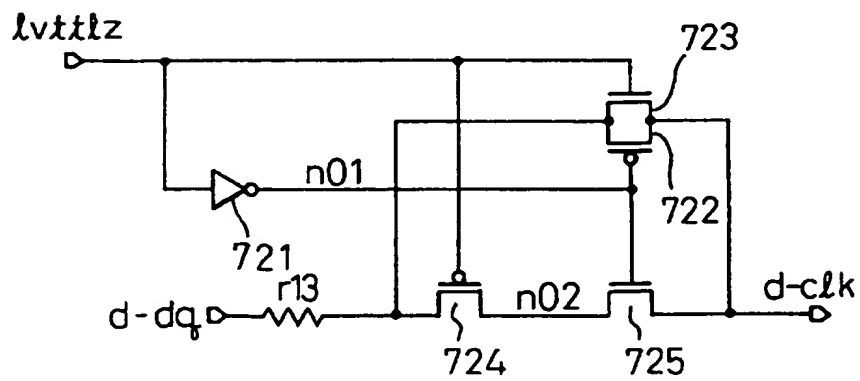


Fig. 72A

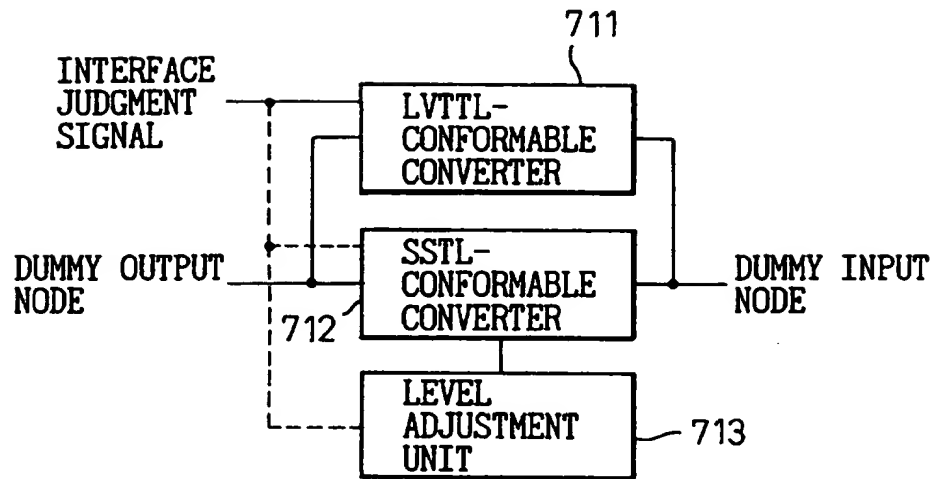


Fig. 72B

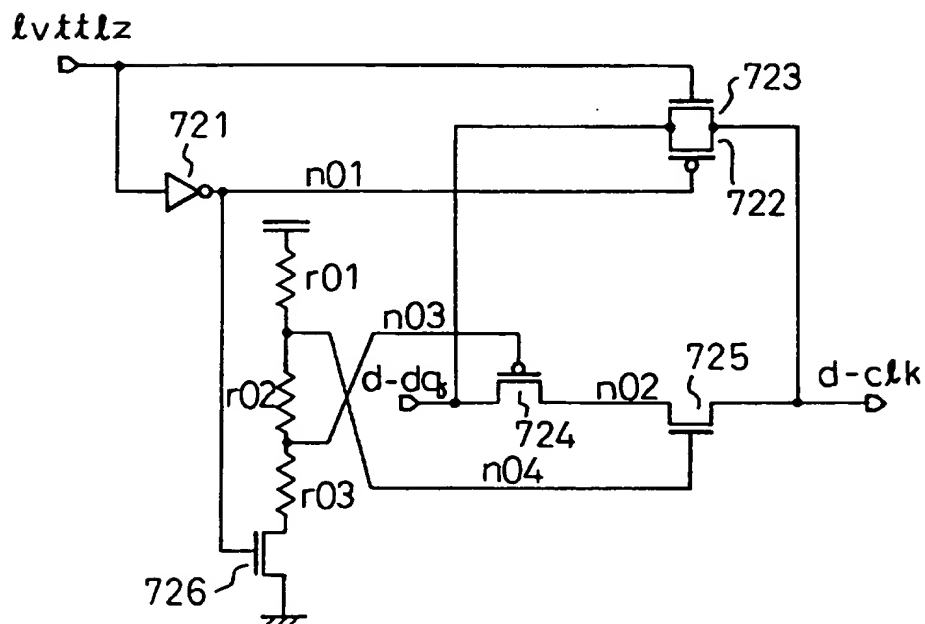


Fig.73

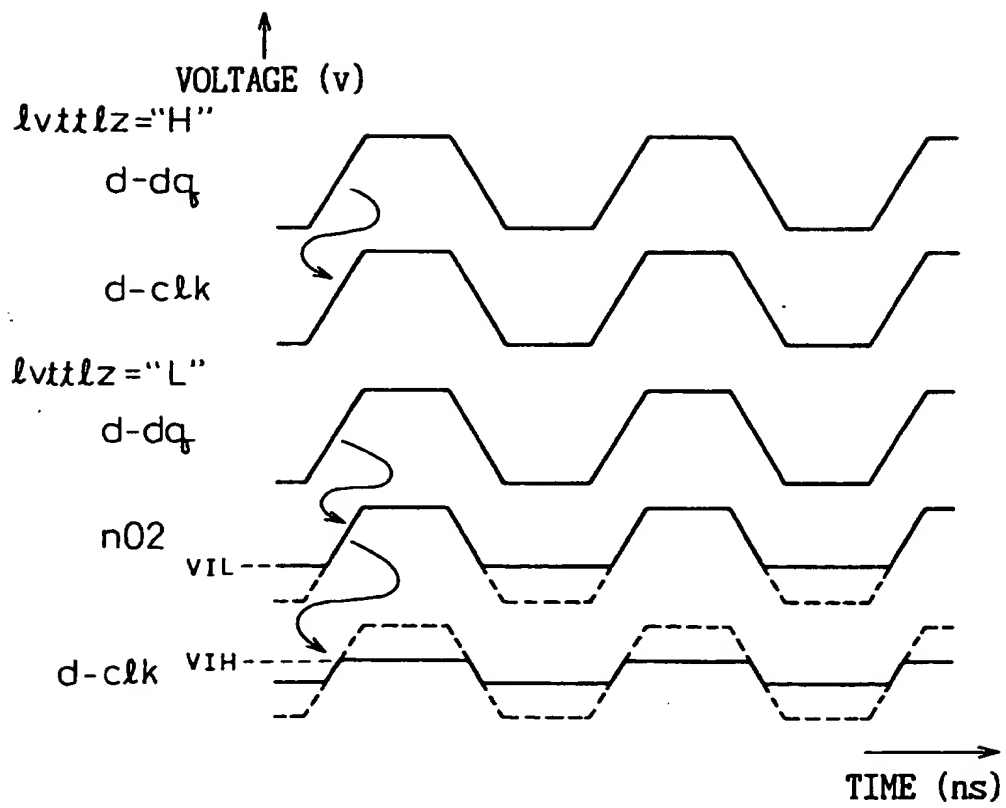


Fig. 74

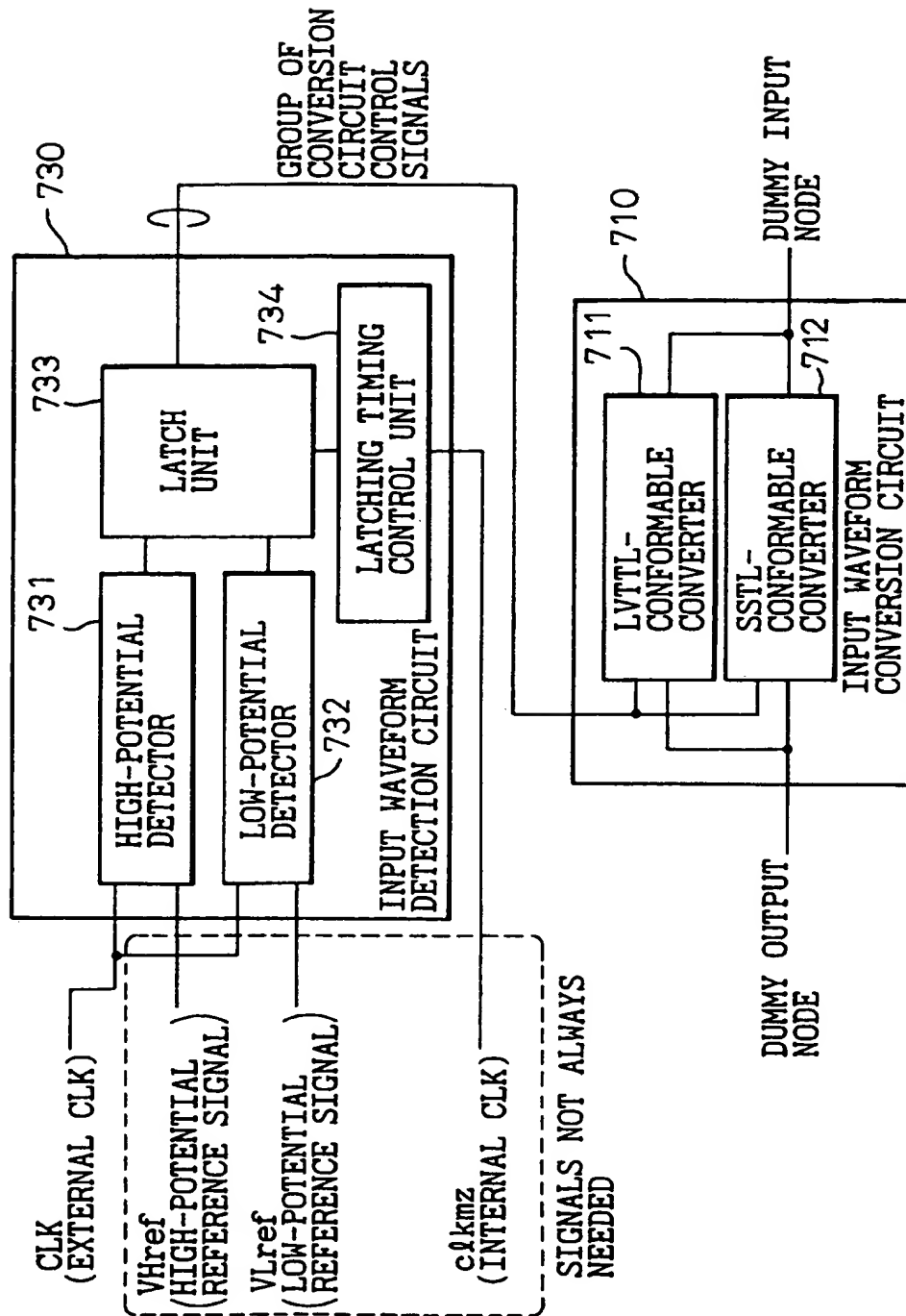


Fig. 75

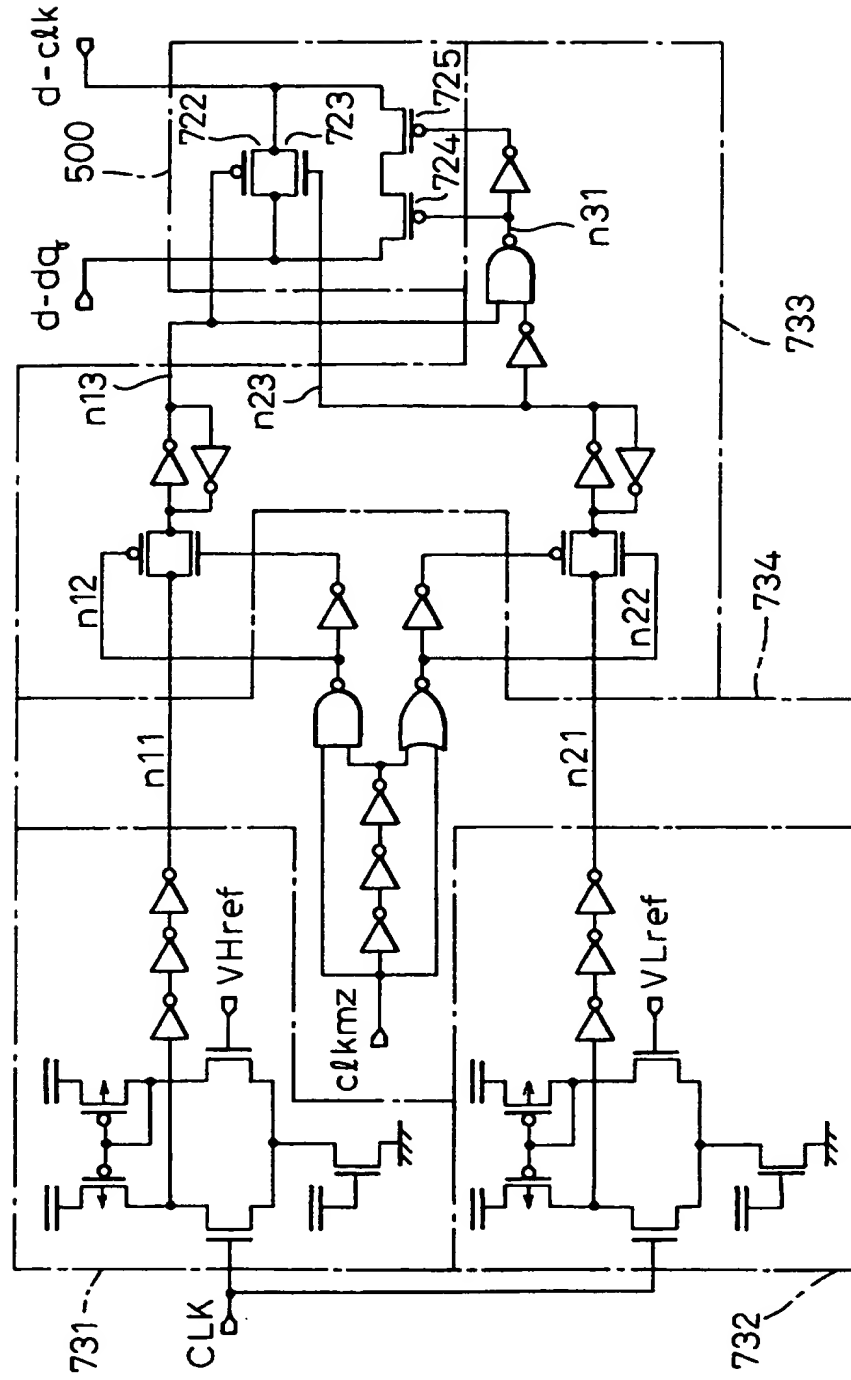


Fig.76

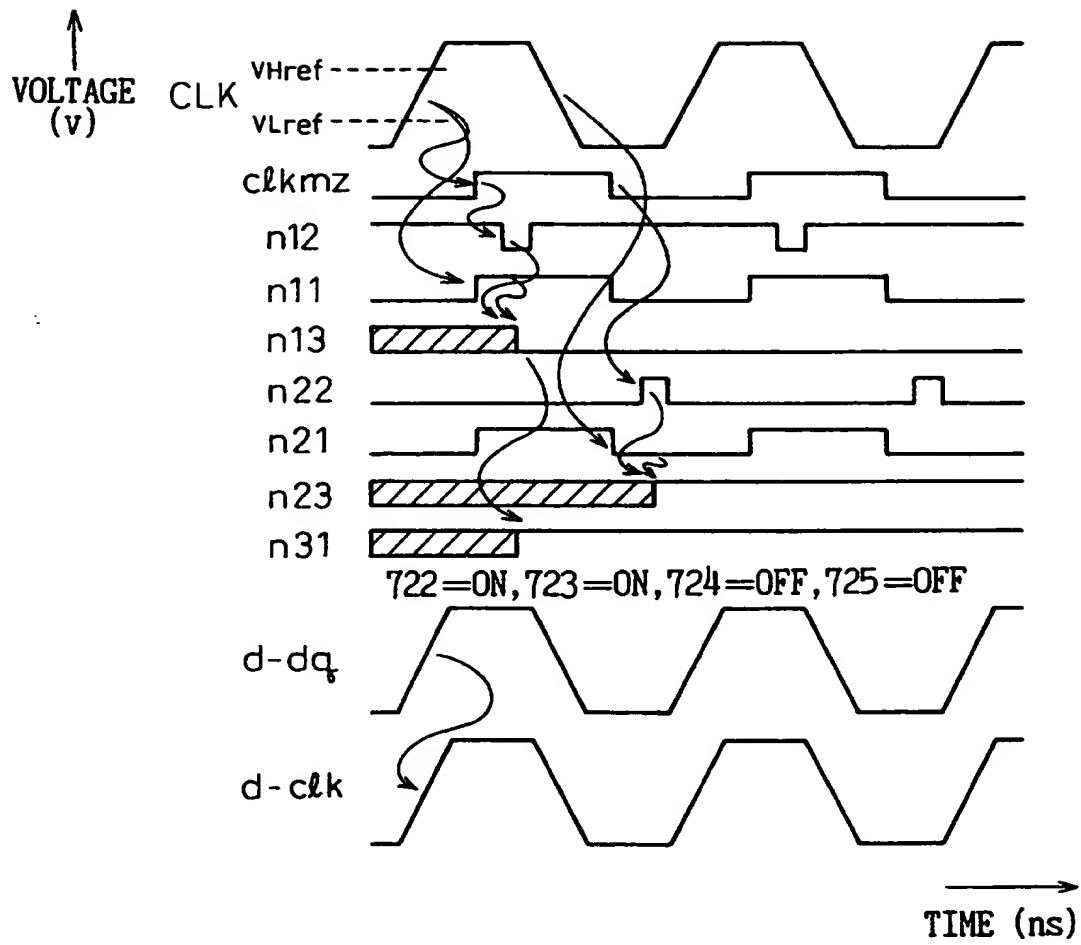


Fig. 77

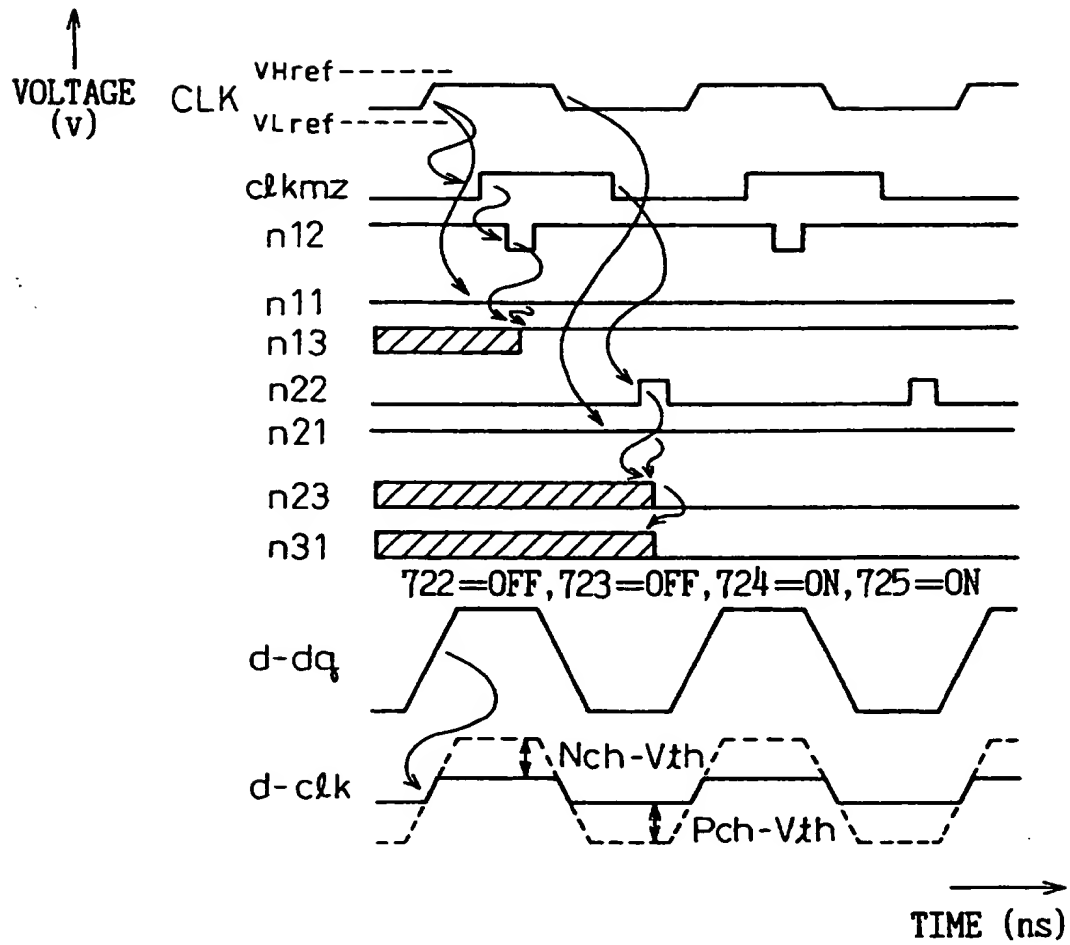


Fig.78

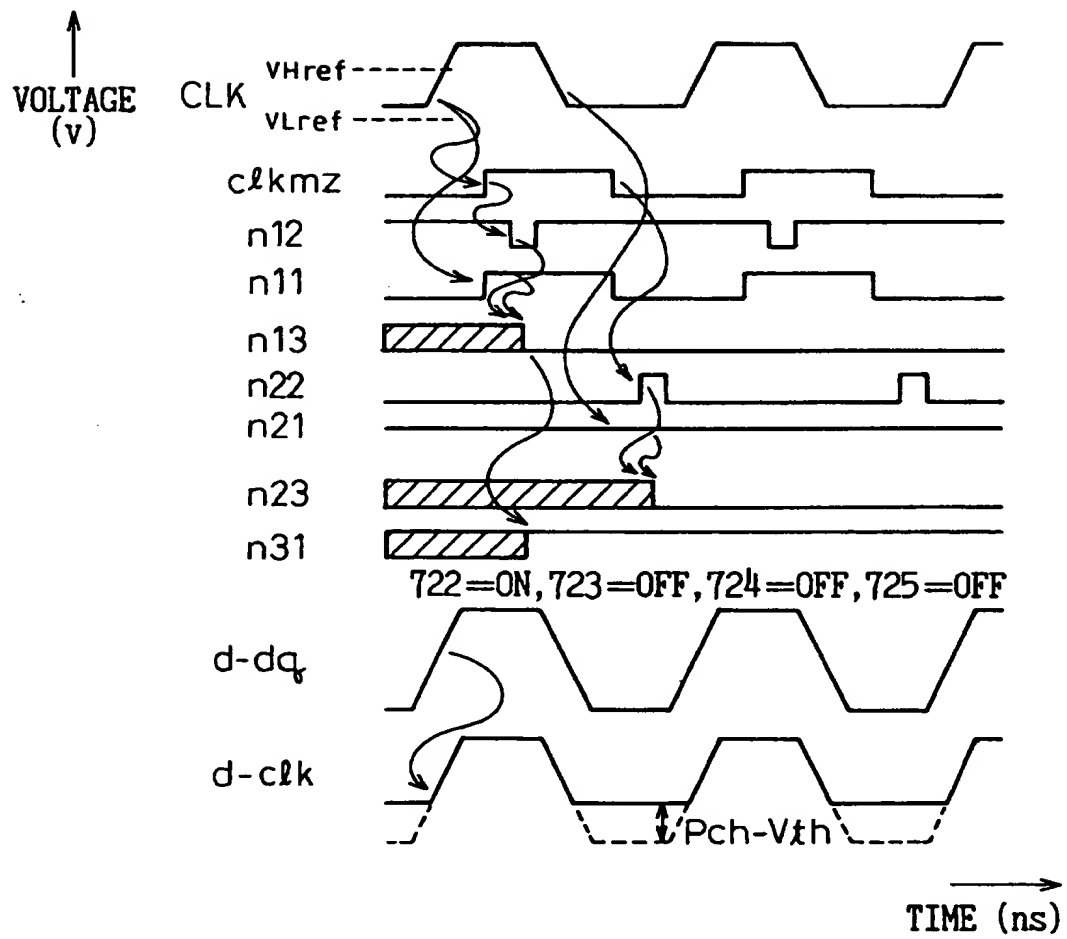


Fig. 79

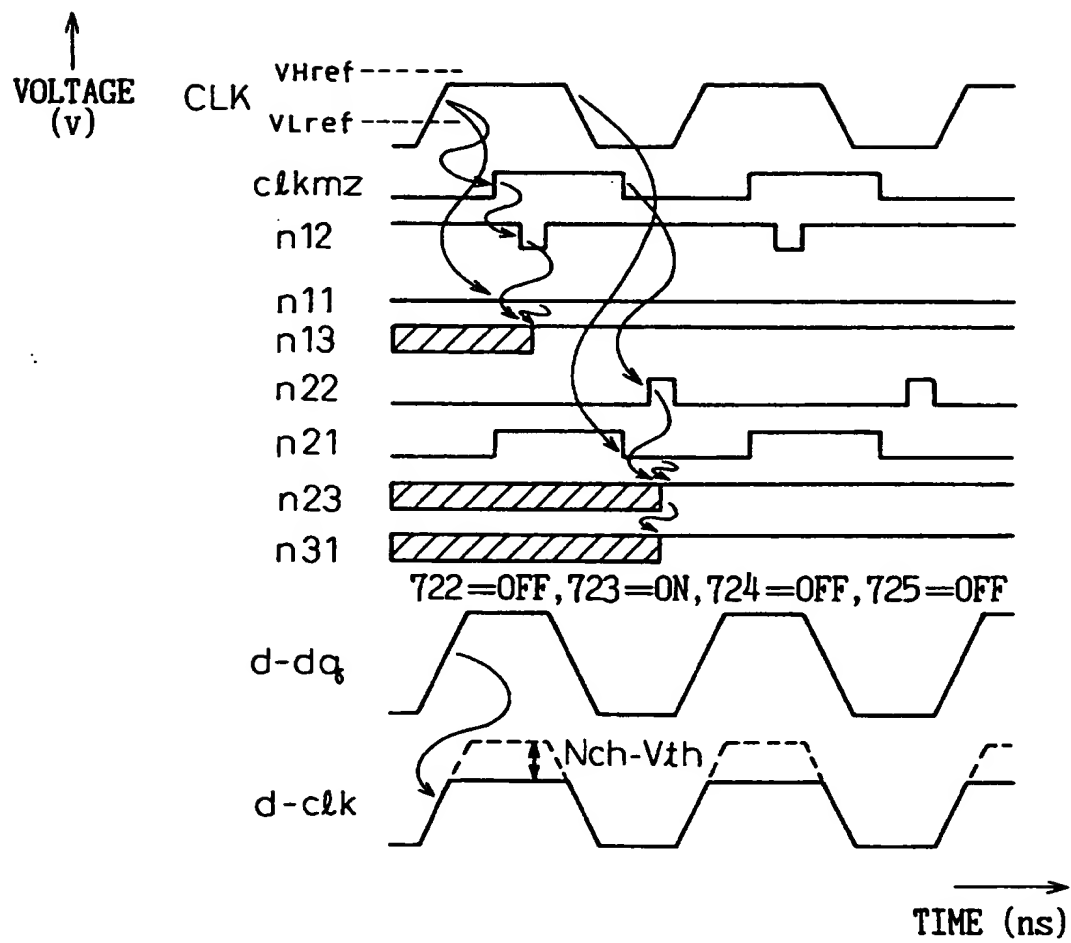


Fig. 80

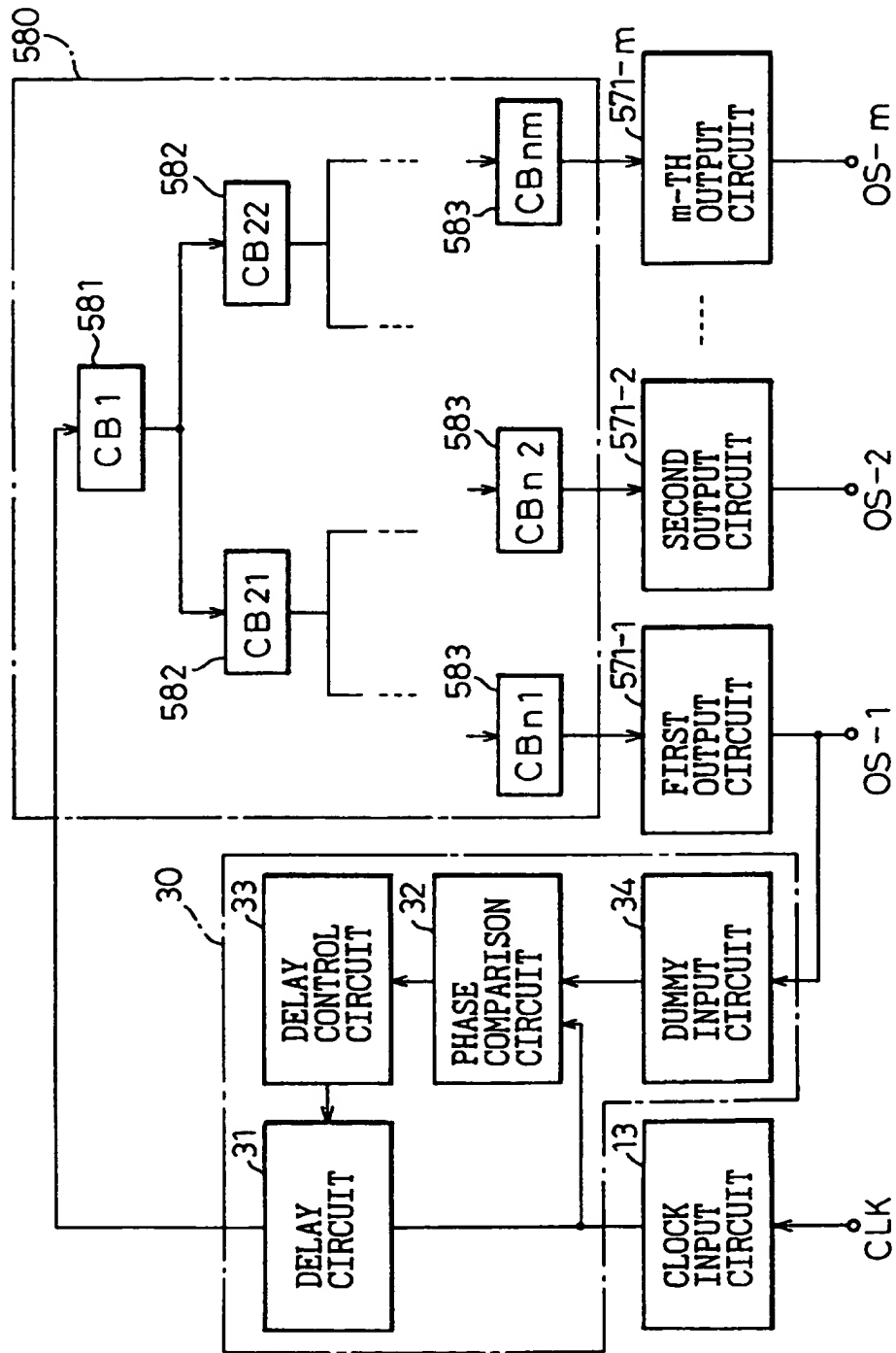
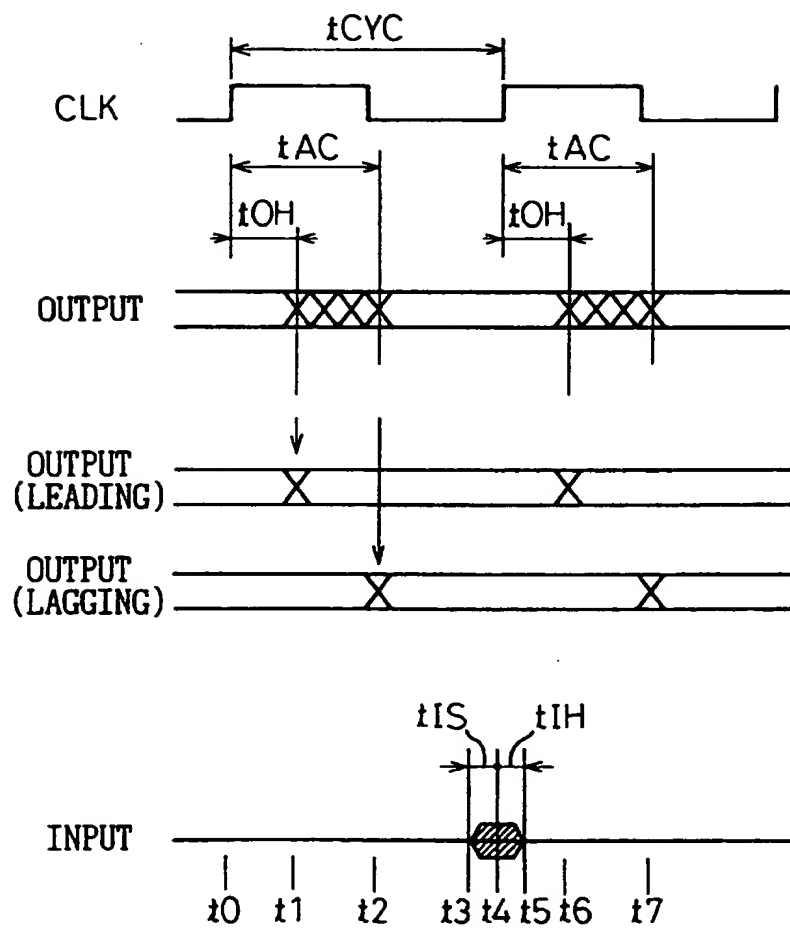


Fig. 81



80/88

Fig.82

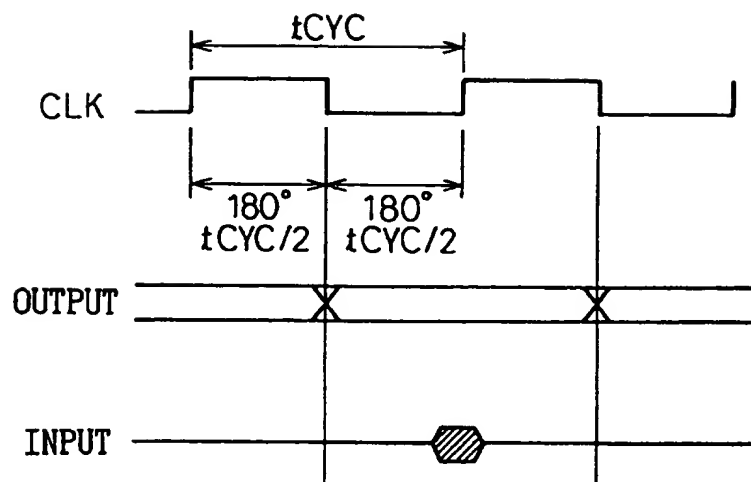


Fig. 83

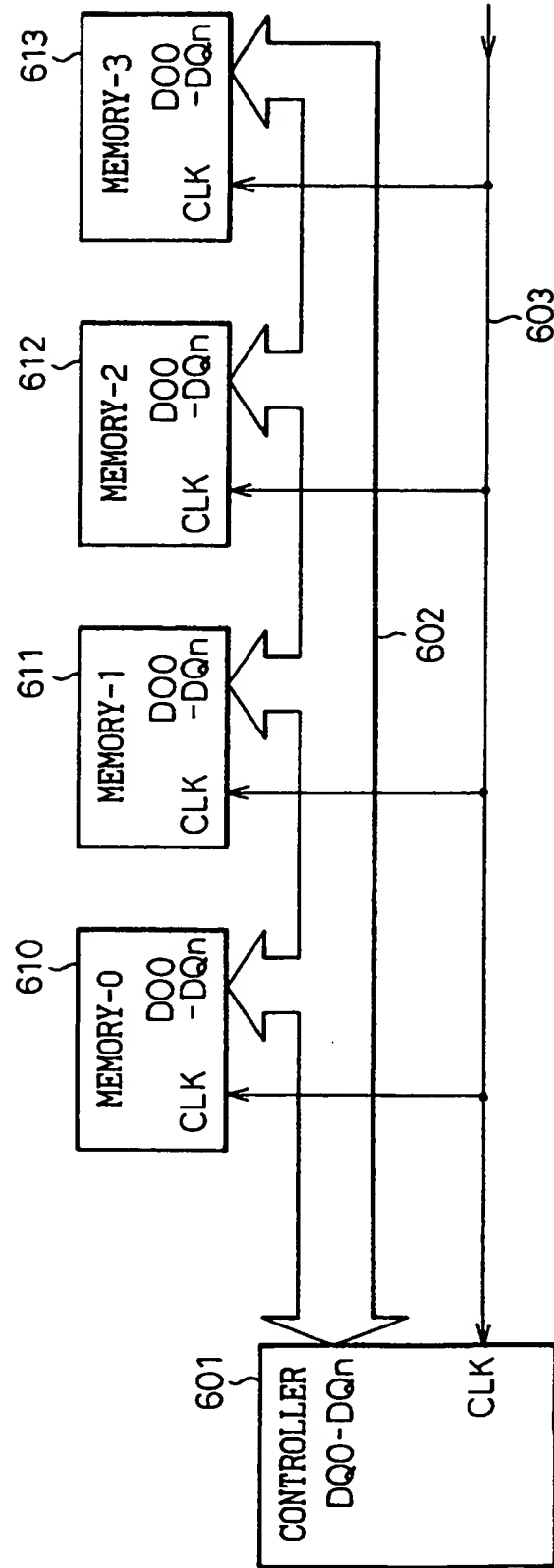


Fig. 84

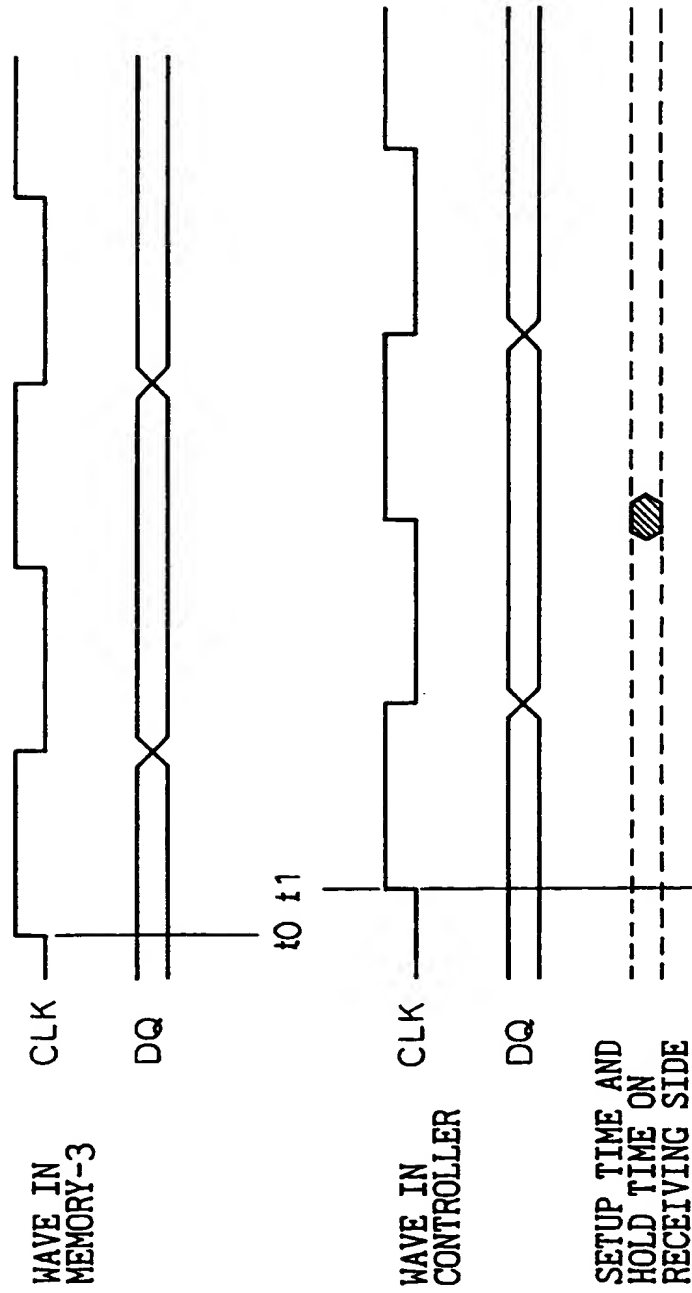


Fig.85

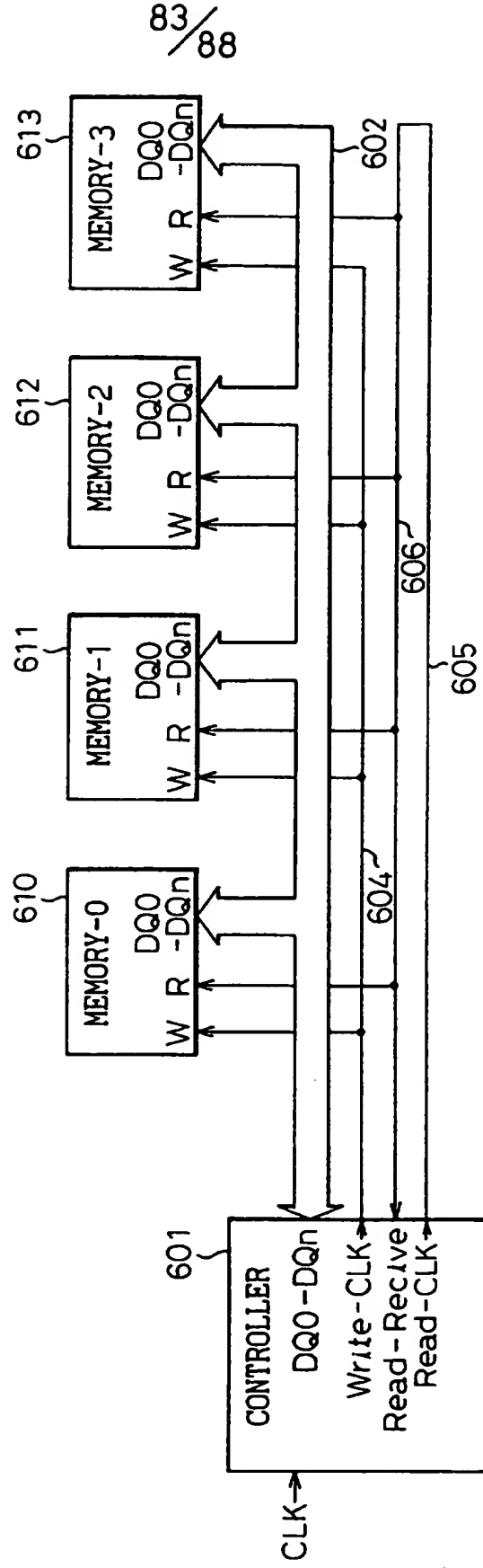


Fig. 86

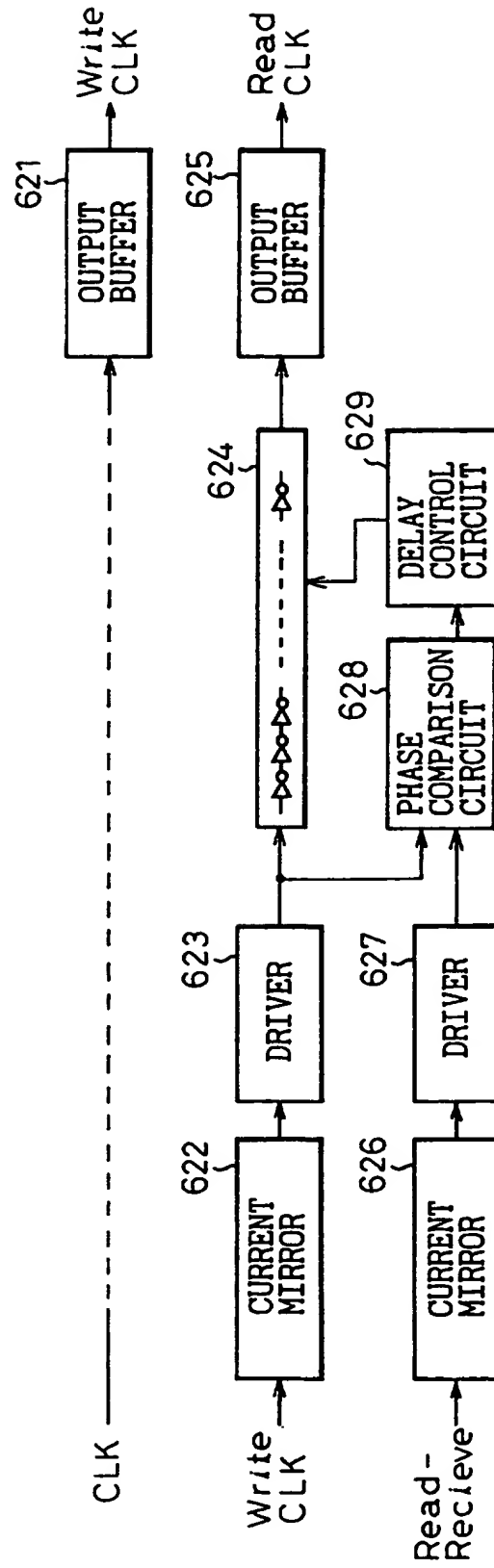


Fig. 87

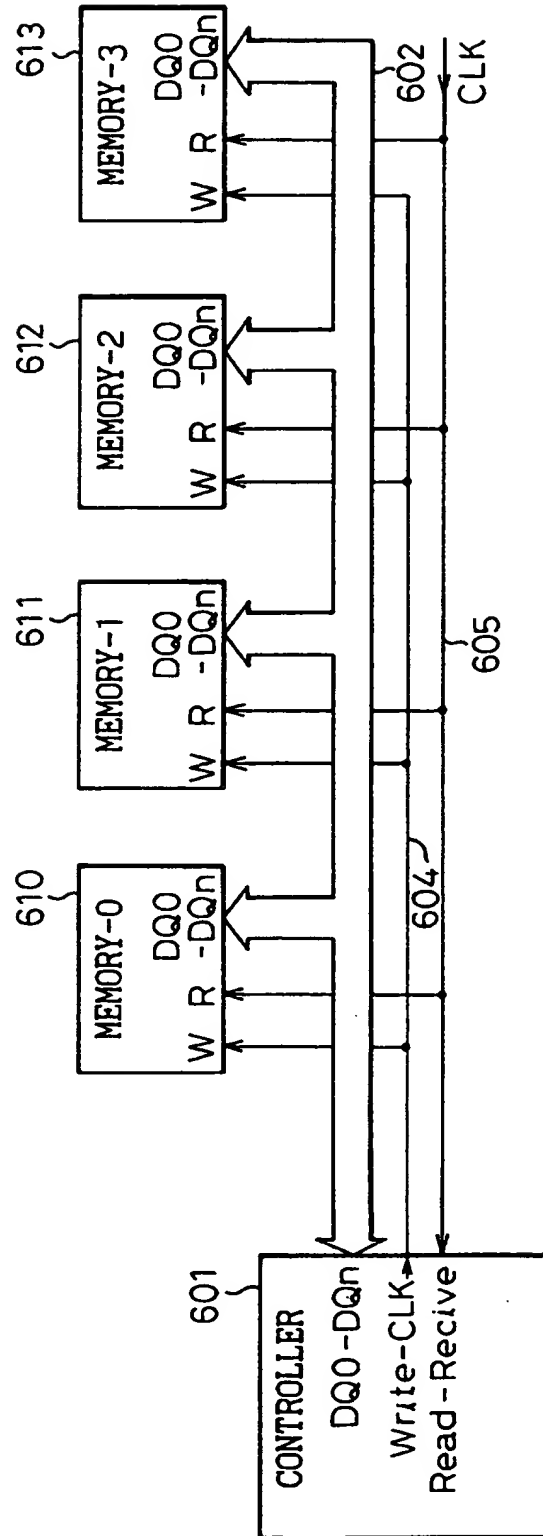


Fig. 88

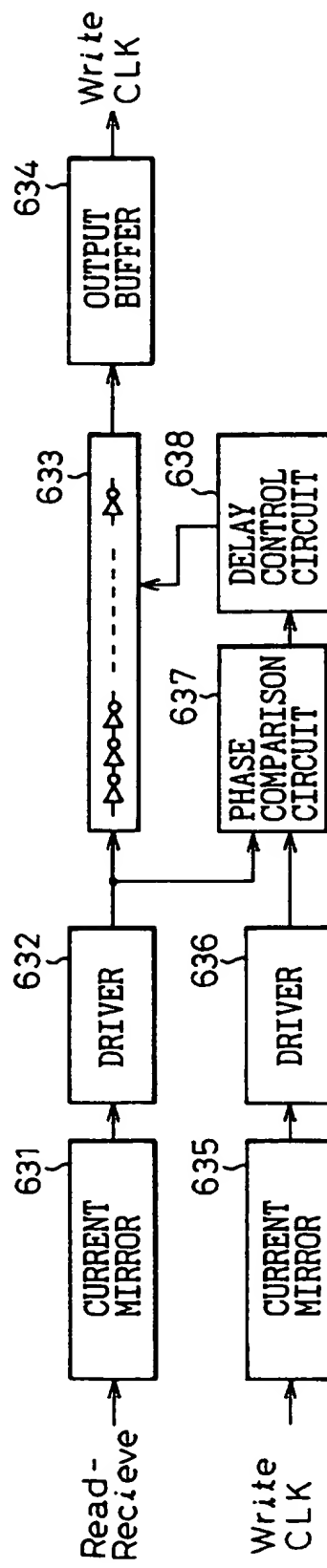


Fig. 89

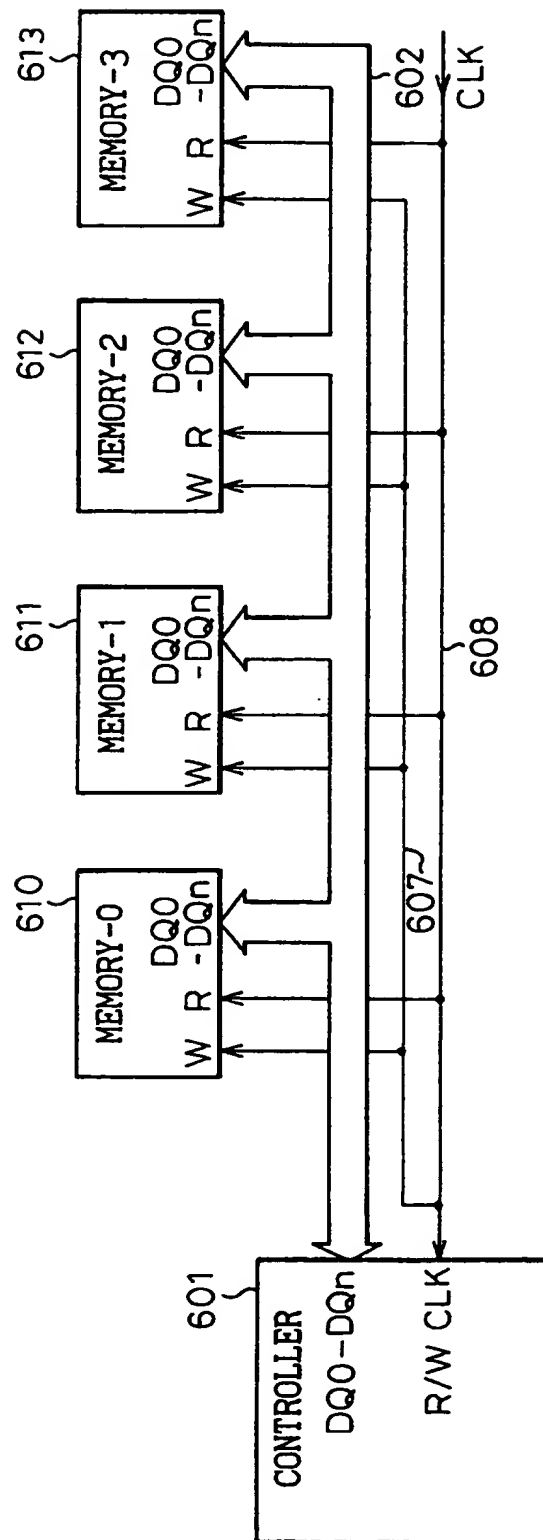
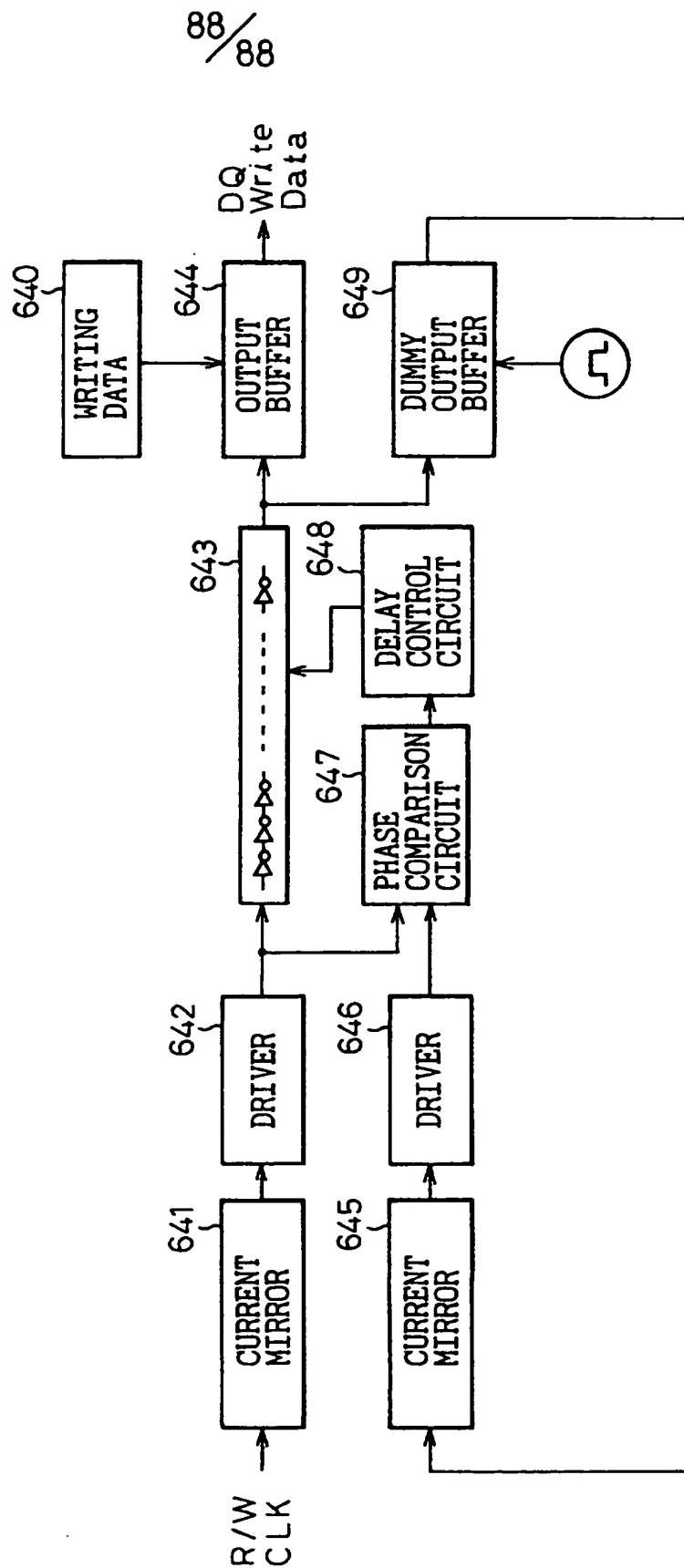


Fig. 90



SEMICONDUCTOR DEVICE, SEMICONDUCTOR SYSTEM AND
DIGITAL DELAY CIRCUIT

The present invention relates to a semiconductor device for outputting a signal with a given accurate phase held relative to an externally-input signal, a semiconductor system composed of such semiconductor devices, and a digital delay circuit employed in the semiconductor system. More particularly, this invention is concerned with a synchronous semiconductor memory from which a signal is output with a given phase held relative to an external clock despite a change in ambient temperature or a fluctuation in supply voltage.

Normally, a semiconductor integrated circuit (including a large scale integration (LSI)) accepts an external signal, and outputs an output signal after carrying out processing according to the input signal. Timing relative to an external input signal according to which an output signal is provided is therefore important. In a general-purpose LSI, the timing is usually determined as one of the specifications for the LSI. Taking a dynamic random access memory (DRAM) for instance, a maximum frequency of an address signal as well as the timing of outputting data relative to a transition edge of the address signal and a data setup time required for writing data are stipulated.

In recent years, there has been a requirement to increase the operating speed of interfaces in line with the increases in frequency of clocks used in a CPU within a computer system, or with increases in processing speeds of various other kinds of electronic circuits. For example, a CPU using a clock with a frequency of 100 MHz or higher has made its debut. However, the access rate and data transfer rate of DRAM widely adopted for main memory are lower than the frequency of the clock by one decade. Various novel DRAM architectures such as a synchronous DRAM (SDRAM) permitting a data transfer rate of 100 MHz or higher have been proposed to date.

The SDRAM inputs or outputs data synchronously with a high-frequency clock that is input externally, and includes a plurality of units capable of inputting or outputting a plurality of bits of data in parallel.

5 A method of interfacing an external unit at a high speed falls into a method of converting a plurality of bits of data into serial data and a method of pipelining internal operations and carrying out the operations of pipes in parallel.

10 In the SDRAM, internal operations and input or output of signals are carried out synchronously with a clock supplied externally. When this SDRAM is employed in a high-speed memory system, if the SDRAM is accessed continuously, a clock access time t_{AC} that is
15 a time interval between the leading edge of a clock and the output of data, and an output data retention time t_{OH} that is a time interval starting with the leading edge of the clock, during which data is retained, are significant. The times t_{AC} and t_{OH} are determined in
20 relation with the same path. When consideration is taken into a difference in characteristic of one SDRAM from another, and the temperature dependency and supply voltage-dependency of the SDRAM, the times t_{AC} and t_{OH} do not coincide with each other but differ from each
25 other to some extent. The time comparable to the difference is the time during which data is uncertain, i.e. the time during which it is uncertain what kind of data is output, the time is unusable by a memory system and is termed as a so-called dead band. It is
30 important to make the uncertain data time as short as possible.

To shorten the uncertain data time, the system should be designed such that differences in characteristic changes in temperature fluctuations in
35 supply voltage or the like have little, or no appreciable, effect on the output timing, so that data is always output with a given phase relative to an external clock. In other words, the clock access time

tAC should be constant, or vary as little as possible. For example, if it is preferable that output of data is carried out synchronously with the rise of an external clock CLK, the clock access time tAC should be zero all the time.

5 The necessity of providing an output signal synchronously with an externally-input signal has been described by taking a synchronous DRAM as an example. This is not limited to the synchronous DRAM but is true among many semiconductor devices. As far as the interior of a semiconductor device is concerned, various measures can be taken to enable the semiconductor device to carry out desired operations. For outputting the result of processing performed internally by a semiconductor device, the relationships of the semiconductor device with other semiconductor devices must be defined. It is important to stabilize the timing of the output. The present invention relates to an art for stabilizing the timing of output relative to an external clock in a semiconductor device.

10 A semiconductor device in accordance with a first aspect of the present invention comprises an input circuit for inputting an external input signal and outputting a reference signal an output circuit for receiving an output timing signal and outputting an output signal according to the timing of the output timing signal, and an output timing control circuit for controlling the output timing of an output signal sent from the output circuit so that the output signal exhibits a given phase relative to the external input signal, wherein the output timing control circuit includes a delay circuit for which a magnitude of a delay can be specified, and which delays a reference signal by the specified magnitude, and applies the resultant reference signal as an output timing signal to the output circuit, a phase comparison circuit for comparing the phase of the output timing signal with

the phase of the reference signal, and a delay control circuit for specifying the magnitude of a delay to be produced by the delay circuit according to the result of the comparison performed by the phase comparison circuit.

In certain preferred embodiments of the first aspect of the invention, the magnitude of a delay needed for adjusting timing by the output timing control circuit is variable, i.e. not fixed. For adjusting the magnitude of a delay so that a signal output from an actual circuit has a given phase relationship relative to an external clock (corresponding to the reference signal) output from the input circuit, the phase relationship of the output signal relative to the external clock can be retained accurately at a given value despite a difference in characteristic of one semiconductor device from another, a change in temperature, or a fluctuation in supply voltage.

The signal to be compared with the external clock is preferably delayed by the same magnitude as the magnitude of a delay produced by the actual circuit. To provide this function, a dummy input circuit can be included for producing the same magnitude of a delay as the input circuit and a dummy output circuit can be included for producing the same delay as the output circuit. For comparing phases, it is preferred that an output signal of the output circuit makes a state transition. During normal operation, the output circuit provides output data. The output data is a varying signal that may be at a high level or at low level. For comparing the phase of an output signal of the output circuit with the phase of the external clock during a normal operation, the phase comparison circuit may judge whether or not the output signal has made a state transition, the phases being compared generally only when the output signal has made a state transition. If the output signal makes no

state transition, the delay control circuit may give control so that the ongoing magnitude of a delay can be retained. Thus, if the output signal makes no state transition, the output signal can be fed back so that control is given until the output signal is in phase with the external clock.

In another preferred configuration, initialization is carried out before a normal operation starts. During the initialization, dummy data that makes a state transition at intervals of a given cycle is output. The phase of the dummy data is compared with that of the external clock. The dummy data is fed back so that control is given until the dummy data is in phase with the external clock. After the dummy data is in phase with the external clock, an adjusted magnitude of a delay is retained. The dummy data makes a state transition at intervals of a given cycle without fail. The phase comparison circuit can compare phases merely by judging in which direction the dummy data makes a state transition.

Using the dummy output circuit, a signal suitable for judging a phase which is independent of an output signal of the output circuit can be output all the time. This means that dummy data can always be output for feedback control. Moreover, if the dummy data is a signal that makes a state transition by taking time longer than the cycle of the clock, the power consumption of the circuit can be minimized.

Furthermore, a second output timing control circuit to be associated with the dummy output circuit may be included separately from the first output timing control circuit associated with the output circuit. During initialization, an output signal and dummy output signal are synchronized with the external clock, so that the output signal and the dummy output signal become synchronous with each other. Thereafter, the dummy output signal is fed back to the first output timing control circuit for the purpose of giving

control. With this configurations the dummy output circuit can be used to achieve adjustment even under the effect of a load connected to the actual output circuit.

5 Further aspects of the invention are exemplified by the attached claims.

For a better understanding of the invention, and to show how the same may be carried into effect, reference will now be made, by way of example, to the
10 accompanying drawings, in which:-

Fig. 1 is a block diagram showing the configuration of a synchronous DRAM (SDRAM);

Fig. 2 is a timing chart showing operations of the SDRAM;

15 Fig. 3 is a diagram showing operations of a pipelined SDRAM;

Fig. 4 is a diagram for explaining the timing of the SDRAM and a problem underlying a high-speed operation;

20 Figs. 5A and 5B are diagrams for explaining the phase relationship of an output relative to a clock in a prior art;

Fig. 6 is a diagram showing a configuration of a semiconductor device of a first aspect of the present
25 invention for synchronizing a timing signal to be applied to an output circuit with an external clock;

Fig. 7 is a diagram for explaining a problem underlying the basic configuration shown in Fig. 6;

30 Fig. 8 is a diagram showing the configuration of a semiconductor device in accordance with a modification of the configuration shown in Fig. 6;

Fig. 9 is a diagram showing the operations of an SDRAM of a first embodiment;

35 Fig. 10 is a diagram showing the configuration of the portion of an SDRAM of the first embodiment responsible for output timing control;

Figs. 11A to 11C are diagrams showing the circuitry and operations of a delay circuit in the

first embodiment;

Fig. 12 is a diagram showing the circuitry of a delay control circuit in the first embodiment;

5 Fig. 13 a timing chart showing the operations of the delay control circuit in the first embodiment;

Fig. 14 is a diagram showing the state transition of an output signal of the delay control circuit in the first embodiment;

10 Fig. 15 is a diagram showing another example of the delay control circuit;

Fig. 16 is a diagram showing the circuitry of a phase comparison unit of a phase comparison circuit in the first embodiment;

15 Figs. 17A to 17C are timing charts showing the operations of the phase comparator of the phase comparison circuit in the first embodiment;

Fig. 18 is a diagram showing the circuitry of an amplifier unit of the phase comparison circuit in the first embodiment;

20 Fig. 19 is a timing chart showing the operations of a JK flip-flop included in the amplifier unit of the phase comparison circuit in the first embodiment;

25 Fig. 20 is a timing chart showing a counting-up operation performed by the amplifier unit of the phase comparison circuit in the first embodiment;

Fig. 21 is a timing chart showing a count retaining operation performed by the amplifier unit of the phase comparison circuit in the first embodiment;

30 Fig. 22 is a timing chart showing a counting-down operation performed by the amplifier circuit of the phase comparison circuit in the first embodiment;

Fig. 23 is a diagram showing the circuitry of an output circuit in the first embodiment;

35 Fig. 24 is a diagram showing the circuitry of a dummy output circuit in the first embodiment;

Figs. 25A and 25B are timing charts showing the operations of the dummy output circuit in the first embodiment;

Fig. 26 is a diagram showing the circuitry of a dummy output circuit in a second embodiment;

Fig. 27 is a diagram showing the circuitry of a dummy output circuit in a third embodiment;

5 Fig. 28 is a diagram showing the circuitry of a dummy output circuit in a fourth embodiment;

Fig. 29 is a diagram showing the configuration of the portion of an SDRAM of a fifth embodiment responsible for output timing control;

10 Fig. 30 is a diagram showing the circuitry of a phase comparison circuit in the SDRAM of the fifth embodiment;

Fig. 31 is a diagram showing the circuitry of a dummy output circuit in the fifth embodiment;

15 Fig. 32 is a timing chart showing the operations performed in the fifth embodiment;

Fig. 33 is a diagram for explaining occurrence of an error deriving from a difference in characteristic of a dummy path from a normal path;

20 Fig. 34 is a diagram showing the configuration of the portion of an SDRAM of a sixth embodiment responsible for output timing control;

Fig. 35 is a diagram showing the circuitry of a dummy output circuit in the sixth embodiment;

25 Fig. 36 is a timing chart showing the operations of the dummy output circuit in the sixth embodiment;

Fig. 37 is a diagram showing the circuitry of an output circuit in the sixth embodiment;

30 Fig. 38 is a timing chart showing the operations of the output circuit in the sixth embodiment;

Fig. 39 is a diagram showing the circuitry of a switching circuit in the sixth embodiment;

35 Fig. 40 is a diagram showing the configuration of the portion of an SDRAM of a seventh embodiment responsible for output timing control;

Fig. 41 is a diagram showing examples of the circuitry of a delay circuit in a receiving-side semiconductor device of the seventh embodiment and of

the configuration of a delay control circuit therein;

Fig. 42 is a diagram showing the configuration or a half phase-shift circuit in the seventh embodiment;

5 Fig. 43 is a diagram showing the circuitry of a phase comparison circuit in the seventh embodiment;

Fig. 44 is a diagram for explaining a phase judging operation in the seventh embodiment;

Fig. 45 is a diagram for explaining a phase judging operation in the seventh embodiment;

10 Fig. 46 is a diagram for explaining a phase judging operation in the seventh embodiment;

Fig. 47 is a truth table concerning a phase judging operation in the seventh embodiment;

15 Fig. 48 is a diagram showing the configuration of the portion of an SDRAM of an eighth embodiment responsible for output timing control;

Fig. 49 is a diagram showing the configuration of the portion of an SDRAM of a ninth embodiment responsible for output timing control;

20 Fig. 50 is a diagram showing the circuitry of a phase comparison circuit in the ninth embodiment;

Figs. 51A and 51B are diagrams for explaining a phase judging operation in the ninth embodiment;

25 Fig. 52 is a truth table concerning a phase judging operation in the ninth embodiment;

Fig. 53 is a diagram showing the configuration of a delay control circuit in the ninth embodiment;

30 Fig. 54 is a diagram showing the configuration of the portion of an SDRAM of a tenth embodiment responsible for output timing control;

Fig. 55 is a diagram for explaining a phase judging operation in the tenth embodiment;

35 Fig. 56 is a diagram showing the configuration of the portion of an SDRAM of an eleventh embodiment responsible for output timing control;

Fig. 57 is a diagram showing the configuration of an output timing control circuit of a second aspect of the present invention;

Fig. 58 is a diagram showing the operations of the output timing control circuit shown in Fig. 57;

Fig. 59 is a diagram for explaining the operations of the output timing control circuit shown in Fig. 57;

5 Fig. 60 is a diagram showing an example of the circuitry of an input circuit;

Figs. 61A and 61B are diagrams showing the operations of the input circuit to be performed when the amplitude of a clock is different;

10 Fig. 62 is a diagram for explaining a problem underlying the output timing control circuit shown in Fig. 57;

Fig. 63 is a diagram for explaining a problem underlying the output timing control circuit shown in Fig. 57;

15 Fig. 64 is a diagram for explaining a problem underlying the output timing control circuit shown in Fig. 57;

Fig. 65 is a diagram showing the basic configuration of an output timing control circuit in a twelfth embodiment;

20 Fig. 66 is a diagram showing the operations of the output timing control circuit in the twelfth embodiment;

25 Fig. 67 is a diagram showing the operations of the output timing control circuit in the twelfth embodiment;

Fig. 68A and 68B are diagrams showing a dummy input waveform conversion circuit in the twelfth embodiment;

30 Fig. 69 is a diagram showing the operations of the dummy input waveform conversion circuit in the twelfth embodiment;

Fig. 70 is a diagram showing the circuitry of an ESD circuit designed for improving a withstanding voltage against static electricity which is interposed between an electrode pad and input circuit;

Fig. 71 is a diagram showing a variant of the

dummy input waveform conversion circuit in the twelfth embodiment in which a delay having the same magnitude as a delay occurring in the ESD circuit occurs;

5 Figs. 72A and 72B are diagrams showing a dummy input waveform conversion circuit in a thirteenth embodiment of the present invention;

Fig. 73 is a diagram showing the operations of the dummy input waveform conversion circuit in the thirteenth embodiment;

10 Fig. 74 is a diagram showing a configuration of a dummy input waveform conversion circuit in a fourteenth embodiment;

Fig. 75 is a circuit diagram of the dummy input waveform conversion circuit in the fourteenth embodiment;

15 Fig. 76 is a diagram showing the operations of the dummy input waveform conversion circuit in the fourteenth embodiment;

20 Fig. 77 is a diagram showing the operations of the dummy input waveform conversion circuit in the fourteenth embodiment;

Fig. 78 is a diagram showing the operations of the dummy input waveform conversion circuit in the fourteenth embodiment;

25 Fig. 79 is a diagram showing the operations of the dummy input waveform conversion circuit in the fourteenth embodiment;

30 Fig. 80 is a diagram showing the arrangement of a clock input circuit, output timing control circuit, clock distribution circuit, and output circuit in an SDRAM of a fifteenth embodiment;

Fig. 81 is a diagram showing output timing in a semiconductor device of a prior art;

35 Fig. 82 is a diagram showing output timing in a semiconductor device embodying the present invention;

Fig. 83 is a diagram showing the arrangement of devices and the signal lines in a semiconductor system of a sixteenth embodiment;

Fig. 84 is a timing chart showing the waveforms of signals employed in the sixteenth embodiment;

Fig. 85 is a diagram showing the arrangement of devices and the signal lines in a semiconductor system of a seventeenth embodiment;

Fig. 86 is a diagram showing a clock timing adjustment system in a controller in the seventeenth embodiment;

Fig. 87 is a diagram showing the arrangement of devices and the signal lines in a semiconductor system of an eighteenth embodiment;

Fig. 88 is a diagram showing a clock timing adjustment system in a controller in the eighteenth embodiment;

Fig. 89 is a diagram showing the arrangement of devices and the signal lines in a semiconductor system of a nineteenth embodiment; and

Fig. 90 is a diagram showing a clock timing adjustment system in a controller in the nineteenth embodiment.

Prior to the description of the embodiments of the present invention, output timing in a synchronous DRAM of a prior art will be described for a better understanding of the differences between the present invention and prior art. The embodiments in which the present invention is adapted to a synchronous DRAM will be described later. The description will proceed by taking a DRAM having a pipelined architecture as an example. However, the present invention is not limited to this kind of DRAM. Moreover, the present invention is not limited to the synchronous DRAM but can apply to any semiconductor integrated circuit for providing an output signal synchronously with an externally-input signal.

Fig. 1 is a block diagram showing the configuration of a synchronous DRAM (SDRAM) having a storage capacity

of 16 megabytes, including two memory banks, and handling data of 8 bits long, which is an example of a pipelined SDRAM.

5 The SDRAM comprises core memories 108a and 108b that
are general-purpose DRAMs, a clock buffer 101, a command
decoder 102, an address buffer/register and bank address
selector 103 (hereinafter, simply, an address buffer), an
I/O data buffer/register 104, control signal latches 105a
and 105b, a mode register 106, and column address
10 counters 107a and 107b. The actions of terminals /CS,
/RAS, /CAS, and /WE are different from those in the prior
art. The terminals are combined in order to input various
commands, whereby an operation mode is determined. The
various commands are interpreted by the command decoder
15 and used to control the circuits according to an
operation mode. Signals /CS, /RAS, /CAS, and /WE are also
input to the control signal latches 105a and 105b, and
have the states thereof latched until a subsequent
command is input.

20 An address signal is amplified by the address buffer
103 and used as a load address of each bank. The address
signal is also used as an initial value by the column
address counters 107a and 107b. Signals read from the
core memories 108a and 108b are amplified by the I/O data
25 buffer/register 104 and output synchronously with the
rise of an external clock CLK that is input externally.
The same operation is performed on an input. That is to
say, input data is written in the I/O data
buffer/register 104.

30 Fig. 2 is a diagram showing the read operation
timing in a general SDRAM.

 The external clock CLK is a signal supplied from a
system in which the SDRAM is employed. Synchronously with
the rise of the clock CLK, various commands, an address
35 signal, and input data are fetched and output data is
provided.

 Assuming that data is read from the SDRAM, an active

(ACT) command that is a combination of command signals (/CS, /RAS, /CAS, and /WE) is input through a command terminal, and a row address signal is input through an address terminal. With the input of the command and row address, the SDRAM becomes active, selects a word line corresponding to the row address, outputs cell information lying on the word line over a bit line, and amplifies the information using a sense amplifier.

When the operating time (t_{RCD}) of a unit handling a row address has elapsed, a read command and column address are input. Data provided by a sense amplifier selected according to the column address is output over a data bus, amplified by a data bus amplifier, further amplified by an output buffer, and output through an output terminal (DQ). This series of operations is identical to that in a general-purpose DRAM. In the case of the SDRAM, the circuits for handling a column address are pipelined. Read data is output continuously during each cycle. A data transfer cycle is therefore equal to the cycle of the external clock.

There are three kinds of access times in the SDRAM. The access times are defined with reference to the rise time instant of the clock CLK. In Fig. 2, the time t_{RAC} is a row address access time, the time t_{CAC} is a column address access time, and the time t_{AC} is a clock access time. When the SDRAM is employed in a high-speed memory system, the time t_{RAC} that is a time interval between the instant at which a command is input and the instant at which the first data is obtained, and the time t_{CAC} are important. For improving the data transfer rate, the clock access time t_{AC} is significant.

Fig. 3 is a block diagram for explaining pipelining in the SDRAM by taking a configuration including three stages of pipes as an example.

Processing circuits for handling a column address in the SDRAM are divided into a plurality of stages according to the flow of processing. The division stages

shall be referred to as pipes. In the clock buffer 101, an internal clock to be supplied to each pipe is produced using the clock CLK. Each pipe is controlled according to a supplied internal clock. A switch for controlling the timing of transmitting a signal is placed on a border between pipes. The switches are also controlled with the internal clock produced by the clock buffer 101.

In this example, in pipe-1, a column address buffer 116 amplifies an address signal, and sends a resultant address signal to a column decoder 118. Information provided by a sense amplifier 117, which is concerned with an address selected by the column decoder 118, is output over a data bus. Information on the data bus is amplified by a data bus amplifier 119. Pipe-2 includes only a data bus control circuit 120. Pipe-3 includes only an I/O buffer 104. If the circuits in the pipes complete their operations within the time corresponding to the cycle of a clock, data can be sent out successively like being relayed by turning on or off the switches each located between pipes synchronously with the clock CLK. Consequently, the processing in the pipes is carried out in parallel. Data is output successively synchronously with the clock CLK through an output terminal.

Fig. 4 is a diagram for explaining a problem occurring when the known SDRAM explained in conjunction with Figs. 1 to 3 is employed in a high-speed memory system.

In Fig. 4, there are shown a clock access time t_{AC} starting with the leading edge of a system clock CLK, an output data retention time t_{OH} defined after the end of a preceding cycle and before the start of a succeeding cycle. The times t_{AC} and t_{OH} are determined in relation to the same path. Because of a difference in characteristic of one SDRAM from another, and the temperature-dependency and supply voltage-dependency thereof, the times t_{AC} and t_{OH} do not coincide with each other but differ from each other to some extent. The time

equivalent to the difference is the time during which data is uncertain, the time during which it is unknown what kind of data is output, the time unusable by a memory system, or a so-called dead band. In other words, the time t_{OH} can be said to be a delay time occurring along a path when the highest operating speed is attained due to the conditions such as a voltage and temperature, and the time t_{AC} can be said to be a delay time occurring along the path when the lowest operating speed is attained. If there is no difference between the times t_{AC} and t_{OH} , the time during which data is uncertain is shortened. It is therefore preferable that the difference between the times t_{AC} and t_{OH} is as small as possible. It is noted that the dead band includes a delay time occurring over a wiring on a printed-circuit board and a difference of the dead band occurring in one SDRAM from that occurring in another, though the delay time and difference are not illustrated.

For fetching (receiving) an output of the SDRAM, the memory system requires a setup time (t_{SI}) and hold time (t_{HI}). These times must be defined within the time during which data output from the memory is certain. The time during which data is certain is expressed as $t_{CLK} + t_{OH} - t_{AC}$ in the illustration.

Thinking of, for example, a system operating at 100 MHz, the cycle of a clock (t_{CLK}) is 10 ns, the memory access time (t_{AC}) is 6 ns, and the hold time is 3 ns. The time usable by the system is 7 ns. The setup time and hold time required by a receiving-side logic in the system using a normal input circuit come to 3 ns ($t_{SI} + t_{HI}$) in total. The remaining 4 ns is a system tolerance time usable for absorbing a delay of a signal occurring on a printed-circuit board and a difference in data rate of one terminal DQ from another. Thinking of a signal propagation time required on a printed-circuit board, the value of 4 ns is very small. If the operating speed of the system is made higher, a more severe timing

adjustment is required. From this viewpoint, it is essential to make the time, during which data is uncertain, shown in Fig. 4 as short as possible.

5 For shortening the data uncertain time, despite a difference in characteristic, a change in temperature, and a fluctuation in supply voltage, data should always be output with a given phase held relative to the external clock CLK, that is, the clock access time tAC should be constant all the time. When, for example, it is
10 preferred that output of data is carried out synchronously with the rise of the external clock CLK, the clock access time tAC should remain zero.

By taking the synchronous DRAM for instance, the necessity of providing an output signal synchronously
15 with an externally-input signal has been described. This is not limited to the synchronous DRAM but is true among many semiconductor devices. For the interior of a semiconductor device, various measures can be taken so that the semiconductor device can operate desirably.
20 However, for outputting the result of processing performed inside a semiconductor device, the relationships with other semiconductor devices must be defined. It is important to stabilize output timing.

Figs. 5A and 5B are diagrams for explaining the
25 phase relationship of an output relative to a clock in a prior art. Fig. 5A shows a signal path along which a signal propagates after an external signal CLK is input through a clock terminal 11, and is then output through a data DQ terminal 12. Fig. 5B is a timing chart showing
30 operation timing in the configuration shown in Fig. 5A. For example, an input terminal 110 through which a clock CLK is input, a clock buffer 101, a line from the clock buffer 101 to an I/O data buffer 104, the I/O data buffer 104, and an output terminal 112 through which data DQ is
35 output, which are shown in Fig. 3, are comparable to the clock terminal 11, an input circuit 13, a line 16, an output circuit 14, and the data terminal 12 which are

shown in Fig. 5A. As far as this path is concerned, the external signal CLK input through the clock terminal 11 is delayed by the input circuit 13 and line 16 and then input as a signal clkiz to the output circuit 14. The output circuit 14 carries out an output operation according to the signal clkiz. An output DQ developing at the data terminal is output while lagging behind the signal clkiz. In other words, the output DQ is output while lagging behind the external signal CLX as illustrated. As mentioned above, the time lag affects the times tAC and tOH, varies depending on a difference of a semiconductor device from another occurring in the process of manufacturing, and on the ambient conditions including a temperature and supply voltage. This becomes an obstacle to a higher operating speed.

Fig. 6 is a diagram showing the configuration of a semiconductor device in accordance with a first aspect of the present invention.

The semiconductor device shown in Figure 6 comprises an input circuit 13 for inputting an external input signal and outputting a reference signal, an output circuit 14 for receiving an output timing signal and outputting an output signal according to the timing of the output timing signal, and an output timing control circuit 20 for controlling the timing of outputting an output signal sent from the output circuit 14 so that the output signal exhibits a given phase relative to an external input signal. The timing control circuit 20 includes a delay circuit 21 enabling specification of a magnitude of a delay, delaying a reference signal by the specified magnitude, and applying a resultant signal as an output timing signal to the output circuit 14, a phase comparison circuit 22 for comparing the phase of the output timing signal with the phase of the reference signal, and a delay control circuit 23 for specifying the magnitude of a delay to be produced by the delay circuit 21

according to the result of the comparison performed by the phase comparison circuit 22.

The magnitude of a delay used to adjust timing by the output timing control circuit 20 is not fixed, but rather the magnitude of a delay is adjustable so that a signal provided by an actual circuit can be set to provide a given phase relationship relative to an external clock (comparable to the reference signal) output from the input circuit 13. Even if there is a difference in characteristic of the semiconductor device from another, a change in temperature, and a fluctuation in supply voltage, the phase relationship of the output signal relative to the external clock can be retained accurately at a given value.

What is compared with the external clock should be a signal delayed by a magnitude equivalent to the magnitude of a delay occurring in an actual circuit. The external clock is input to the input circuit 13 in the semiconductor device and subjected to amplification and other processing. The external clock that can be compared is therefore an external clock output from the input circuit, and has a phase difference comparable to a delay occurring in the input circuit 13 relative to an actual external clock. It is therefore preferred that a dummy input circuit 24 for producing the same magnitude of a delay as the input circuit 13 is included, and a signal made by passing an output timing signal through the dummy input circuit 24 is compared with an external clock output from the input circuit 13 in order to cancel the magnitude of a delay caused by the input circuit 13.

In the configuration shown in Fig. 6, an output of the delay circuit 21 is input to the dummy input circuit 24. An object-of-comparison signal to be compared with an external clock by the phase comparison circuit 22 does not therefore undergo a delay occurring in the output circuit 14. A phase relationship to be controlled is determined in consideration of correction

for the delay. The delay occurring in the output circuit 14 is larger than a delay occurring in any other component. When there is a difference in characteristic of the semiconductor device from another, a change in temperature, and a fluctuation in supply voltage, there arises a problem that a variation of the magnitude of a delay occurring in the output circuit 14 is too large to be ignored.

Fig. 7 is a diagram for explaining this problem. Assume that control is given so that a signal is output synchronously with the leading edge of an external clock CLK. An output timing signal supplied from the delay circuit 21 to the output circuit 14 and used to define the timing of outputting a signal from the output circuit 14 rises at a time instant succeeding by a given time the leading edge of the clock CLK in anticipation of a delay occurring in the output circuit 14. If the magnitude of the delay occurring in the output circuit 14 has a predicted value, an output makes a state transition synchronously with the leading edge of the clock CLK. However, because of the aforesaid factors, when the magnitude of a delay occurring in the output circuit 14 varies, the output timing of a signal from the output circuit deviates from the leading edge of the clock CLK by a time corresponding to the variation. When this kind of variation is predicted, a margin must be preserved accordingly. This makes it hard to realize a higher operating speed.

For solving this kind of problem, an output signal of the output circuit 14 can be input to the dummy input circuit 24 and compared in phase with the external clock. For comparing phases, the output signal of the output

circuit 14 is required to make a state transition. During a normal operation, the output circuit 14 outputs output data. The output data is a varying signal that may be at a high level or at low level. For comparing the phase of an output signal of the output circuit 14 with the phase of the external clock during a normal operation, the phase comparison circuit 22 judges whether the output signal has made a state transition. Only when the output signal has made a state transition, are phases compared. When the output signal has not made a state transition, the delay control circuit 23 gives control so that the ongoing magnitude of a delay can be retained. When the output signal has not made a state transition, the output signal is fed back so that control is given according to the result of comparison performed by the phase comparison circuit 22 until the output signal is phased with the external clock.

In another configuration, initialization is carried out before a normal operation is started. During the initialization, dummy data that makes a state transition at intervals of a given cycle is output. The dummy data is compared in phase with the external clock, and fed back so that control is given until the dummy data is phased with the external clock. After the dummy data is phased with the external clock, the adjusted magnitude of a delay is retained. Since the dummy data makes a state transition at intervals of the given cycle without fail, the phase comparison circuit 22 should merely judge in which direction the dummy data has made a state transition so as to compare phases.

As shown in Fig. 8, a dummy output circuit having the same characteristic as the output circuit 14 may be included so that an output signal of the dummy output circuit can be compared in phase with an external clock. A semiconductor device shown in Fig. 8 is different from the one having the configuration shown in Fig. 6 in the points that a dummy output circuit 35 is included, that

an output timing signal output from the delay circuit 31 is input to the dummy output circuit 35, that the dummy output circuit 35 outputs a dummy output signal according to the output timing signal and sends the dummy output
5 signal to the phase comparison circuit 32 via the dummy input circuit 35, and that the dummy output signal is compared with an external clock sent from the input circuit.

In the configuration shown in Fig. 8, the dummy
10 output circuit can always output a signal suitable for judging a phase which is independent of an output signal of the output circuit. The aforesaid dummy data can therefore be output all the time for the purpose of feedback control.

15 Embodiments in which the present invention is adapted to a synchronous DRAM (SDRAM) will be described below. The SDRAMs of the embodiments have the overall configuration shown in Fig. 1. Fig. 9 is a diagram showing signal paths along which a read operation is
20 carried out in the SDRAMs of the embodiments.

As is apparent from the comparison of Fig. 9 with Fig. 3, the SDRAMs of the embodiments have substantially the same configuration as the SDRAM of the prior art. However, the configuration of the clock buffer 101 is
25 different. In the SDRAMs of the embodiments, the clock buffer 101 includes an internal clock generation circuit 121 and output timing control circuit 122. The internal clock generation circuit 121 is similar to the clock buffer 101 included in the SDRAM of the prior art,
30 generates an internal clock from an external clock CLK, and supplies the internal clock to pipe-1 and pipe-2. The output timing control circuit 122 has the basic configuration shown in Fig. 8, and controls the output timing of data supplied from the output circuit 14 so
35 that the data exhibits a given phase relative to the external clock CLK.

Fig. 10 is a diagram showing the configuration of

the output timing control circuit 122 in the first embodiment, wherein the terminal 11 through which the external clock CLK is input, the output circuit 14, and the data output terminal 12 are also shown.

5 As shown in Fig. 10, the output timing control circuit in the first embodiment comprises an input circuit circuit 13 for receiving an external clock CLK input through the external clock input terminal 11, a delay locked loop (DLL) for delaying the clock CLK input from the input circuit 13 and generating an output clock that defines the output timing of data from the output circuit 14, a dummy input circuit 34 having the same circuitry as the input circuit 13, a dummy output circuit 37 having the circuitry equivalent to that of the output circuit 14, a dummy signal line 36 linking the DLL 40 and dummy output circuit 47 which is equivalent to the signal line 16 linking the DLL 40 and output circuit 14, and a dummy output load 38 having a load equivalent to a load predicted to be connected to the data output terminal 12.

15 The input circuit 13 includes an electrostatic defense circuit (ESD) 131, a current mirror 132 for amplifying a clock CLK, a latch 133, a clock control circuit 134, and an one-Nth frequency divider 135. The input circuit 13 is the same as a widely-adopted external clock input circuit except the one-Nth frequency divider 135. The one-Nth frequency divider 135 will be described later. Herein, the detailed description will be omitted. The dummy input circuit 35 includes, like the input circuit 13, a dummy ESD 341, a dummy current mirror 342, a dummy latch 343, and a dummy clock control circuit 344. The circuits have the same circuitries as those of the input circuit 13. The magnitude of a delay of a signal occurring in the dummy input circuit is the same as that occurring in the input circuit.

20 The DLL 40 includes a delay circuit 41a for delaying a signal input from the clock control circuit 134 by a specified magnitude, a dummy delay circuit 41b for

delaying a signal input from the one-Nth frequency divider 135 by a specified magnitude, a phase comparison circuit 42 for comparing a signal sent from the one-Nth frequency divider 13 with a signal sent from the dummy clock control circuit 344, a delay control circuit 43 for specifying the magnitudes of delays to be produced by the delay circuit 41a and dummy delay circuit 41b according to the result of the comparison performed by the phase comparison circuit 42.

Figs. 11A to 11C are diagrams showing the circuitry of the delay circuit 41a and dummy delay circuit 41b, and the waveforms of operating waves. Fig. 11A shows the circuitry of a delay circuit for handling one bit, Fig. 11C shows the circuitry in which the delay circuit for handling one bit is connected on a plurality of stages, and explains the operations of the connected delay circuits, and Fig. 11B is a timing chart showing the operations of the delay circuit for handling one bit.

As shown in Fig. 11A, a delay circuit for handling one bit is composed of two NAND circuits 401 and 402, and an inverter 403. The operations of the delay circuit for handling one bit will be described in conjunction with Fig. 11B. An input ϕE is an activation signal. When the input ϕE goes high, the delay circuit operates. In Fig. 11B, the input ϕE is high, and reception is enabled. A signal IN is an input signal to be supplied to the delay circuit for handling one bit. A signal ϕN is a signal supplied from a right-hand delay circuit out of the plurality of stages of delay circuits. A signal OUT is an output signal sent from the delay circuit for handling one bit. Waves 4a-1 and 4a-2 are waves developing at associated internal terminals in the circuitry shown in Fig. 11A. The output signal OUT serves as a signal ϕN to be supplied to a left-hand delay circuit.

When the signal ϕN is low, the signal OUT remains low. When the signal ϕN is high and the signal ϕE is low, the signal OUT is high. When the signal ϕN is high and

the signal ϕE is high, if the input signal IN is low, the signal OUT goes high. If the signal IN is high, the signal OUT goes low. In Fig. 11B, the signal ϕE is high and the signal ϕN is high. When the signal IN rises or makes a low-to-high transition, the input signal IN is reversed while passing through the NAND gates 401 and 402 and the inverter 403. Consequently, the output OUT is provided.

Fig. 11C shows an example in which a plurality of stages of delay circuits each handling one bit, each of which has the circuitry shown in Fig. 11A, are cascaded to constitute an actual delay circuit. Only three stages are shown. However, in practice, a plurality of stages of delay circuits are cascaded. A signal line over which the activation signal ϕE is transmitted is provided for each circuit element. That is to say, there are a plurality of signal lines $\phi E-1$, $\phi E-2$, $\phi E-3$. The signals are controlled by the delay control circuit 43.

In Fig. 11C, a delay circuit for handling one bit located in the center is activated, and the signal $\phi E-2$ is driven high. In this case, when the input signal IN makes a low-to-high transition, since the signals $\phi E-1$ and $\phi E-3$ applied to the left-hand delay circuit for handling one bit and to the right-hand delay circuit for handling one bit are low, the input signal IN is cut off by NAND circuits 401-1 and 401-3 respectively. The signal $\phi E-2$ applied to the activated center delay circuit for handling one bit is high. The input signal IN therefore passes through a NAND circuit 401-2. Since an output OUT of the right-hand delay circuit for handling one bit is high, the input signal IN passes through a NAND circuit 402-2 and is transmitted as a low-level signal to an output terminal OUT. As mentioned above, when the output OUT of the right-hand delay circuit, that is, the signal ϕN is low, the output OUT of the center delay circuit is always low. The low-level signal is transmitted to the NAND circuit and inverter of the left-hand delay circuit

for handling one bit, and fetched as a final signal OUT.

The input signal IN is thus transmitted via an activated delay circuit for handling one bit while being routed along a folded path, and finally fetched as a signal OUT. Depending on the activation signal ϕE for a delay circuit which is driven high, the magnitude of a delay can be controlled. The magnitude of a delay to be produced by a delay circuit for handling one bit is determined with a total signal propagation time required for a signal to propagate the NAND circuits and inverter. The time is regarded as a unit delay time of the DLL. A total delay time is calculated by multiplying the magnitude of a delay to be produced by a delay circuit for handling one bit by the number of stages through which a signal is passed.

Fig. 12 is a diagram showing the circuitry of a delay control circuit, and Fig. 13 is a timing chart showing the operations thereof. As shown in Fig. 12, the delay control circuit has a delay control circuit 430-2 for handling one bit, which is encircled with a dashed line, connected by the number of the plurality of stages of delay circuits. An output of each stage is the activation signal ϕE to be applied to each stage of a delay circuit.

The delay control circuit 430-2 for handling one bit has transistors 435-2, 437-2, 438-2, and 439-2 connected in series with one another to both terminals of a flip-flop composed of a NAND circuit 432-2 and inverter 433-2, and further includes a NOR circuit 431-2. The gate of the transistor 438-2 is connected to a terminal 5a-2 of a delay control circuit of a preceding stage. The gate of the transistor 439-2 is connected to a terminal 5a-5 of a delay control circuit of a succeeding stage. Thus, signals provided by the preceding and succeeding stages are received. A set signals ϕSE and ϕSO used for a counting-up operation are applied alternately to every other delay control circuit. A reset signals ϕRE and ϕRO

used for a counting-down operation are applied alternately to every other delay control circuit. As illustrated, in the delay control circuit 430-2 for handling one bit located in the center, the transistor 435-2 is connected on a signal line over which the signal ϕSO is transmitted and the transistor 437-2 is connected on a signal line over which the signal ϕRO is transmitted. The equivalent transistors of the delay control circuits on both sides of the delay control circuit 430-2 are connected on the signal lines ϕSE and ϕRE . Signals developing at a terminal 5a-1 of the left-hand delay control circuit and at a terminal 5a-4 of the center delay control circuit are input to the NOR circuit 431-2. A signal ϕR is a signal for resetting a delay control circuit. After the power supply is turned on, the signal ϕR is driven low temporarily. Thereafter, the signal ϕR is fixed high.

Fig. 13 is a diagram showing the operations of the delay control circuit shown in Fig. 12.

First, the signal ϕR is driven low temporarily. The potentials at the terminals 5a-1, 5a-3, and 5a-5 are driven high, and the potentials at the terminals 5a-2, 5a-4, and 5a-6 are reset to low. For a counting-up operation, the counting-up signals ϕSE and ϕSO go high and low alternately repeatedly. When the signal ϕSE makes a low-to-high transition, the terminal 5a-1 is grounded to have the potential thereof driven low, and the potential at the terminal 5a-2 is driven high. When the potential at the terminal 5a-2 is driven high, the signal $\phi E-1$ makes a high-to-low transition. This state is latched by the flip-flop. Even when the signal ϕSE goes back to low, the output $\phi E-1$ remains low. When the potential at the terminal 5a-1 is driven low, the output $\phi E-2$ makes a low-to-high transition. Since the potential at the terminal 5a-2 is driven high, the transistor 438-2 is turned on. When the signal ϕSO makes a low-to-high transition, the terminal 51-3 is grounded to have the

potential thereof driven low, and the potential at the terminal 5a-4 is driven high. When the potential at the terminal 5a-4 is driven high, the signal $\phi E-2$ makes a high-to-low transition. Since this state is latched by the flip-flop, even if the signal ϕSO goes back to low, the output $\phi E-2$ remains low. When the potential at the terminal 5a-3 is driven low, the output $\phi E-3$ makes a low-to-high transition. In the drawing, only one of the pulses ϕSE and ϕSO is output. Since many stages of delay control circuits are connected, when the signals ϕSE and ϕSO go high and low alternately repeatedly, a stage whose output ϕE goes high is shifted sequentially rightward. When it is judged from the result of comparison performed by the phase comparison circuit 42 that the magnitude of a delay should be increased, the pulses ϕSE and ϕSO are input alternately.

If a state in which the counting-up signals ϕSE and ϕSO and the counting-down signals ϕRE and ϕRO are not output, that is, remain low is retained, a stage whose output ϕE goes high is fixed. When it is judged from the result of comparison performed by the phase comparison circuit 42 that the magnitude of a delay should be retained intact, the pulses ϕSE , ϕSO , ϕRE , and ϕRO are not input.

For a counting-down operation, the pulses ϕRE and ϕRO are input alternately. On the contrary to the counting-up operation, a stage whose output ϕE goes high is shifted sequentially leftward.

As mentioned above, in the delay control circuit shown in Fig. 12, a stage whose output ϕE goes high can be shifted one by one with input of pulses. When the delay circuit shown in Fig. 11C is controlled using outputs ϕE , the magnitude of a delay can be increased or decreased in units of one unit value.

The delay circuit and delay control circuit will be explained in more detail. In the first embodiment, the circuit shown in Fig. 11C is used as the delay circuit

and a delay control circuit like the one shown in Fig. 12 is used to control the delay circuit. For realizing a circuit capable of changing the magnitude of a delay stepwise in units of a unit value, a delay line having a plurality of signal paths connected in series with one another is generally used so that the magnitude of a delay can be specified by selectively outputting a signal over part of the plurality of signal paths. As far as this kind of delay line is concerned, it should be avoided that any one of the signal paths is not selected even in a transient state in which one signal path over which a signal is output is shifted to an adjoining one in order to change the magnitude of a delay. The delay control circuit for controlling the delay line is therefore required to output a signal specifying any one of the signal paths even in the transient state. Each stage of the delay control circuit shown in Fig. 12 outputs two complementary signals. That is to say, an output of the NAND circuit and an output of the inverter are mutually complementary. The stages ending with a certain stage output complementary signals of one states, and the subsequent stages output reversed complementary signals. The stage from which the reversed complementary signals are first output is shifted sequentially. In other words, the delay control circuit shown in Fig. 12 operates in the same manner as a shift register. In the circuitry shown in Fig. 12, a NOR circuit on each stage of the shift register calculates the NOR of one of complementary signals output from one stage and the other one of complementary signals output from an adjoining stage, and an output of the NOR circuit is placed on a selected signal line of each stage shown in Fig. 11C. In a MOS transistor, a fall or a transition from a logical "high" state to a logical "low" state is quicker than a rise or a transition from the logical "low" state to the logical "high" state. In the circuitry shown in Fig. 12, an output of a NOR circuit whose inputs represent the

logical "low" state indicates a selected position of the delay line. One of the inputs of the NOR circuit changes to the logical "high" state slowly. The logical "high" state of an input of a NOR circuit for indicating the next selected position of the delay line changes to the logical "low" state more quickly. Before an output of a NOR circuit that has indicated a selected position previously stops indicating the selected position, an output of another NOR circuit that indicates the next selected position starts indicating the selected position. Thus, the state in which no NOR circuit indicates a selected position can be avoided.

Fig. 14 is a diagram showing a change of outputs taking place when a NOR circuit indicating a selected position is shifted sequentially in the delay control circuit shown in Fig. 12. As illustrated, before a previous selector signal falls, the next selector signal rises. The problem that a path of the delay line is not selected will not arise.

Another conceivable delay control circuit is, for example, such that AND circuits having the nodes 5a-2 and 5a-3 and the nodes 5a-4 and 5a-5 in the circuitry shown in Fig. 12 as input terminals thereof are included, and the outputs of the AND circuits are provided as the signals $\phi E-1$ and $\phi E-2$. This circuit has a problem that the outputs of all the AND circuits are low in a transient state.

Fig. 15 is a diagram showing an example of circuitry in which AND circuits (combinations of NAND circuits and inverters) are substituted for the NOR circuits in the circuitry shown in Fig. 12. In this circuitry, inputs to an AND circuit are one of complementary signals output from one stage and the other one of complementary signals output from a stage succeeding an adjoining stage. Owing to this circuitry, outputs of two adjoining AND circuits are driven high at the same time, that is, indicate a selected position. Two AND circuits indicating a selected

position are shifted one by one to adjoining circuits. One of the outputs of the two AND circuits therefore remains high. The state in which neither of the AND circuits indicates a selected position can be avoided.

5 When the outputs of two AND circuits are high, two paths in the delay line shown in Fig. 11C are activated simultaneously. The waveform of a signal is therefore deformed slightly. However, the deformation can be ignored as long as the magnitude of a delay on one stage

10 is small.

The phase comparison circuit 42 is composed of two circuits; a phase comparator and amplifier unit. Fig. 16 is a diagram showing the circuitry of the phase comparator, Figs. 17A to 17C are timing charts showing

15 the operations of the phase comparator, and Fig. 19 is a timing chart showing the operations of the amplifier unit.

In Fig. 16, there are shown an output signal ϕ_{out} and external clock ϕ_{ext} which are compared by the phase comparison circuit 42. The phase of the output ϕ_{out} is judged with reference to that of the clock ϕ_{ext} . Output signals ϕ_a to ϕ_e are supplied to the amplifier unit. As shown in Fig. 16, the phase comparator consists of

20 flip-flops 421 and 422 each composed of two NAND circuits, latches 425 and 426 for latching the states of the flip-flops, a circuit 424 for generating an activation signal for the latches, and a delay circuit

25 423 for providing the permissible value of the phase of the external clock ϕ_{ext} and producing one delay.

Fig. 17A shows a situation in which the object-of-comparison signal ϕ_{out} is leading the reference-of-comparison signal ϕ_{ext} and the signal ϕ_{out} makes a low-to-high transition earlier than the signal ϕ_{ext} . When both the signals ϕ_{out} and ϕ_{ext} are low, the

30 potentials at the terminals 6a-2, 6a-3, 6a-4, and 6a-5 of the flip-flops 421 and 422 are high. When the output ϕ_{out} makes a low-to-high transition, the terminals 6a-2 and

35

6a-4 make a high-to-low transition. Thereafter, the signal ϕ_{ext} makes a low-to-high transition. The time corresponding to one delay later, a terminal 6a-1 makes a low-to-high transition. However, since the potentials
5 across the flip-flops are already finalized, no transition occurs. The terminal 6a-2 remains low, the terminal 6a-3 remains high, the terminal 6a-4 remains low, and the terminal 6a-5 remains high. When the signal ϕ_{ext} makes a low-to-high transition, the output signal ϕ_a
10 of the circuit 424 makes a low-to-high transition. A high-level pulse is applied temporarily to a terminal 6a-6. Since the terminal 6a-6 is connected to NAND circuits of the latches 425 and 436, the NAND circuits are activated temporarily. The potentials across the
15 flip-flops 421 and 422 are therefore fetched into the latches 425 and 426. Finally, the output signal ϕ_b goes high, the output signal ϕ_c goes low, the output signal ϕ_d goes high, and the output ϕ_e goes low.

Next, Fig. 17B shows a situation in which the
20 object-of-comparison signal ϕ_{out} is substantially in phase with the reference-of-comparison signal ϕ_{ext} and the signal ϕ_{out} makes a low-to-high transition substantially simultaneously with the signal ϕ_{ext} . The signal ϕ_{out} makes a low-to-high transition within a time
25 interval between the rise time instant of the signal ϕ_{out} and the rise time instant of the potential at the terminal 6a-1. In this case, when the signal ϕ_{ext} makes a low-to-high transition, the potential at the terminal 6a-3 of the flip-flop 421 makes a low-to-high transition.
30 However, the potential at the terminal 6a-1 of the flip-flop 422 remains low and the potential at the terminal 6a-4 makes a high-to-low transition. Thereafter, the potential at the terminal 6a-1 makes a high-to-low transition. However, since the state of the flip-flop 422
35 is already finalized, no transition occurs. Thereafter, the terminal 6a-6 is driven high temporarily, the state is latched by the latch. Finally, the output signal ϕ_b

goes low, the output signal ϕ_c goes high, the output signal ϕ_d goes high, and the output signal ϕ_e goes low.

Fig. 17C shows a situation in which the object-of-comparison signal ϕ_{out} lags behind the reference-of-comparison signal ϕ_{ext} and the signal ϕ_{out} makes a low-to-high transition later than the signal ϕ_{ext} . In this case, the signal ϕ_{ext} causes the flip-flops 421 and 422 to make a state transition. The potentials at the terminals 6a-3 and 6a-5 make high-to-low transitions. Finally, the output signal ϕ_b goes low, the output signal ϕ_c goes high, the output signal ϕ_d goes low, and the output signal ϕ_e goes high.

Thus, it becomes possible to detect using the rise time instant of the signal ϕ_{ext} as a reference whether the signal ϕ_{out} goes high earlier, nearly simultaneously, or later. The result of the detection is latched by setting the output signals ϕ_b , ϕ_c , ϕ_d , and ϕ_e to specific values. Based on the values, it is determined whether either a counting-up or counting-down operation should be carried out in order to select a stage of the delay control circuit.

Fig. 18 is a diagram showing the circuitry of the amplifier unit of the phase comparison circuit 42.

The amplifier unit consists of two blocks; a JK flip-flop 427 and an amplifier 428 composed of NAND circuits and inverters. The JK flip-flop 427 inputs a signal ϕ_a from the phase comparator shown in Fig. 16. Depending on whether the signal ϕ_a is low or high, the potentials at terminals 7a-9 and 7a-11 go low and high alternately and repeatedly. The amplifier 428 amplifies and outputs an output signal of the JK flip-flop 427 according to the signals ϕ_b to ϕ_d .

To begin with, the operations of the JK flip-flop 427 will be described with reference to the timing chart of Fig. 19. When the signal ϕ_a makes a high-to-low transition at a time instant T1, the potential at a node 7a-10 makes a low-to-high transition. With the state

transition of the potential at a node 7a-1, the potentials at terminals 7a-1, 7a-6, and 7a-7 make a state transition. However, since the signal ϕ_a is low, the potential at a node 7a-8 does not make a state transition. Consequently, an output 7a-9 makes no state transition. Only an output 7a-11 makes a low-to-high transition. Thereafter, when the signal ϕ_a makes a low-to-high transition at a time instant T2, the potential at a node 7a-8 makes a high-to-low transition opposite to that at the time instant T1. The potential at the node 7a-10 makes no state transition because the potential at a terminal 7a-7 makes no state transition. The output 7a-9 makes a low-to-high transition, while the output 7a-11 makes no state transition. Thus, the outputs 7a-9 and 7a-11 of the JK flip-flop 427 go high and low alternately and repeatedly in responsive to the state transition of the signal ϕ_a .

Next, the operations of the amplifier 428 will be described with reference to Figs. 20 to 22. Fig. 20 shows a situation in which the object-of-comparison signal ϕ_{out} makes a low-to-high transition earlier than the rise of the reference-of-comparison signal ϕ_{ext} . The input signal ϕ_b sent from the phase comparator goes high, the input signal ϕ_c goes low, the input signal ϕ_d goes high, and the input signal ϕ_e goes low. Consequently, the potential at a terminal 7a-12 is fixed to high and the potential at a terminal 7a-13 is fixed to low. The signals ϕ_{SO} and ϕ_{SE} make a state transition according to the state of the JK flip-flop. However, the signals ϕ_{RO} and ϕ_{RE} make no state transition because the potential at the terminal 7a-13 is low.

Fig. 21 shows a situation in which the object-of-comparison signal ϕ_{out} and reference-of-comparison signal ϕ_{ext} make a low-to-high transition nearly simultaneously. The signal input from the phase comparator, ϕ_b , is low, the input signal ϕ_c is high, the input signal ϕ_d is high, and the input signal

ϕ_e is low. Consequently, the potentials at the terminals 7a-12 and 7a-13 are fixed to low. The output of the JK flip-flop will not affect an output of the amplifier, and the signals ϕ_{SO} , ϕ_{SE} , ϕ_{RO} , and ϕ_{RE} remain low.

5 Fig. 22 shows a situation in which the object-of-comparison signal ϕ_{out} makes a low-to-high transition later than the rise of the reference-of-comparison signal ϕ_{ext} . In this case, the signal input from the phase comparator, ϕ_b , is low, the
10 input signal ϕ_c is high, the input signal ϕ_d is low, and the input signal ϕ_e is high. Consequently, the potential at the terminal 7a-12 is fixed to low and the potential at the terminal 7a-13 is fixed to high. The signals ϕ_{RO} and ϕ_{RE} make a state transition according to the state of
15 the JK flip-flop. The signals ϕ_{SO} and ϕ_{SE} make no state transition because the potential at the terminal 7a-13 is low.

 Fig. 23 is a diagram showing the circuitry of the output circuit 14.

20 In Fig. 23, signals Data1 and Data2 are associated with stored data items that are read from a cell array 115 and output via the sense amplifier 117, data bus amplifier 119, and data bus control circuit 120. When the output data is high, the signals Data1 and Data2 are low.
25 When the output data is low, the signals Data1 and Data2 are high. The output data may be neither high nor low but may exhibit a high impedance. In this case, the data bus control circuit 120 causes the signal Data1 to go high and the signal Data2 to go low. A signal ϕ_{oe} is an output
30 signal of the delay circuit 40. According to the signal ϕ_{oe} , the output timing of the output circuit is controlled. When the signal ϕ_{oe} goes high, information represented by the signal Data1 or Data2 is output through the data output terminal 14. For outputting a
35 high-level signal through the data output terminal 14, the signal ϕ_{oe} makes a low-to-high transition, the potential at a node 8a-1 goes low, the potential at a

node 8a-2 goes high, and transfer gates are turned on. The signals Data1 and Data2 are therefore transmitted to nodes 8a-3 and 8a-6. Consequently, the potential at a terminal 8a-5 is driven low, and the potential at a terminal 8a-8 is driven high. A p-channel transistor for output is turned on, while an n-channel transistor is turned off. A high-level output is developed at the data output terminal 14. When the signal ϕ_{oe} is driven low, the transfer gates are turned off. The previous output state is retained.

Fig. 24 is a diagram showing the circuitry of the dummy output circuit 37 as well as a capacitive device 38 serving as a dummy output load. Figs. 25A and 25B are diagrams showing the operations of the dummy output circuit 37 and indicating the relationship of an internal clock with a dummy output signal developing at a terminal 8a-9. Fig. 25A shows the operations performed without the one-Nth frequency divider 135. Fig. 25B shows the operations performed with a frequency division ratio set to 4.

As apparent from the output circuit 14 shown in Fig. 23, the dummy output circuit 37 has circuitry analogous to that of the output circuit 14. Unlike the output circuit 14, the dummy output circuit need not output data. Signals input through transfer gates are therefore fixed to low. For outputting data, the dummy output 8a-9 goes high without fail. A clock Int-CLK is an internal clock that is used to open or close transfer gates for controlling the output timing of the dummy output circuit and is input to one of the terminals of a NAND circuit including a feedback inverter. As shown in Fig. 25A, when the clock int-CLK goes high, the dummy output 8a-9 is driven high through the same operations as the output circuit 14. When the clock Int-CLK goes back to low, the transfer gates are closed and the potentials at nodes 8a-3 and 8a-6 are driven high. The dummy output 8a-9 is driven low.

Fig. 25A shows waveforms attained without the one-Nth frequency divider 135. A clock int-CLK has the same cycle as an external clock CLK. In Fig. 25A, the capacitance of the dummy output load 38 is very small. In practice, a load having a capacitance corresponding to the capacitance of a line on which the output circuit of the SDRAM is connected or the capacitance of a device to be driven must be included. The rise and fall times of the dummy output 8a-9 become vary long. The operations of the dummy output circuit are restricted by the rise and fall times of the dummy output 8a-9. When the cycle of the external clock CLK gets shorter, the dummy output circuit may not operate.

In this embodiment, as shown in Fig. 10, the one-Nth frequency divider 135 is included. The one-Nth divider 135 calculates a submultiple of the frequency of an output of the latch 133, and generates a clock Int-CLK shown in Fig. 25B in relation to the external clock. The clock Int-CLK goes high during one cycle of the external clock with every four external clock pulses. Using the clock Int-CLK for the dummy output circuit, a problem, that the frequency at which the dummy output circuit can operate is restricted by the rise and fall times of a dummy output, can be avoided.

When the one-Nth frequency divider 135 is included, the dummy output 8a-9 has a waveform shown in Fig. 25B. The phase comparison circuit 42 compares the phase of the dummy output with that of the external clock once per four cycles of the external clock. The power consumption is reduced accordingly.

The components of the SDRAM of the first embodiment have been described so far. In the SDRAM of the first embodiment, for specifying the magnitude of a delay to be produced by the delay circuit 41a or 41b, a reset is carried out to specify an initial position. Thereafter, a selected position is shifted stage by stage on the basis of the result of comparison of phases in order to attain

a given phase relationship. Some time is therefore required after the magnitude of a delay is reset at the time of turning on the power supply until an optimal magnitude of a delay is specified. When the SDRAM of the first embodiment is employed, therefore, a given initialization period must be preserved after the power supply is turned on so that an external clock can be applied for a given number of pulses.

In the SDRAM of the first embodiment, the internal processing system is divided into a plurality of pipes that successively carry out processing. The pipes operate in parallel. The above description has referred to the output operations alone. The input operations are also pipelined. Input or output of data can therefore be carried out synchronously with a high-frequency external clock. The transfer rate improves drastically.

As mentioned above, in the SDRAM of the first embodiment, the output timing of data is controlled so that the data exhibits a given phase relative to the external clock. Even if the temperature or supply voltage changes during the use of the SDRAM, data is always output synchronously with the given phase of the external clock. Moreover, dummy circuits equivalent to the input circuit and output circuit are included. In consideration of variations of the magnitudes of delays occurring in the input and output circuits, control is given so that the given phase can be attained relative to the external clock. Thus, a phase relationship can be controlled very accurately. This results in a further improved transfer rate.

In an existing semiconductor device, the ratings of an output signal and other signals are stipulated to be compatible with any other semiconductor device. An SDRAM or a semiconductor device to be used in combination with the SDRAM generally adopts either of two standards "Low Voltage Transistor Transistor Logic (LVTTL)" and "Series Stub Termination Logic (SSTL)." In some SDRAMs, an output

circuit capable of outputting data according to either of the two standards is included, and a selector signal is applied externally in order to set the output circuit to either of the two standards. If an output circuit can be
5 switched to either of modes so that an output can be provided according to either of different standards, the characteristic of the output circuit changes with the switching. As already described, since a variation of the magnitude of a delay occurring in an output circuit is so
10 large that it is important to include a dummy output circuit equivalent to the output circuit and to use a signal passing through the dummy output circuit for phase comparison. If the characteristic of the output circuit changes with switching, the characteristic of the dummy
15 output circuit must be changed accordingly. The second to fourth embodiments are embodiments of SDRAMs in which the characteristic of an output circuit can be changed by switching.

Fig. 26 is a diagram showing the circuitry of a
20 dummy output circuit in an SDRAM of the second embodiment. The SDRAM of the second embodiment has the same components as that of the first embodiment except for the dummy output circuit.

As apparent from comparison with Fig. 24, a
25 difference of the dummy output circuit in the SDRAM of the second embodiment from that in the first embodiment lies in that two drivers each composed of an n-channel transistor and p-channel transistor are included; that is, a driver 371 conformable to the LVTTTL and a driver
30 372 conformable to the SSTL, and that a selector signal ctt2 for instructing which driver should be selected is input to NAND circuits and NOR circuits connected to the gates of the n-channel transistors and p-channel
transistors. The sizes of the p-channel transistor and
35 n-channel transistor constituting the LVTTTL-conformable driver 371 are different from those of the p-channel transistor and n-channel transistor constituting the

SSTL-conformable driver 372. The sizes of transistors constituting each driver are defined appropriately according to an output mode. The selector signal ctt2 is driven high in order to indicate the SSTL standard, and driven low in order to indicate the LVTTL standard. The selector signal ctt2 is generated by judging whether a voltage applied externally to a reference power terminal is equal to or larger than a given value Vref. In the circuitry shown in Fig. 26, when the selector signal ctt2 is high, signals to be applied to the gates of the n-channel transistor and p-channel transistor of the LVTTL-conformable driver 371 make a state transition according to the potentials at nodes 8a-4 and 8a-7. Consequently, a dummy signal is output. Low-level and high-level signals are applied to the gates of the n-channel transistor and p-channel transistor of the SSTL-conformable driver 371, and both the n-channel transistor and p-channel transistor of the SSTL-conformable driver 371 are turned off to enter a so-called high-impedance state. By contrast, when the selector signal ctt2 is low, the LVTTL-conformable driver 371 enters a high-impedance state and the SSTL-conformable driver 371 outputs a dummy signal.

Thus, in the SDRAM of the second embodiment, the characteristic of the dummy output circuit is switched.

Fig. 27 is a diagram showing the circuitry of a dummy output circuit in an SDRAM of the third embodiment. The SDRAM of the third embodiment has the same components as the SDRAM of the first embodiment except the dummy output circuit.

A current flowing into an output transistor in a driver is different between the SSTL and LVTTL standards. The SSTL standard requires that a larger current should flow. The current flowing into the output transistor varies depending on the dimensions of the transistor. A transistor used to meet the SSTL standard must therefore be larger in size. In general, a transistor employed in a

driver is large in size. For including two drivers conformable to the SSTL and LVTTL respectively as shown in Fig. 26, a large area is needed. The dummy output circuit in the SDRAM of the third embodiment includes an
5 LVTTL-conformable driver 373, and a driver 374 capable of causing a current conformable to the SSTL standard to flow when used in combination with the LVTTL-conformable driver 373. When the LVTTL standard is instructed, the driver 374 is brought to a high-impedance state. When the
10 SSTL standard is instructed, both the LVTTL driver 373 and driver 374 operate so that a current conformable to the SSTL standard can flow.

The SSTL and LVTTL standards each stipulate an output load. An SDRAM of the fourth embodiment is an
15 SDRAM in which dummy output loads can be switched.

Fig. 28 is a diagram showing the circuitry of a dummy output circuit in the SDRAM of the fourth embodiment. The SDRAM of the fourth embodiment has the same components as the SDRAM of the third embodiment
20 except the dummy output loads.

As shown in Fig. 28, the dummy output circuit in the SDRAM of the fourth embodiment has two dummy output loads; an SSTL-conformable load 377 and LVTTL-conformable load 378. Either of the loads can be selectively
25 connected to a dummy output terminal 8a-24 according to a selector signal cttZ. A capacitive device having a capacitance of 30 pF is used as the SSTL-conformable load 377, and a capacitive device having a capacitance of 50 pF is used as the LVTTL-conformable load. Furthermore,
30 when the SSTL-conformable load 377 is selected, a termination resistor 379 having one terminal thereof connected to a power supply VccQ is connected to the dummy output terminal 8a-24.

In the first to fourth embodiments, the dummy output
35 circuit outputs data that rises or makes a low-to-high transition. The phase of the leading edge of the data relative to an external clock is detected. However, a

variation in the magnitude of a delay occurring in an output circuit is different between data that rises to make a low-to-high transition and data that falls to make a high-to-low transition. In the configurations of the first to fourth embodiments, there is a difference in phase relative to the external clock between the rising data and falling data. In general, the circuitry like the ones shown in Figs. 26 to 28 in which an n-channel transistor and p-channel transistor are connected in series between a power supply terminal and ground and either of the transistors is turned on according to data to be output is adopted for a driver in an output circuit. In this kind of driver, the driving abilities of the n-channel transistor and p-channel transistor may be unbalanced because of a difference in conditions for manufacturing between the n-channel transistor and p-channel transistor. This leads to the difference in phase. The fifth embodiment attempts to solve this problem.

Fig. 29 is a diagram showing the configuration of an output timing control circuit in an SDRAM of the fifth embodiment.

As apparent from comparison between Figs. 10 and 29, a difference of the SDRAM of the fifth embodiment from that of the first embodiment lies in a point that two delay circuits and two dummy delay circuits are included so that the phases of rising data and falling data can be adjusted independently. The difference from the first embodiment will be described below.

A first delay circuit 41a-H is a delay circuit for adjusting the output timing of rising data, and a second delay circuit 41a-L is a delay circuit for adjusting the output timing of falling data. A clock CLK output from the clock control circuit 134 is input to both the delay circuits. An output of the first delay circuit 41a-H is input to the output circuit 14 and used as a timing signal for outputting high-level data. An output of the

second delay circuit 41a-L is input to the output circuit 14 and used as a timing signal for outputting low-level data. Likewise, a first dummy delay circuit 41b-H is a dummy delay circuit for adjusting the output timing of rising dummy data, and a second dummy delay circuit 41b-L is a dummy delay circuit for adjusting the output timing of falling dummy data. A clock Int-CLK output from the one-Nth frequency divider 135 is input to both the dummy delay circuits. An output of the first dummy delay circuit 41b-H is input to the dummy output circuit 37 over a dummy signal line 36-H and used as a timing signal for outputting high-level dummy data. An output of the second dummy delay circuit 41b-L is input to the dummy output circuit 37 over a dummy signal line 36-L and used as a timing signal for outputting low-level dummy data. The delay circuits have the same circuitry.

A delay control circuit is composed of two delay control circuits 43-H and 43-L having the circuitry shown in Fig. 11C. An output of the delay control circuit 43-H is used to specify the magnitude of a delay to be produced by the first delay circuit 41a-H and first dummy delay circuit 41b-H. An output of the delay control circuit 43-L is used to specify the magnitude of a delay to be produced by the second delay circuit 41a-L and second dummy delay circuit 41b-L.

Fig. 30 is a diagram showing the circuitry of a phase comparison circuit in the fifth embodiment. As apparent from comparison with Figs. 16 and 18, a difference from the first embodiment lies in a point that a switching circuit 412 for causing a signal ϕ_{ddq} to go high in response to a signal, data, is included as a stage preceding a comparator of the phase comparison circuit, and in a point that two amplifiers are included; an amplifier 414 for outputting a high-level signal and an amplifier 415 for outputting a low-level signal.

In the switching circuit 412, for example, when the signal, data, is high, the signal ϕ_{ddq} makes a

low-to-high transition. This enables output of a high-level signal. Since the signal, data, is high, a transfer gate 416 is turned on. This causes the signal ϕ_{ddq} to input as a signal ϕ_{out} to a phase comparator 413.

5 On the contrary, when the signal, data, is low, a transfer gate 417 is turned on. A signal whose polarity is opposite to that of the signal ϕ_{ddq} is input as a signal ϕ_{out} to the phase comparator 413. The input ϕ_{out} of the phase comparator 413 is a signal always making a
10 low-to-high transition irrespective of the input signal. The phase comparator 413 has the same circuitry as that shown in Fig. 16.

The two amplifiers 414 and 415 have the same circuitry as that shown in Fig. 18. A difference lies in
15 a point that a NAND circuit that inputs signals ϕ_b to ϕ_e is formed as a circuit capable of inputting three signals and is controlled with the signal data. When the signal, data, is high, the amplifier 414 for outputting a high-level signal is activated to operate. When the
20 signal, data, is low, the amplifier 415 for outputting a low-level signal is activated to operate. The operations of the circuit elements of the amplifiers are identical to those of the circuit shown in Fig. 18.

Fig. 31 is a diagram showing the circuitry of the
25 dummy output circuit 37 in the fifth embodiment.

Two activation signals ϕ_{doeH} and ϕ_{doeL} that are timing signals output from the first and second dummy delay circuits 41b-H and 41b-L are input to the dummy output circuit 37. The signal ϕ_{doeH} is an activation
30 signal used to output a high-level signal, while the signal ϕ_{doeL} is an activation signal used to output a low-level signal. Which of the activation signals should be used is specified with the signal, data, and a signal /data.

35 Assuming that the signal, data, is high and the signal /data is low, the signal ϕ_{doeH} is validated. A switching signal for switching terminals 10-1 and 10-2 is

output so that upper transfer gates in Fig. 31 operate. On the contrary, when the signal, data, is low and the signal /data is high, the signal doeL is validated. A switching signal for switching terminals 10-10 and 10-11 is output so that lower transfer gates in Fig. 31 operate. Once data is output to the dummy output circuit, the data is latched and held by the latch. Even if the validated activation signal is driven low, data is retained until the next activation signal is input.

10 The output circuit 14 has the same circuitry as that shown in Fig. 27 except that timing signals output from the first and second delay circuits 41a-H and 41a-L are input on behalf of the activation signals ϕ_{doeH} and ϕ_{doeL} .

15 Fig. 32 is a waveform diagram showing the operations of the components in the fifth embodiment. The upper part of the drawing is concerned with a high-level output, while the lower part thereof is concerned with a low-level output.

20 For providing a high-level output, the external clock CLK makes a low-to-high transition and is amplified by the input circuit 13. A signal $\phi_{1/N}$ is a signal having passed through the frequency divider 135 and input to the dummy delay circuits 41b-H and 41b-L. A signal ϕ_{doeH} is a
25 signal having passed through the dummy delay circuit 41b-H and serves as an activation signal to be input to the dummy output circuit 37. With the activation signal, the dummy output circuit 37 operates to output a dummy output 10-9. The dummy output 10-9 is input to the dummy
30 input circuit 34 and serves as an input signal ϕ_{out} of the phase comparison circuit 42. The phase comparison circuit compares the leading edge of the clock CLK that is an encircled part (a) of Fig. 32 with the leading edge of the input signal ϕ_{out} that is another encircled part
35 (b) of Fig. 32.

For providing a low-level output, the operations performed until the signal $\phi_{1/N}$ is output are identical

to the above operations. A signal ϕ_{doeL} is a signal having passed through the dummy delay circuit 41b-L different from the above dummy delay circuit, and input as an activation signal to the dummy output circuit 37.

5 In response to the activation signal, the dummy output circuit 37 outputs a low-level signal. The signal is input to the dummy input circuit 34 and serves as a signal ϕ_{ddq} . The signal ϕ_{ddq} is reversed by the switching circuit 412 shown in Fig. 30 and input as a signal ϕ_{out}

10 to the phase comparison circuit 42. The phase comparison circuit compares the leading edge of the clock CLK that is the encircled area (a) in Fig. 31 with the leading edge of the input signal ϕ_{out} thereof that is another encircled area (c) therein.

15 As mentioned above, in the fifth embodiment, the magnitude of a delay can be controlled differently between a high-level output and low-level output. A clock access time required for providing a high-level output can be agreed with a clock access time required for

20 providing a low-level output. This leads to an expanded margin of a system using the SDRAM. Eventually, the system can be operated at a high speed.

In the first to fifth embodiments, a delay circuit for outputting output data, a dummy delay circuit

25 analogous to the delay circuit, and a dummy output circuit are included. A dummy load analogous to a load connected to an output terminal is included, and a dummy output signal analogous to an actually-provided output signal is generated. The phase of the dummy output signal

30 is compared with that of an external clock. The phase relationship of the output signal relative to the external clock is retained very accurately compared with that in the prior art. However, in a system using this kind of semiconductor device, routing a line to the

35 output terminal is actually not constant. It is rare that a constant load (capacitance or output impedance) is retained all the time. It is therefore quite rare that

the actual load connected to the output circuit is consistent with a dummy load. A slight temporal error occurs between an actual output waveform and a dummy output waveform.

5 Fig. 33 is a diagram for explaining the occurrence of the error.

10 With the passage of an operating time T2 of an input circuit from a time instant T1 at which an external clock CLK rises, a delay circuit operates to delay an output timing signal. An output circuit then outputs data. The required time or the delay time shall be a time T4. Herein, a clock access time is a time T6. Even when an analogous dummy delay circuit is manufactured, it has some errors. Even when the same position in the dummy delay circuit as that in the delay circuit is selected, the magnitude of a delay produced by the dummy delay circuit may be different from that produced by the delay circuit. Furthermore, the magnitude of a delay produced by the dummy delay circuit may be different from that produced by the delay circuit because of an error in a dummy output circuit or dummy load from another created in the process of manufacturing. The magnitude of a delay produced by the dummy delay circuit is therefore a time T5. A time T7 in Fig. 33 is an error in the delay time.

20 This error is small. The slight temporal difference has posed no problem in the past. In a modern high-speed system, however, this small error dominates the limit of an operating speed and is posing a problem.

30 The sixth embodiment provides an SDRAM in which the negligible error is minimized. In the first to fifth embodiments, a delay circuit and a dummy delay circuit have the same magnitude of a delay specified according to a selector signal sent from a shared delay control circuit. In contrast, in the sixth embodiment, a phase comparison circuit and delay control circuit are provided for each of a delay circuit and dummy delay circuit. During an initialization period immediately after the

power supply is turned on, a considerable number of dummy cycles are carried out. During each dummy cycle, dummy data is output from an output circuit. The delay circuit is controlled so that the dummy data can be phased with an external clock. On the other hand, the dummy delay circuit is controlled so that the dummy data output from a dummy output circuit can be phased with the external clock. In this state, the magnitude of a delay produced by the delay circuit is set to a value, determined in consideration of the influence of a actually-connected load, enabling output data of the output circuit to be phased with the external clock. Likewise, the dummy delay circuit is controlled to produce a magnitude of a delay enabling dummy output data to be phased with the external clock. In this state, if the dummy output data is input to the phase comparison circuit associated with the normal delay circuit, output data can be controlled so that the output data can follow the external clock so as to be phased with the external clock even if it varies. This configuration can be adapted to the SDRAM of the first embodiment. The sixth embodiment to be described below is an embodiment realized by adapting the configuration to the SDRAM of the fifth embodiment shown in Fig. 29.

Fig. 34 is a block diagram showing the configuration of an SDRAM of the sixth embodiment.

As illustrated, in the sixth embodiment, a DLL 44 for generating a timing signal used to define the output timing of the output circuit 14 that outputs normal data, and a dummy DLL 45 for generating a dummy timing signal used to define the output timing of the dummy output circuit 37 that outputs a dummy output are included. The DLL 44 includes a high-level delay circuit 441a, a low-level delay circuit 441b, a phase comparison circuit 442, and a delay control circuit 443a. The dummy DLL 45 includes a high-level dummy delay circuit 451a, a low-level dummy delay circuit 451b, a phase comparison

circuit 452, and a delay control circuit 453a. Dummy
input circuits 34c and 34d are associated with the DLL 44
and dummy DLL 45 respectively. A signal corresponding to
an external clock sent from the input circuit 13 is input
5 to the delay circuits. A signal sent from the input
circuit 34 and signals sent from the associated dummy
input circuits are input to the phase comparators. A
supply voltage VccQ is applied to the output circuit 14,
and an output timing signal sent from the DLL 44 is
10 supplied thereto. An output of the output circuit 14 is
applied to an output terminal 12 and supplied to the
switching circuit 39. A wiring 151 on a printed-circuit
board and an input circuit receiver 152 of another LSI
are connected to the output terminal 12. The wiring and
15 receiver are actual output loads. Likewise, the supply
voltage VccQ is applied to the dummy output circuit 37,
and a dummy output timing signal sent from the dummy DLL
45 is supplied thereto. An output of the dummy output
circuit 37 is supplied to the dummy input circuit 34d via
20 the dummy output load 38, and also supplied to the
switching circuit 39. The switching circuit 39 switches a
signal to be supplied to the dummy input circuit 34c to
the output of the output circuit 14 or the output of the
dummy output load 38. The foregoing dummy circuits and
25 associated normal circuits are mutually analogous and
have the same circuitries.

Also included are a dummy data generation circuit 53
for generating dummy data used to force the output
circuit 14 and dummy output circuit 37 to output a
30 low-level signal and high-level signal during a dummy
cycle immediately after the power supply is turned on, a
power on detection circuit 52 for detecting the fact that
the power supply is turned on, and a command decoder 51.

The operations of the circuits in the sixth
35 embodiment will be described below.

The phase comparison circuits 442 and 452 give
control so that when the transition edges of an output

signal and dummy output signal precede the rise time instant of an external clock, the magnitudes of delays to be produced by associated delay circuits are increased, and that when the transition edges thereof succeed the rise time instant thereof, the magnitudes of delays to be produced thereby are decreased. This control is given in relation to both the transition edges of the output signal and dummy output signal going high and the transition edges thereof going low.

Thinking of a memory system in which the foregoing SDRAM is employed, immediately after the power supply of the system is turned on, the memory system starts operating synchronously with a clock so as to check and adjust the operations of various logics and a PLL included in the system. A considerable number of dummy cycles are therefore executed, and an external clock is input during each cycle. During a dummy cycle, if an operation for changing the magnitudes of delays to be produced by the delay circuits so that the transition edges of the output signal and dummy output signal exhibit a given phase relative to the external clock is repeated, the DLL and dummy DLL can be adjusted. However, immediately after the power supply is turned on, no information is written in the memory. The output signal and dummy output signal are stable. Adjustment cannot be carried out with the output signal and dummy output signal held stable. It is therefore necessary to internally generate data used to adjust the delay circuits during a dummy cycle. In this embodiment, the dummy data generation circuit 53 is newly included for this purpose. Dummy data is forcibly generated using the output waves of the power on detection circuit 52 and command decoder 51 which are included in a known SDRAM. Thus, the delay circuits are adjusted.

Fig. 35 is a diagram showing the circuitry of the dummy data generation circuit in the sixth embodiment.

The dummy data generation circuit is composed of two

units; an activation signal generator 381 and flip-flop 382. A signal ϕ_{ext} made by amplifying the external clock CLK using the input circuit, a signal ϕ_R for informing the fact that the power supply is turned on, a signal ϕ_{MRS} for starting an operation actually after initialization of the memory is completed are input to the activation signal generator 381. The operations of the circuit elements will be described with reference to the waveforms shown in Fig. 36.

A voltage V_{cc} is applied and boosted at a time instant T1. Some time later, the power on detection circuit 52 operates to generate a signal ϕ_R . When the dummy data generation circuit 53 receives the signal, a signal ϕ_{SW} goes high and a signal $\phi_{\overline{SW}}$ goes low. At a time instant T2, an external signal ϕ_{ext} serving as a reference signal is input. With this signal, the flip-flop 372 outputs a signal ϕ_D and $\phi_{\overline{D}}$ whose cycles are twice as long as that of an external clock. These signals are input to the output circuit and dummy output circuit and used as output data.

In the case of an SDRAM, it is necessary to set an operation mode in a mode register within each memory without fail prior to the start of actual operations. For setting an operation mode in the mode register, a mode register set instruction must be issued. In response to this instruction, the command decoder 51 outputs a signal ϕ_{MRS} . Assuming that the signal ϕ_{MRS} is issued at a time instant T3, the signal ϕ_{SW} goes low and the signal $\phi_{\overline{SW}}$ goes high. The potential at a terminal 10a-2 is stabilized. Thereafter, dummy data has a fixed value.

Fig. 37 is a diagram showing the circuitry of the output circuit 14 in the sixth embodiment, and Fig. 38 is a timing chart showing the operations of the output circuit. The dummy output circuit 37 has the same circuitry as the output circuit but is smaller in dimensions. The dummy output circuit operates in exactly the same manner as the output circuit.

Dummy data generated by the dummy data generation circuit 53 is input to the output circuit 14. The output circuit 14 is composed of a high-impedance control unit 141, a dummy data switch 142, and an output amplifier 143. Dummy data is input to the high-impedance control unit 141. A signal ϕZ is a signal for bringing an output to a high-impedance state. For making the impedance of an output high, the signal ϕZ is driven low. During a dummy cycle immediately after the power supply is turned on during which the switch ϕSW is high, the signal ϕZ is invalidated. The potential at a node 12a-1 goes low and the potential at a node 12a-2 goes high. Since the signal ϕSW is low, dummy data ϕD can pass through the dummy data switch 142. By contrast, since the signal ϕSW is high, a signal DB on an actual data bus will not pass to nodes 12a-11 and 12a-12.

In this state, the dummy data ϕD is validated. When the dummy data ϕD is high, the potentials at the node 12a-11 and 12a-12 go high. When an output circuit activation signal ϕoe synchronous with an external clock ϕext (a signal passing through the DLL 44) goes high, a high-level signal is output as an output signal. On the contrary, when the dummy data ϕD is low, the potentials at the nodes 12a-11 and 12a-12 go low. When the signal ϕoe is driven high, a low-level signal is output as the output signal.

As mentioned above, a dummy cycle immediately after the power supply is turned on is used. The time instant at which the output signal goes high or low agrees with the rise time instant of the external clock by the DLL 44. The time instant at which the dummy output signal goes high or low agrees with the rise time instant by the dummy DLL 45. Needless to say, since the waveform of the output signal is slightly different from that of the dummy output, values set in the delay circuits in the DLL 44 and dummy DLL 45 are mutually different. At this time, the output signal and dummy output signal are

synchronized with the external clock.

After a dummy cycle is completed (after the signal ϕ MRS is output), a memory cycle actually starts. Data stored in a memory is output through the output terminal 12. The data is random. It is unknown what kind of data is output. In the SDRAM, the data input terminal and data output terminal 12 are I/O common terminals. Input data may be input through the terminals. In this case, the system including the DLL 44 cannot be used to adjust the delay circuits 441a and 441b. The switching circuit 39 is switched in order to switch an object-of-comparison signal to be fed to the DLL 44 from the output signal to the dummy output signal.

Fig. 39 is a diagram showing the circuitry of the switching circuit 39. The switching circuit 39 includes two transfer gates each formed by connecting an n-channel transistor and p-channel transistor in parallel. A signal ϕ SW is used to bring either of the transfer gates to a passing state.

Consequently, temperature or the like may vary during a memory cycle. It may become necessary to adjust the magnitude of a delay to be produced by each delay in the DLL 44. In this case, the dummy output signal is used as an object-of-comparison signal. Since the waveforms of the external clock, output signal, and dummy output signal agree with one another during a dummy cycle immediately after the power supply is turned on, a deviation of the waveform of the dummy output signal from that of the external clock should merely be detected. Once the phase of the dummy output signal is adjusted according to the result of the detection, the output signal is phased with the external clock.

In the sixth embodiment, the output signal can be phased with the external clock through a series of operations in consideration of a difference in wiring or load of an actually-employed printed-circuit board from another board. As a result, a sufficient margin can be

ensured even for a system operating at a higher speed. The operations of the higher-speed system can be stabilized.

5 In the first to sixth embodiments, a dummy output circuit is included for outputting dummy data. The phase of an output signal is compared with that of an external clock. Alternatively, the dummy output circuit may not be included. Nevertheless, the phase of the output signal of an output circuit can be compared with that of the external clock. The seventh embodiment is an embodiment in which the phase of an output signal is compared with that of an external clock.

Fig. 40 is a diagram showing the configuration of an output timing control circuit in the seventh embodiment. As shown in Fig. 40, the output timing control circuit in the seventh embodiment comprises the input circuit 13, the output circuit 14, a delay circuit 501, a delay control circuit 502, a phase comparison circuit 503, a half phase-shift circuit 504 for generating a half-shifted clock, which is 180° out of phase with a clock CLK1 output from the input circuit 13, using the clock CLK1, first and second dummy input circuits 505 and 506, and first, second, and third latches 507, 508, and 509. The input circuit 13 and output circuit 14 are identical to those employed in the aforesaid embodiments. In the seventh embodiment, the phase comparison circuit 503 judges whether or not an output signal has made a state transition. If the output signal had made no state transition, the phase comparison circuit 503 outputs a hold signal (HOLD). Only when the output signal has made a state transition, does the phase comparison circuit compare phases, and it outputs a control signal (UP/DOWN), which instructs to increase or decrease the magnitude of a delay, to the delay control circuit 502 on the basis of the result of the comparison. The half phase-shift circuit 504, and the first, second, and third

latches 507, 508, and 509 are circuits for generating a signal which the phase comparison circuit 503 uses to judge whether or not an output signal had made a state transition or to compare phases. The latches are normal
5 latches. The circuitry of the normal latch is well-known. A description of the circuitry will therefore be omitted.

Fig. 41 is a diagram showing an example of the circuitries of the first delay circuit 501 and delay control circuit 502. As illustrated, the delay circuit
10 501 includes a string of inverters 521 having a plurality of inverters connected in series, a string of AND gates having a plurality of AND gates 522-1, 522-2, etc., and 522-n arranged so that an output of every other stage of the string of inverters 521 can be input through one of
15 input terminals of each AND gate, a string of transistors composed of n-channel transistors 523-1, 523-2, etc., and 523-n which input outputs of the AND gates through gates thereof, have sources thereof grounded, and have drains thereof connected in common, a resistor 524 connected
20 between a signal line, on which the drains of the n-channel transistors are connected in common, a high-potential power supply, and a buffer 525 whose input terminal is connected on the signal line and which outputs an internal clock CLK2. The delay control circuit
25 502 is composed of an up/down counter 526 and a decoder 527. When the hold signal HOLD is low, the up/down counter 526 does not carry out a counting operation. When the hold signal HOLD is high, the up/down counter carries out a counting operation synchronously with the rise of a signal $\phi 1/2CLK1$. When the up/down signal UP/DOWN is high, a counting-up operation is carried out. When the up/down signal is low, a counting-down operation is carried out. The decoder 527 decodes an output of the up/down counter
30 29 and causes any one output to go high and another output to go low. When the up/down counter 526 counts up pulses, an output position of a high-level signal is shifted rightward. When the up/down counter 526 counts
35

down pulses, the output position thereof is shifted leftward. Output terminals of the decoder 527 are connected to another input terminals of the AND gates 522-1, 522-2, etc., and 522-n. Only an AND gate to which
5 a high-level signal is input from the decoder 527 is activated. Among the outputs of the string of inverters, a signal to be input to the activated AND gate is output as an internal clock CLK2. Since the number of stages of the string of inverters through which an output signal
10 passes varies depending on which AND gate should be activated, the magnitude of a delay of the internal clock can be specified. An adjustment unit adopted for controlling the magnitude of a delay is the magnitude of a delay to be specified by passing a signal through two
15 inverters. The delay control circuit 502 must be designed so that any path in the delay circuit 501 can be selected without fail in the same manner as that described in conjunction with Figs. 11A to 15.

Fig. 42 is a diagram showing the configuration of a
20 half phase-shift circuit 504. As shown in Fig. 42, the half phase-shift circuit 504 includes a current mirror 511, a clock input buffer 512, first and second half-phase delay circuits 513 and 516 having the same circuitry mutually, buffers 514 and 517, a phase
25 comparison circuit 518, a delay control circuit 519, and a buffer 515 for outputting a half-phase clock $\phi 1/2CLK1$. The current mirror 511 and clock input buffer 512 constitute an input circuit. The first and second half-phase delay circuits 513 and 516 are digital delay
30 lines whose magnitudes of delays can be changed selectively and which are controlled to produce the same magnitude of a delay. The phase comparison circuit 518 compares the phase of a clock output from the buffer 512 with that of a clock output from the buffer 517, and
35 outputs the result of the phase comparison to the delay control circuit 519. Based on the result of the phase comparison, the delay control circuit 519 controls the

first and second half-phase delay circuits 513 and 516 so that the clock output from the buffer 512 can be phased with the clock output from the buffer 517. The circuitry shown in Fig. 43, which will be described later, is adopted for the phase comparison circuit 518, and the circuitry shown in Fig. 41 is adopted for the delay circuits 513 and 516.

A clock output from the buffer 512 is delayed by the first delay circuit 513, input to the second delay circuit 516 via the buffer 374, delayed by a magnitude identical to the magnitude of a delay produced by the first delay circuit 513, and then input to the phase comparison circuit 518 via the buffer 517. The phase comparison circuit 518 compares the phases of the clocks output from the buffers 512 and 517. The delay control circuit 519 changes the magnitudes of delays to be produced by the first and second delay circuits 513 and 516 on the basis of the result of the comparison so that the clocks can be phased with each other. When the clocks are phased with each other, since the path along which a signal is input from the first delay circuit 513 to the second delay circuit 516 via the buffer 514 has the same length as the path along which a signal is input from the second delay circuit 516 to the phase comparison circuit 518 via the buffer 517, the phase of a signal input to the second delay circuit 516 is shifted exactly by a half cycle from that of a signal input to the first delay circuit 513. The phases of the clocks output from the buffers 514 and 517 are therefore mutually shifted by a half cycle. A half-shifted clock $\phi_{1/2}$ generated by shifting the clock by a half cycle is output from the buffer 515. Using the half phase-shift circuit shown in Fig. 42, the half-shifted clock $\phi_{1/2}$ made by shifting the phase of a clock by exactly a half cycle can be provided.

In the seventh embodiment, since the half-shifted clock $\phi_{1/2}$ made by shifting the phase of a clock exactly by a half cycle is needed by other circuit elements, the

circuitry shown in Fig. 42 is adopted. If a signal made by shifting the phase of a clock by exactly a half cycle is unnecessary, an inverter may be substituted for the circuitry.

5 In either case, the latch 507 latches an output of the dummy input circuit 505 synchronously with the rise of a clock CLK1. The latch 508 latches an output of the dummy input circuit 506 synchronously with the fall of the clock CLK1. The latch 509 latches an output of the latch 508 synchronously with the fall of the clock CLK1. The latch 509 therefore latches an output of the dummy input circuit 509 in one cycle after the clock CLK1 to be latched by the latch 508 falls. An output of the latch 507, an output of the latch 508, and an output of the latch 509 are input as outputs RG1, RG2, and RG0 to the phase comparison circuit 503.

15 Fig. 43 is a circuit diagram showing the circuitry of the phase comparison circuit 503. The operations of the phase comparison circuit 503 will be described with reference to Figs. 44 to 46.

20 When no phase shift occurs, an output signal shall make a state transition at the leading edge of a clock CLK1 output from the input circuit 13. Points indicated with arrows in Fig. 44 represent the timing of each latch of latching an output signal. In order from the left, the signals RG0, RG1, and RG2 are latched according to the arrow-indicated timing. State 1 in Fig. 44 is a state in which the output signal remains high but makes no state transition. At this time, the signals RG0, RG1, and RG2 are all high. A hold signal HOLD goes low. Since no phase shift can be identified, a counting operation is not carried out. Likewise, state 2 is a state in which the output signal remains low but makes no state transition. At this time, the signals RG0, RG1, and RG2 are all low. The hold signal HOLD goes low and no counting operation is carried out.

States 3 and 4 shown in Fig. 45 are states in which

the output signal makes a high-to-low transition. In state 3 in which the transition edge of the output signal lags behind the leading edge of the clock CLK1, the signals RG0, RG1, and RG2 go high, high, and low respectively. In this state, the hold signal HOLD goes high and the up/down signal UP/DOWN goes low. The magnitude of a delay to be produced by the delay circuit 501 and specified by the delay control circuit 502 is decreased. In state 4 in which the transition edge of the output signal leads the leading edge of the clock CLK1, the signals RG0, RG1, and RG2 go high, low, and low respectively. In this case, the signal HOLD is driven high, and the signal UP/DOWN is driven high. The magnitude of a delay to be produced by the delay circuit 501 and specified by the delay control circuit 502 is increased.

States 5 and 6 shown in Fig. 46 are states in which the output signal makes a low-to-high transition. In state 5 in which the transition edge of the output signal lags behind the leading edge of the clock CLK1, the signals RG0, RG1, and RG2 go low, low, and high respectively. In this case, the signal HOLD is driven high and the signal UP/DOWN is driven low, the magnitude of a delay to be produced by the delay circuit 501 and specified by the delay control circuit 502 is decreased. In state 6, in which the transition edge of the output signal leads the leading edge of the clock CLK1, the signals RG0, RG1, and RG2 go low, high, and high respectively. In this case, the signal HOLD is driven high and the signal UP/DOWN is driven high. The magnitude of a delay to be produced by the delay circuit 501 and specified by the delay control circuit 502 is increased.

In the truth table of Fig. 47, the values of the signals RG0, RG1, and RG2 and the requested operations are listed in one-to-one correspondence with the foregoing states.

As mentioned above, in the output timing control

circuit in the seventh embodiment shown in Fig. 40, the phases of an output signal and clock are compared with each other, and control is given so that the output signal can be phased with the clock. The output signal is a varying signal that may assume a high or a low level. The phase comparison circuit 503 in the seventh embodiment judges whether or not the output signal has made a state transition. Only when the output signal has made a state transition, are phases compared. When the output signal has made no state transition, the delay control circuit 502 gives control so that the ongoing magnitude of a delay can be maintained. When the output signal has made no state transition, the output signal is fed back so that control is given according to the result of comparison performed by the phase comparison circuit 503 until the output signal is phased with the clock. Using the output signal, phase comparison can be achieved.

Fig. 48 is a block diagram showing the configuration of an output timing control circuit in the eighth embodiment. The output timing control circuit in the eighth embodiment is an example realized by adapting the configuration described in the fifth embodiment, in which timing control is given differently between when an output signal makes a low-to-high transition and when the output signal makes a high-to-low transition, to the output timing control circuit in the seventh embodiment. A difference from the seventh embodiment lies in a point that two delay circuits 501-H and 501-L, and two delay control circuits 502-H and 502-L for controlling the delay circuits mutually independently are included. A further description will be omitted.

For detecting the phase of an output signal relative to an external clock, a phase adjustment mode may be defined in order to carry out phase adjustment. For this purpose, a dummy data output circuit for outputting dummy data that makes a state transition at intervals of a

given cycle as shown in Fig. 35 is included. In the phase adjustment mode, an output circuit outputs dummy data. The phase of an output signal of the output circuit is compared with that of an external clock. The output signal is fed back so that control is given until the output signal is phased with the external clock. After the output signal is phased with the external clock, the phase adjustment mode is switched to a normal mode. In the normal mode, the adjusted magnitude of a delay is retained. This way, a phase can be adjusted through feedback control in the same manner as that in the first to sixth embodiments.

Fig. 49 is a block diagram showing the configuration of an output timing control circuit in the ninth embodiment. The output timing control circuit in the ninth embodiment is an example realized by employing another phase comparison circuit in the basic configuration of the output timing control circuit having the dummy output circuit shown in Fig. 8. As described previously, when the dummy output circuit is included, the dummy output circuit outputs dummy data that has been generated by a dummy data generation circuit and that makes a state transition at intervals of a given cycle. The phase of the output signal is compared with that of a clock. Since the dummy data makes a state transition at intervals of a given cycle, a phase comparison circuit 532 judges whether or not the output signal makes a state transition. If the output signal makes no state transition, it is unnecessary to output a hold signal so as not to change the magnitude of a delay to be produced by a delay circuit. The circuitry in the ninth embodiment includes a latch 533 for latching an output signal of a dummy input circuit 505 synchronously with a clock CLK1, and a latch 534 for latching an output signal of a dummy input circuit 506 synchronously with a clock $\phi 1/2CLK1$. An output of the latch 533 and an output of the latch 534 are input as signals RG1 and RG2 to the phase comparison

circuit 532. The phase comparison circuit 532 identifies the phase of the output signal on the basis of the signals RG1 and RG2.

5 Fig. 50 is a diagram showing the circuitry of the phase comparison circuit 532 employed in the output timing control circuit in the ninth embodiment. As is apparent from the drawing, the phase comparison circuit includes only the circuit for calculating an up/down signal UP/DOWN which is included in the phase comparison
10 circuit shown in Fig. 43. As mentioned above, in the ninth embodiment, it is judged whether or not an output signal makes a state transition. If the output signal makes no state transition, it is unnecessary to output a hold signal. A unit for generating the hold signal HOLD
15 is therefore excluded.

Figs. 51A and 51B are diagrams showing the judgment operations carried out by the phase comparison circuit 532 shown in Fig. 49. As shown in Fig. 51A, when an output signal DQ (an output of the dummy input circuit)
20 lags behind a clock CLK1, signals RG1 and RG2 have different values. When the output signal DQ leads the clock CLK1, the signals RG1 and RG2 have the same value. When the signals RG1 and RG2 have different values, the phase comparison circuit 532 causes the up/down signal
25 UP/DOWN to go low so as to decrease the magnitude of a delay of the clock. When the signals RG1 and RG2 have the same value, the phase comparison circuit 532 causes the signal UP/DOWN to go high so as to increase the magnitude of a delay of the clock.

30 In the truth table of Fig. 52, the values of the signals RG1 and RG2 and the requested operations are listed in one-to-one correspondence to the foregoing states of the up/down signal.

Referring back to Fig. 49, the circuitries shown in
35 Fig. 41, which are employed in the seventh embodiment, are adopted for the delay circuit 501 and delay control circuit 531. However, as shown in Fig. 53, the hold

signal HOLD is not input to the up/down counter. The hold facility is unnecessary.

Fig. 54 is a block diagram showing the configuration of an output timing control circuit in the tenth embodiment. The output timing control circuit in the tenth embodiment is an example realized by adapting the configuration described in the first embodiment, in which a one-Nth frequency divider is used to set the cycle of an output signal of a dummy output circuit to one-Nth of the cycle of a clock, to the circuitry in the ninth embodiment. As illustrated, a difference from the ninth embodiment lies in the point that a one-Nth frequency divider 542, a clock control circuit 541 for delaying a clock by a magnitude equivalent to the magnitude of a delay occurring in the one-Nth frequency divider 542, a delay circuit 501 for delaying a clock $CLK1/N$ whose frequency is one-Nth of the frequency of the clock, and dummy clock control circuits 543 and 544, located on the output stages of the dummy input circuits 505 and 506, for producing the same magnitude of a delay as the clock control circuit 541 are included, and in the points that a latch 533 latches an output of the dummy clock control circuit 543 synchronously with the clock $CLK1/N$, and a latch 544 latches an output of the dummy control circuit 544 synchronously with a clock $CLK1/N$ whose polarity is opposite to that of the clock $CLK1/N$. The other components are identical to those in the ninth embodiment.

Fig. 55 is a diagram showing the judgment operations performed in the tenth embodiment. As illustrated, even when an external clock CLK fails to exhibit a duty cycle of 50% because of a decay or the like occurring during propagation, the transition edge of a signal $CLK1/N$ whose frequency is one-Nth of the frequency of the external clock is synchronous with the leading edge of the external clock CLK. If the dummy output circuit 37 provides an output synchronously with the signal $CLK1/N$,

a resultant dummy output signal makes a state transition synchronously with the leading edge of the signal CLK1/N. The timing according to which the latch 533 latches an output is therefore an occasion on which the signal CLK1/N is about to rise. The timing according to which the latch 534 latches an output is an occasion on which the signal CLK1/N is about to rise. In other words, the timing according to which the latch 534 latches an output coincides with about a middle point of the transition edge of the dummy output signal. When an output signal DQ lags behind the clock, signals RG1 and RG2 have different values. When the output signal DQ leads the clock, the signals RG1 and RG2 have the same value.

Fig. 56 is a block diagram showing the configuration of an output timing control circuit in the eleventh embodiment. The output timing control circuit in the eleventh embodiment is an example realized by adapting the configuration described in the fifth embodiment, in which timing control is given differently between when an output signal makes a low-to-high transition and when the output signal makes a high-to-low transition, to the output timing control circuit in the tenth embodiment. A further description will be omitted.

In the aforesaid embodiments, an input signal to a dummy input circuit, that is, an output signal of a dummy output circuit is a signal having the same level as a clock input to an input circuit. However, as described previously, there are two system standards, LVTTTL and SSTL. The output signal of the dummy output circuit may therefore not have the same level as the clock input to the input circuit. The twelfth embodiment is an embodiment in which output can be carried out according to appropriate timing even in such a situation.

Fig. 57 is a diagram showing the configuration of an output timing control circuit in which the twelfth embodiment is implemented. A standard configuration that can be employed in the aforesaid embodiments is shown. To

begin with, a problem occurring when the output signal of a dummy output circuit does not have, as mentioned above, the same level as a clock to be input to an input circuit will be described.

5 As already described, the output timing control circuit has the clock control unit (DLL) 30 interposed between the input circuit 13 for fetching an external clock input through the clock terminal 11 and outputting a signal clkz, and the output circuit 14 for outputting
10 data through the data output DQ terminal 12. The output timing control circuit can adjust the phase of a clock to be supplied to the output circuit 14, that is, an output timing control signal clkiz. The DLL 30 includes the delay circuit 31 for delaying the signal clkz supplied
15 from the input circuit 13. The magnitude of a delay to be produced by the delay circuit 31 can be changed by the delay control circuit 33. For adjustment, it is necessary to detect the phase of a data output DQ relative to an external clock CLK. Since the data output DQ makes state
20 transitions at random, there is a difficulty in identifying a phase using the data output. A dummy output path along which dummy data d-dq is output according to the same timing according to which the output circuit 14 outputs data D-DQ is laid down so that the phase of the
25 dummy data can be compared with that of the external clock CLK. In reality, the phase cannot be compared directly with the phase of the external clock clk. To enable the comparison of the phase of the output clkz of the input circuit 13 with the phase of the clock, a dummy
30 input circuit 34 equivalent to the input circuit 13 is included. The dummy data d-dq is input to the dummy input circuit 34, and the phase of an output d-clkz of the dummy input circuit 34 is compared with the phase of the output clkz. A signal to be transmitted along the dummy
35 output path must have the same timing as the data D-DQ. The dummy output path is composed of the dummy line 36 causing the same delay as the line 16 linking the DLL 30

and output circuit 14, the dummy output circuit 37, equivalent to the output circuit 14, for outputting dummy data, and a dummy load 38. The DLL 30 includes the phase comparison circuit 32 for comparing the signal clkz
5 output from the input circuit with the signal d-clkz output from the dummy input circuit 34, and judges whether the signal d-clkz leads or lags behind the signal clkz. Based on the result of the judgment, the delay control circuit 33 increases or decreases the magnitude
10 of a delay to be produced by the delay circuit 31 until the signal d-clkz exhibits a given phase relative to the signal clkz. After the signal d-clkz has the given phase relative to the signal clkz, the delay control circuit 33 retains the state.

15 Thus, the output timing control circuit includes a dummy path equivalent to a normal signal path. The phase of a dummy signal propagating along the dummy path is compared with the phase of an external clock.

Fig. 58 is a timing chart showing the operations of the output timing control circuit. Fig. 58 shows an
20 example in which timing is adjusted so that a data output DQ can make a state transition synchronously with the rise of an external clock CLK. As shown in Fig. 58, an output clkz of the input circuit lags behind the external clock CLK. The output clkz is delayed by the delay
25 circuit 31, and output as signals clkiz and d-clkiz. The signals clkiz and d-clkiz are delayed by the signal line and dummy signal line 36, and then input to the output circuit 14 and dummy output circuit 37. The output
30 circuit 14 and dummy output circuit 37 duly output the data output DQ and dummy output d-dq. The dummy output d-dq is delayed by the dummy input circuit 34, and input as a signal d-clkz to the phase comparison circuit 32. At an initial step at which adjustment is not completed, the
35 signals clkiz, d-clkiz, DQ, d-dq, and d-clkz shall be output as signals clkiz', d-clkiz', DQ', d-dq', and d-clkz' respectively. The phase comparison circuit 32

compares the signal clkz with the signal d-clkz'. Assuming that the signal clkz leads, as illustrated, the signal d-clkz' by a time t_p , the signal DQ' leads the clock CLK by the time t_p . The phase comparison circuit 42 therefore judges that the signal clkz leads the signal d-clkz'. Accordingly, the delay control circuit 33 increases by one step the magnitude of a delay to be produced by the delay circuit 31. The operations are continued until the signal clkz is phased with the signal d-clkz, that is, until the magnitude of a delay to be produced by the delay circuit 31 is increased by the time t_p . When the magnitude of a delay is increased by the time t_p , the signals clkiz and d-clkiz output from the delay circuit 31 have the illustrated waveform. Accordingly, the signals DQ and d-dq have the illustrated waveform. Eventually, the signal DQ comes to make a state transition synchronously with the rise of the external clock CLK.

In the output timing control circuit using the foregoing DLL, a difference in phase of an internal clock, which is delayed while propagating along a path from the clock terminal through the input circuit, signal line, and output circuit to the data output DQ terminal, from an external clock is adjusted by delaying the internal clock using the delay circuit until the output timing of the output circuit equals a given phase of the external clock CLK. This operation can be regarded as an operation of advancing the internal clock by the delay caused by the path. This way of thinking helps simplify the further description. The way of thinking will be utilized below.

Fig. 59 is a diagram for explaining the operations of the circuits shown in Fig. 57 in line with the above way of thinking. As mentioned previously, in an existing SDRAM, a time t_{AC} is determined by the number of stages of logical elements ranging from a stage on which an external clock CLK is input to a stage on which a data

output DQ is supplied, and by physical distance. Referring to Fig. 57, a delay of an internal signal occurring at the clock terminal 11 and input circuit 13 and along a long-distance line and a delay thereof occurring along a path reaching the DQ terminal through the output circuit (data latch) 14 come to the time tAC. Therefore, a path identical to the path is laid down inside a chip, and a delay occurring along the path is measured. Consequently, the time tAC required when the SDRAM operates can be calculated. The path used to calculate the time tAC is a dummy path. The delay occurring along the path is equal to a delay of an output d-clkiz of the dummy delay circuit occurring until the output d-clkiz is provided as a signal d-clkz after propagating along a path from the dummy signal line 36 through the dummy output circuit 37 and dummy output load 38 to the dummy input circuit 34. This delay is equivalent to the time tAC. The delay time shall be a time ta and the magnitude of a delay occurring in the input circuit 13 and dummy input circuit 34 shall be a magnitude tb. The delay circuit 31 subtracts the time ta from the cycle of the signal clkiz (actually, delays the signal clkiz), that is, advances the signal clkiz, whereby data can be output through the data output terminal synchronously with the clock CLK. This operation is generally referred to as delay-locked looping. In Fig. 59, for convenience' sake, the data output DQ shall make a state transition at intervals of the same cycle as the external clock CLK, and the leading edge of the data output DQ shall be controlled to coincide with the leading edge of the clock CLK. The same applies to subsequent diagrams.

Now, a generally-adopted input circuit will be described briefly. Fig. 60 is a circuit diagram showing the circuitry of an input circuit generally employed in an SDRAM. An external clock CLK is applied to an input terminal CLK. The potential at a terminal vref is used as

a reference level for judging whether an input level is higher or lower, and set to an intermediate potential between potentials V_{IH} and V_{IL} . However, when an initial input stage circuit having the inverting ratio of an inverter adjusted is employed, a level signal v_{ref} is not required. An inverted potential provided by the inverter may be used as the signal v_{ref} . Through an output terminal $clkz$, a signal which is in phase of the external clock CLK and of which level is conformed to a signal level employed in a CMOS is output.

As described previously, for existing semiconductor devices, a plurality of interface standards have been stipulated in order to make signals employed in one semiconductor device compatible with other semiconductor devices. As far as an SDRAM or a semiconductor device to be used in combination with an SDRAM is concerned, two standards, LVTTL and STLL, are generally adopted. According to the LVTTL standard, a voltage V_{IH} is set to 2.0 V and a voltage V_{IL} is set to 0.8 V. According to the SSTL standard, the voltage V_{IH} is set to $V_{ref} + 2.0$ V, and the voltage V_{IL} is set to $V_{ref} - 0.2$ V. The signals have different amplitudes between the standards. When a signal having a different amplitude is input to the input circuit shown in Fig. 60, the characteristic of the input circuit changes.

Figs. 61A and 61B are diagrams showing a change in characteristic of the input circuit shown in Fig. 60 deriving from a difference in amplitude of an input signal. Fig. 61A shows the waveforms of internal operating waves according to the LVTTL standard, while Fig. 61B shows the waveforms of internal operating waves according to the SSTL standard. As is apparent from the drawings, when the SSTL is adopted, signals having the same amplitudes as those employed when the LVTTL is adopted are output internally. Depending on the conditions for an input wave, the response or response speed of the input circuit varies. To be more specific,

the gain of the input circuit, that is, the amplification ability and response ability thereof are constant. The response ability differs between when a wave having a small amplitude is amplified to a CMOS level and when a wave having a large amplitude close to the CMOS level is amplified. When the slope of an input wave is steep, the response speed gets higher. When the slope is moderate, the response speed gets lower. For the alternating-current specifications of an SDRAM, signal levels are measured with a half of a voltage VCC. The aforesaid times are measured with the half voltage $1/2V_{CC}$. The above phenomenon is not limited to the circuit shown in Fig. 60 but may occur in any general input circuit.

An SDRAM is designed to be able to operate in response to any input signal conformable to either of the two standards of LVTTL and SSTL. For the SDRAM, the dummy output load 38 lying along the dummy path is determined by predicting a load to be applied externally of a device. This means that the SDRAM is designed in consideration of an output interface. In many SDRAMs, the amplitude of an output is larger than a difference between the potentials V_{IH} and V_{IL} . That is to say, the dummy output d-dq has a large amplitude. As far as the LVTTL is concerned, almost all users give control on the assumption that the input signal has as large an amplitude as an output signal. In the LVTTL, therefore, an external clock CLK input to the input circuit through a clock terminal has the same amplitude as the dummy output d-dq input to a dummy input circuit. No problem therefore occurs.

However, in the SSTL, the external clock CLK to be input to the input circuit through the clock terminal is an SSTL-conformable signal having a small amplitude, while the dummy output d-dq to be input to the dummy input circuit is a signal having a large amplitude. The input circuit therefore exhibits a difference in

characteristic as discerned through comparison between Figs. 61A and 61B. When the input circuit exhibits such a difference in characteristic, even if the output timing control circuit shown in Fig. 57 is employed, an error occurs in the output timing, that is, phase of an output. Occurrence of the error will be described with reference to Fig. 62.

Assuming that the external clock CLK is a signal having a small amplitude, the response of the input circuit to the clock is slow. A signal clkz output from the input circuit is output in a time lag tx. The signal clkz is delayed by a delay circuit. Consequently, signals clkiz' and d-clkiz' are output. In response to the signals, an output circuit and a dummy output circuit provide data DQ' and dummy data d-dq'. At this time, the transition edges of the data DQ' and data d-dq coincide with the leading edge of the clock CLK. A dummy input circuit receives the dummy data d-dq' and outputs a signal d-clkz'. However, since the dummy data d-dq' has a large amplitude, the time lag of the signal d-clkz' from the data d-dq' becomes a time ty. There is a phase difference, $tq = tx - ty$, between the signals clkz and d-clkz' which are compared by a phase comparison circuit. A delay control circuit increases the magnitude of a delay to be produced by the delay circuit so as to nullify the phase difference. As illustrated, when the phase difference between the signals clkz and d-clkz becomes null, the signal clkiz lags behind the signal clkiz' by a time tq. Data DQ is stabilized in a state in which the data DQ lags behind the clock CLK by the time tq. Thus, as far as a known output timing control circuit is concerned, when the external clock CLK is a signal having a small amplitude, a phase error occurs between the data output DQ and external clock CLK.

Figs. 63 and 64 are diagrams for explaining the phenomenon explained in conjunction with Fig. 62, in which a phase error occurs between a data output DQ and

an external clock CLK because an input signal has a different amplitude, by utilizing the way of thinking described in conjunction with Fig. 59. Fig. 63 is concerned with the LVTTL, while Fig. 64 is concerned with the SSTL. In the case of the LVTTL shown in Fig. 63, a delay occurring in an input circuit is equal to a delay occurring in a dummy input circuit, t_b . Therefore, when the signal $clkiz$ is advanced by the measured magnitude of a delay occurring along a dummy path, the data output DQ is brought into phase with the external clock CLK. By contrast, when the SSTL is adopted, a delay t_b occurring in the input circuit is different from a delay t_b' occurring in the dummy input circuit. Even if the signal $clkiz$ is advanced by the measured magnitude of a delay occurring along the dummy path, there is a phase difference between the external clock CLK and data output DQ. In a semiconductor device of the twelfth embodiment, this problem is solved. Even when a signal having a different amplitude is input, the data output DQ is always brought into phase with the external clock CLK.

Fig. 65 is a diagram showing the basic configuration of a semiconductor device of the twelfth embodiment. As shown in Fig. 65, the semiconductor device of the twelfth embodiment has, in addition to the components shown in Fig. 57, a dummy input waveform conversion circuit 39 for converting the waveform of dummy data $d-dq$ input to the dummy input circuit 34 to a waveform identical to the waveform of an external clock CLK. The waveform of a dummy data signal is thus agreed with that of the external clock. Eventually, occurrence of a phase difference deriving from a difference in waveform between two signals is prevented.

Figs. 66 and 67 are diagrams for explaining the operations of the semiconductor device of the twelfth embodiment. Fig. 66 shows the operations in the LVTTL in which a large-amplitude signal is input, while Fig. 67 shows the operations in the SSTL in which a

small-amplitude signal is input. As shown in Fig. 66, in the LVTTL, the dummy output signal d-dq has a large amplitude and is converted into a signal d-clk having the large amplitude by the dummy input waveform conversion circuit 39. At this time, a delay occurring in the dummy input waveform conversion circuit 39 has a negligible magnitude. Both an external clock CLK and the signal d-clk have a large amplitude, and the input circuit 13 and dummy input circuit 34 are mutually equivalent. A delay time $t_{b'}$ occurring in the dummy input circuit 34 is equal to a delay time t_b occurring in the input circuit 13. Once the external clock CLK is advanced by a delay time t_a occurring along the dummy path by means of the DLL 30, the output signal DQ is phased with the external clock CLK.

As shown in Fig. 67, in the SSTL, the dummy output signal d-dq has a large amplitude and is converted into a signal d-clk having a small amplitude by the dummy input waveform conversion circuit 39. At this time, a delay occurring in the dummy input waveform conversion circuit 39 has a negligible magnitude. With the conversion, both the external clock CLK and signal d-clk have a small amplitude. The input circuit 13 and dummy input circuit 34 are mutually equivalent. The delay time $t_{b'}$ occurring in the dummy input circuit 34 is equal to the delay time t_b occurring in the input circuit 13. Once the external clock CLK is advanced by the delay time t_a occurring along the dummy path by means of the DLL 30, the output signal DQ is phased with the external clock CLK.

Figs. 68A and 68B are diagrams showing the configuration of the dummy input waveform conversion circuit in the twelfth embodiment. Fig. 68A is a block diagram showing the basic configuration, and Fig. 68B is a circuit diagram. As shown in Fig. 68A, the dummy input waveform conversion circuit includes an LVTTL-conformable converter 711 and SSTL-conformable converter 712. The LVTTL-conformable converter 711 and SSTL-conformable

converter 712 share a dummy output node and a dummy input node. A dummy output d-dq output from the dummy output circuit 37 to the dummy load 38 is input through the dummy output node. A dummy input d-clk resulting from waveform conversion is output through the dummy input node and input to the dummy input circuit 34. Either of the VTTL-conformable converter 711 and SSTL-conformable converter 712 is activated with an interface judgment signal lvttlz. The dummy output d-dq is converted by an activated converter. Consequently, the dummy input d-clk is output. The interface judgment signal lvttlz is a signal generated by a circuit incorporated in a chip for specifying which interface standard is adopted to operate the chip. When an interface employed is conformable to LVTTL, the signal lvttlz goes high. When the interface is conformable to the SSTL, the signal lvttlz goes low.

In an actual dummy input waveform conversion circuit in the twelfth embodiment, the LVTTL-conformable converter 711 is, as shown in Fig. 68B, formed with a transfer gate composed of a p-channel transistor 722 and an n-channel transistor 723. The SSTL-conformable converter 712 is formed with a circuit made by connecting a p-channel transistor 724 and n-channel transistor 725 in series. The interface judgment signal lvttlz is applied to the gate of the n-channel transistor 723 of the LVTTL-conformable converter 711 and to the gate of the p-channel transistor 724 of the SSTL-conformable converter 712. A signal whose polarity is opposite to that of the interface judgment signal lvttlz is applied to the gate of the p-channel transistor 722 of the LVTTL-conformable converter 711 and to the gate of the n-channel transistor 725 of the SSTL-conformable converter 712.

Fig. 69 is a diagram showing the operations of the dummy input waveform conversion circuit in the twelfth embodiment. When LVTTL is specified, the interface judgment signal lvttlz is high. The transistors 722 and

723 are turned on, and the transistors 724 and 725 are turned off. The transfer gate composed of the transistors 722 and 723 enters a passing state, while the path made by connecting the transistors 724 and 725 in series enters a cutoff state. In other words, the LVTTL-conformable converter 711 is activated, while the SSTL-conformable converter 712 is inactivated. An input signal d-dq therefore passes through the transfer gate and is output as a signal d-clk with the waveform held intact.

When the SSTL is specified, the interface judgment signal lvttlz is low. The transistors 722 and 723 are turned off, and the transistors 724 and 725 are turned on. The transfer gate composed of the transistors 722 and 723 enters the cutoff state. The path made by connecting the transistors 724 and 725 in series enters the passing state. In other words, the LVTTL-conformable converter 711 is inactivated, and the SSTL-conformable converter 712 is activated. Since the transistors 724 and 725 are on, a signal n02 developed after the signal d-dq passes through the p-channel transistor 724 has a level calculated by subtracting the threshold voltage of the p-channel transistor 724, $P_{ch}\text{-}V_{th}$, from the level of the signal d-dq. A signal d-clk has a level calculated by subtracting the threshold voltage of the n-channel transistor 725, $N_{ch}\text{-}V_{th}$, therefrom. The amplitude of a wave input to the input circuit is therefore decreased and approximated to that of an SSTL-conformable signal having a small amplitude which is input externally. In the circuit shown in Fig. 68, a delay occurring in the LVTTL-conformable converter 711 or SSTL-conformable converter 712 is of a negligible level.

In general, for improving a withstanding voltage against static electricity originating from an electrode pad linked to external pins, a circuit like the one shown in Fig. 70, which is referred to as an ESD circuit, is interposed between an electrode pad 11 and the input

circuit 13. As illustrated, the ESD circuit includes no logical element. However, since resistors r11 and r12 are inserted into a signal path, a delay is caused by the resistors. The delay caused by the resistors must be taken into account in designing a dummy path. It is conceivable to connect a circuit equivalent to the ESD circuit to the dummy input circuit 34. Alternatively, the dummy input waveform conversion circuit 39 may be designed to produce a delay equivalent to the delay caused by the ESD circuit. In this case, in the circuitry shown in Fig. 68B, assuming that the on-state resistance of the p-channel transistor 722 is rm01, the on-state resistance of the n-channel transistor 723 is rm02, the on-state resistance of the p-channel transistor 724 is rm03, and the on-state resistance of the n-channel transistor 725 is rm04, the values of the resistances rm01, rm02, rm03, and rm04 are determined so that $rm01 * rm02 / (rm01 + rm02)$ and $rm03 + rm04$ will be equal to the resistance of the ESD circuit. Another method is, as shown in Fig. 71, to include a resistor r13 so that the resistance of the dummy input waveform conversion circuit 39 will be equal to that of the ESD circuit. Owing to the circuitry, a delay equivalent to the delay caused by the ESD circuit can be produced. This results in the further improved precision in timing adjustment.

In the dummy input waveform conversion circuit in the twelfth embodiment shown in Fig. 68B, when the SSTL is specified, the waveform of an input is determined with the threshold voltages Pch-Vth and Nch-Vth. The amplitude thereof cannot therefore be controlled arbitrarily. Depending on a use situation, it may become necessary to convert the amplitude of an input to an amplitude other than the amplitude determined with the threshold voltages. From this viewpoint, there is a problem that a usable range is limited. A dummy input waveform conversion circuit in the thirteenth embodiment solves this problem and can convert the amplitude of an input

signal into any amplitude.

Figs. 72A and 72B are diagrams showing the configuration of a dummy input waveform conversion circuit in the thirteenth embodiment. Fig. 72A is a block diagram showing the basic configuration, and Fig. 72B is a circuit diagram. Fig. 73 is a diagram showing the operations of the dummy input waveform conversion circuit in the thirteenth embodiment. As apparent from comparison with Figs. 68A and 68B, the dummy input waveform conversion circuit in the thirteenth embodiment has, in addition to the components of the dummy input waveform conversion circuit in the twelfth embodiment, a level adjustment unit 713 for controlling the gate potentials of the transistors 724 and 725 so that the level of a signal d-clk output from the SSTL-conformable converter 712 can be controlled. The level adjustment unit 713 develops potentials VIH and VIL by bringing about a voltage drop using resistors r01 to r03 connected in series, and causes a potential $|VIL| - |Pch-Vth|$ to develop at the gate of the n-channel transistor 724 and a potential $|VIH| - |Nch-Vth|$ to develop at the gate of the n-channel transistor 725. The signal d-clk becomes a signal whose amplitude is defined with the potentials VIH and VIL. An n-channel transistor 726 is connected to the resistors r01 to r03 of the level adjustment unit 713. The n-channel transistor 726 is on in the SSTL. This causes the level adjustment unit 713 to become active. The potentials VIH and VIL are developed. In the LVTTL, the n-channel transistor 7136 is turned off, and the level adjustment unit 713 is inactivated. Thus, a current is prevented from flowing into the level adjustment unit. This results in a minimized power consumption.

In the first and second embodiments, the interface judgment signal lvttlz is used to determine whichever of the LVTTL-conformable converter 711 or SSTL-conformable converter 712 should be activated. The interface judgment signal is set in anticipation of a waveform of an output

to a semiconductor device. However, there is a possibility that a signal not having an anticipated waveform may be input. This poses a problem that an output signal does not exhibit a given phase relative to an external clock. A dummy input waveform conversion circuit in the fourteenth embodiment solves this problem.

Fig. 74 is a diagram showing the basic configuration of a dummy input waveform conversion circuit in the fourteenth embodiment. As shown in Fig. 74, the dummy input waveform conversion circuit has, in addition to the components of the dummy input waveform conversion circuit 710 in the twelfth embodiment, an input waveform detection circuit 730 for detecting the amplitude of an external clock CLK. Incidentally, the dummy input waveform conversion circuit in the thirteenth embodiment shown in Figs. 72A and 72B may be substituted for the dummy input waveform conversion circuit 710 in the twelfth embodiment. Based on the result of detection performed by the input waveform detection circuit 730, either of the LVTTTL-conformable converter 771 and SSTL-conformable converter 712 of the dummy input waveform conversion circuit 710 is activated. The input waveform detection circuit 730 includes a high-potential detector 731 for detecting whether or not the level of an external clock CLK becomes higher than a first given level, a low-potential detector 732 for detecting whether or not the level of the external clock CLK becomes lower than a second given level, and a latch unit 733 for latching the results of detection performed by the high-potential detector 731 and low-potential detector 732 in response to a control signal sent from a latching timing control unit 734. For merely identifying the LVTTTL or SSTL, the employment of either of the high-potential detector 731 and low-potential detector 732 will do. Detection in both the directions would improve detection precision. If a plurality of detection circuits were included for comparing the external clock with a

plurality of levels, the precision would further improve. Herein, the description proceeds on the assumption that the level of the external clock is compared with two high and low levels.

5 Fig. 75 is a diagram showing the actual circuitry of the dummy input waveform conversion circuit in the
fourteenth embodiment. The high-potential detector 731 is
formed with a current mirror using the level of a signal
VHref as a reference level. The low-potential detector
10 732 is formed with a current mirror using the level of a
signal VLref as a reference level. The level VHref is
lower than a voltage VCC and higher than a voltage Vref.
The level VLref is higher than a voltage VSS and lower
than the voltage Vref. The outputs of the two current
15 mirrors are amplified to CMOS-conformable levels by an
inverter, and output as signals n11 and n21 to the latch
unit 733. A signal clkmz is a signal synchronous with the
clock CLK. Herein, a signal generated for another purpose
by another part of a chip is used as the signal clkmz.
20 The signal clkmz may be generated by the dummy input
waveform conversion circuit. The latching timing control
unit 734 generates pulses n12 and n22 from the signal
clkmz for the purpose of latching. The latch unit 733
includes a first latch for latching an output of the
25 high-potential detector 731 responsively to the pulse
n12, and a second latch for latching an output of the
low-potential detector 732 responsively to the pulse n22.
When the clock CLK is high, if the pulse n12 goes low,
the signal n11 is latched by the first latching circuit.
30 Consequently, a signal n13 is transmitted. Likewise, when
the clock CLK is low, if the pulse n22 goes high, the
signal n21 is latched by the first latch. Consequently, a
signal n23 is transmitted. Based on the values of the
signals n13 and n23 resulting from latching, the waveform
35 of a dummy output to be output through a terminal d-dq is
converted into the one identical to the waveform of a
dummy input to be input through a terminal d-clk, and

then transmitted. Current mirrors are used as the high-potential detector 731 and low-potential detector 732. Alternatively, circuits utilizing the inverting ratio of an inverter will do. In other words, a threshold value of an output of an inverter may be used as a reference. In this case, the signals VHref and VLref are unnecessary.

Figs. 76 to 79 are timing charts showing the operations of the circuit in the fourteenth embodiment shown in Fig. 75.

When the LVTTL is adopted, as shown in Fig. 76, a wave whose level exceeds those of the levels VHref and VLref is input as a clock CLK. When it is said that the LVTTL is adopted, this means that a signal having a large amplitude is input. The signal is not necessarily a signal conformable to the LVTTL standard. In this case, the "high" level of the clock CLK exceeds the level VHref. A signal in phase with and synchronous with the clock CLK is transmitted as the signal n11. Likewise, since the "low" level of the clock CLK exceeds the level VLref, a signal in phase with and synchronous with the clock CLK is transmitted as the signal n21. The signal clk_{mz} is synchronous with the clock CLK. The pulse n12 going low is generated at the leading edge of the signal clk_{mz}, and the pulse n22 going high is generated at the trailing edge of the signal clk_{mz}. During the duration of the pulse n12, the signal n11 is high and the signal n13 is low. During the duration of the pulse n22, the signal n21 is low and the signal n23 is high. The signal n31 is therefore driven high. The transistors 722 and 723 are turned on and the transistors 724 and 725 are turned off. This means that the LVTTL-conformable converter 711 is turned on and the SSTL-conformable converter 712 is turned off. The signal d-dq is transmitted as a signal d-clk with the waveform held intact. Consequently, a wave having a large amplitude is transmitted from the dummy input circuit.

When the SSTL is adopted, as shown in Fig. 77, a wave whose level does not exceed the levels V_{Href} and V_{Lref} is input as a clock CLK. When it is said that the SSTL is adopted, this means that a signal having a small amplitude is input. The signal is not necessarily a signal conformable to the SSTL standard. In this case, since the "high" level of the clock CLK does not exceed the level V_{Href} , the signal $n11$ goes low irrespective of the level of the clock CLK. Likewise, since the "low" level of the clock CLK will not fall below the level V_{Lref} , the signal $n21$ is high irrespective of the level of the clock CLK. The signal $n13$ is therefore driven high, the signal $n23$ is driven low, and the signal $n31$ is driven low. The transistors 722 and 723 are therefore turned off, and the transistors 724 and 725 are turned on. This means that the LVTTTL-conformable converter 711 is turned off and the SSTL-conformable converter 712 is turned on. The waveform of the signal $d-dq$ becomes a waveform resulting from subtraction of the threshold voltages $P_{ch}-V_{th}$ and $N_{ch}-V_{th}$ by the transistors 724 and 725. Consequently, the signal $d-clk$ is transmitted. Thus, a wave having a small amplitude is transmitted from the dummy input circuit.

Fig. 78 shows the operations performed when a wave whose level exceeds the level V_{Href} but does not fall below the level V_{Lref} is input as an external clock CLK. In this case, a variant of the SSTL that is an SSTL-1 is adopted. Anyhow, a wave which has an intermediate amplitude and whose low level is rather high should merely be input. In this case, since the high level of the clock CLK exceeds the level V_{Href} , a wave in phase with and synchronous with the clock CLK is transmitted as the signal $n11$. However, since the low level of the clock CLK will not fall below the level V_{Lref} , the signal $n21$ is always high irrespective of the level of the clock CLK. The signal $n13$ is therefore driven low, the signal $n23$ is driven low, and the signal $n31$ is driven high. The

p-channel transistor 722 is turned on, the n-channel transistor 723 is turned off, and the transistors 724 and 725 are turned off. The signal d-dq is therefore transmitted via the transistor 722 alone. Consequently, the signal d-clk whose waveform results from subtraction of the threshold voltage $P_{ch}-V_{th}$ from the low potential of the signal d-dq is transmitted.

Fig. 79 shows the operations performed when a wave whose low level falls below the level V_{Lref} but whose high level does not exceed the level V_{Href} is input as an external clock CLK. Herein, a variant of the SSTL that is an SSTL-2 is adopted. A wave which has an intermediate amplitude and whose high level is rather low should merely be input. In this case, the low level of the clock CLK falls below the level V_{Lref} , a wave in phase with and synchronous with the clock CLK is transmitted as the signal n21. However, since the high level of the clock CLK will not exceed the level V_{Href} , the signal n11 is always low irrespective of the level of the clock CLK. The signal n13 is therefore driven high, the signal n23 is driven high, and the signal n31 is driven high. The p-channel transistor 722 is turned off, the n-channel transistor 723 is turned on, and the transistors 724 and 725 are turned off. The signal d-dq is therefore transmitted via the n-channel transistor 723 alone. Consequently, the signal d-clk whose waveform results from subtraction of the threshold voltage $N_{ch}-V_{th}$ from the high potential of the signal d-dq is transmitted.

As mentioned above, in the fourteenth embodiment, the amplitude of an input external clock is judged, and the amplitude of an output is converted according to the result of the judgment. The amplitude of an input signal and that of a dummy signal input to the dummy input circuit can therefore be agreed with each other reliably. Consequently, the output exhibits a given phase relative to the external clock irrespective of the amplitude of the external clock.

In the first to fourteenth embodiments, an output timing control circuit for a semiconductor device of the present invention has been described. How to adapt such an output timing control circuit to a semiconductor device will be described in conjunction with another embodiment.

Fig. 80 is a diagram showing the arrangement of the clock input circuit 13, output timing control circuit 30, first to m-th output circuits 571-1, 571-2, etc., and 571-m, and a clock signal distribution circuit 580.

As illustrated, this semiconductor device outputs a plurality of signals OS-1, OS-2, etc., and OS-m. The output circuits 571-1, 571-2, etc., and 571-m are associated with the output signals. The clock distribution circuit 580 distributes a clock, which is input from the clock input circuit 13 via the output timing control circuit 30, into the output circuits 571-1, 571-2, etc., and 571-m arranged in the semiconductor device via a plurality of buffers (CB1, CB21, etc., and CBnm) 581 to 583. The lengths of lines reaching distribution destinations, and the numbers of buffers through which the clock passes are mutually the same. Thus, an equidistant wiring is realized. In Fig. 80, clocks input to the output circuits 571-1, 571-2, etc., and 571-m are all in phase. The clock input circuit 13 and output timing control circuit 30 are located near one of the output circuits 571-1, 571-2, etc., and 571-m, or herein, the first output circuit 571-1. The output timing control circuit 30 gives control so that an output signal of the first output circuit 571-1 can be phased with the external clock CLK. As mentioned above, since the clock distribution circuit 580 has the equidistant wiring, the clocks input to the output circuits are all in phase. If the output signal of the first output circuit 571-1 is synchronous with the external clock CLK, the output signals of all the output circuits will be synchronous with the external clock CLK.

In a semiconductor device to which any of the circuitries of the first to fifteenth embodiments is adapted, compared with a known semiconductor device, the precision in synchronism of an output signal with an external clock improves drastically. An embodiment in which a semiconductor system is constructed using semiconductor devices capable of providing an output with the high precision ensured for synchronism with the external clock will be described below.

A known output timing and underlying problems will be described. Fig. 81 is a diagram for explaining the output timing of a known semiconductor device for outputting data synchronously with an external clock. In the known semiconductor device, an operation for outputting data is started responsively to the rise of an external clock CLK (t_0). An output actually develops at an output terminal some time later. The time differs with a difference of one process from another, a fluctuation in supply voltage, a change in temperature, or the like. When the time is the shortest, the output develops at a time instant t_1 . When the time is the longest, the output develops at a time instant t_2 . That is to say, a clock access time ranges from a time t_{OH} starting with the leading edge of the external clock to a time t_{AC} . The times t_{OH} and t_{AC} are stipulated in the specifications for a semiconductor device. The time interval between the time instants t_1 and t_2 is a time which cannot be used actually and during which data is uncertain.

On a side receiving such an output, a setup time t_{IS} and a hold time t_{IH} are needed. The times t_{IS} and t_{IH} are defined in relation to the leading edge of the external clock. A start time instant of the setup time t_{IS} is a time instant t_3 , and an end time instant of the hold time t_{IH} is a time instant t_5 . In the drawing, a difference between the time interval $t_2 - t_6$ and the time interval $t_3 - t_5$ is regarded as a timing margin of the system. The timing margin must be long enough to absorb errors caused

by various factors in the system.

In recent years, the frequency of an external clock has gotten higher and higher. This poses a problem that the timing margin cannot be preserved sufficiently.

5 Fig. 82 is a diagram showing output timing in a semiconductor device of the present invention. In the known semiconductor device, as shown in Fig. 81, an output operation is started at the leading edge of an external clock. In contrast, in the semiconductor device
10 of the present invention, an output signal is output synchronously with the trailing edge of the external clock. Needless to say, the leading and trailing edges of the external clock have a phase difference of 180° between them. The external clock is therefore a signal
15 having a duty cycle of 50%. As already described, in the semiconductor device of the present invention, the output timing of an output signal can be controlled so that the output signal exhibits a given phase relative to the external clock. The output signal develops immediately at
20 an output terminal synchronously with the trailing edge of the external clock. The middle point during a period during which the output signal is finalized coincides with the leading edge of the external clock. The same timing margin can be preserved before and after input.
25 Assuming that the cycle of the external clock gets shorter gradually, the merit of providing an output according to the foregoing timing will be more apparent.

30 Fig. 83 is a diagram showing the arrangement of devices and the layout of signal lines in a memory system of the sixteenth embodiment constructed using semiconductor memories 610 to 613 each capable of controlling the output timing of an output signal so that the output signal exhibits a given phase relative to an external clock. Fig. 84 is a diagram showing the phase
35 relationship of data relative to a clock CLK in the memory system of the sixteenth embodiment.

In the drawing, there is shown a controller 601 in the memory system. The semiconductor memories 610 to 613 are arranged as illustrated. Data items stored in the semiconductor memories 610 to 613 are output over a data bus 602 synchronously with a clock CLK applied to a clock line 603. Assuming that the propagation direction over the clock line 603 of the clock CLK is a direction from the right in the drawing to the left therein, the time required for the clock CLK to reach the rightmost memory 3 is the shortest. The time required for the clock CLK to reach the leftmost memory is the longest. However, talking of the time required for data output synchronously with the clock CLK to reach the controller 601, the time required for data output from the leftmost memory is the shortest. If the propagation speed over the clock line 603 of the clock CLK is equal to the propagation speed over the data bus 602 of the data signal, as shown in Fig 84, data items output from the memories reach the controller 601 according to the timing according to which the clock CLK reaches the controller 601. The controller 601 should therefore fetch data synchronously with the clock CLK.

Fig. 85 is a diagram showing the arrangement of devices and the layout of signal lines in a memory system of the seventeenth embodiment.

In the memory system of the seventeenth embodiment, a clock CLK is input to the controller 601 first. The controller 601 uses the clock CLK to generate a writing clock Write-CLK and a read clock Read-CLK. A clock line over which the clock Read-CLK propagates is a signal line 605. The clock Read-CLK is sent back to the controller 601 over a signal line 606 after propagated to the position of the rightmost memory 613 over the signal line 605. The clock Read-CLK is supplied to the memories over the signal line 606. Data items output from the memories are fetched into the controller 601 in the same manner as those in the sixteenth embodiment.

In the seventeenth embodiment, the clock Read-CLK propagating over the signal line 606 is input as a clock Read-Receive to the controller 601. The magnitude of the delay of the clock Read-CLK is adjusted so that the clock Read-Receive is phased with the clock Read-CLK.

Fig. 86 is a diagram showing the systems of clocks within the controller 601 in the seventeenth embodiment.

As shown in Fig. 86, an externally-input clock CLK is input to an output buffer 621, and then output as a clock Write-CLK. The clock Write-CLK passes through a current mirror 622 and driver 623 so as to be amplified. After being delayed by a specified magnitude by a delay circuit 624, the clock Write-CLK is output as a clock Read-CLK from an output buffer 625. The returning clock Read-CLK is received as a clock Read-Receive. After passing through a current mirror 626 and driver 627, the clock Read-Receive is input to a phase comparison circuit 628. An output of the driver 623 is also input to the phase comparison circuit 628, whereby the phase of the output is compared with that of the clock. Based on the result of the comparison, a delay control circuit 629 specifies a magnitude of a delay to be produced by the delay circuit. Thus, the magnitude of the delay of the clock Read-CLK is adjusted so that the clocks Read-CLK and Read-Receive will be in phase with each other.

Fig. 87 is a diagram showing the arrangement of devices and the layout of signal lines in a memory system of the eighteenth embodiment.

In the memory system of the eighteenth embodiment, like the one of the sixteenth embodiment, a clock CLK propagating in a direction in which data items output from memories propagate is received as a clock Read-Receive by the controller 601. The controller 601 generates a writing clock Write-CLK using the clock Read-Receive. Reading data from the memories is carried out synchronously with the clock CLK. The magnitude of the delay of the output clock Write-CLK is adjusted so

that the clock will be phased with the clock
Read-Receive.

Fig. 88 is a diagram showing the systems of clocks
within the controller 601 in the eighteenth embodiment.

5 As shown in Fig. 88, an externally-input clock
CLK-Receive is amplified while passing through a current
mirror 631 and driver 632. After being delayed by a
specified magnitude by a delay circuit 633, the clock is
output as a clock Write-CLK from an output buffer 634.
10 The clock Write-CLK is input to a phase comparison
circuit 637 after passing through a current mirror 635
and driver 636. An output of the driver 632 is also input
to the phase comparison circuit 637, whereby the phase of
the output is compared with that of the clock. Based on
15 the result of the comparison, a delay control circuit 638
specifies the magnitude of a delay to be produced by the
delay circuit 633. Thus, the clock Write-CLK is adjusted
so that it is phased with the clock Read-Receive.

Fig. 89 is a diagram showing the arrangement of
20 devices and the layout of signal lines in a memory system
of the nineteenth embodiment.

In the memory system of the nineteenth embodiment, a
clock terminal of the controller 601 is shared by a read
clock and writing clock. Like the memory system of the
25 sixteenth embodiment, a clock CLK propagating in a
direction in which data output from memories propagate is
received as a clock R/W-CLK by the controller 601.
Fetching of data output from the memories into the
controller 601 is carried out in the same manner as that
30 in the sixteenth embodiment. The clock CLK is branched to
a clock line 607 immediately before input to the
controller 601, and returned in an opposite direction to
serve as a writing clock. Data output from the controller
601 and to be written in a memory therefore propagates in
35 parallel with the writing clock. The question is how to
bring the data to be written in a memory into phase with
the writing clock.

Fig. 90 is a diagram showing the systems of clocks within a controller 601 in the nineteenth embodiment.

As shown in Fig. 90, an externally-input clock R/W-CLK is amplified while passing through a current mirror 641 and driver 642. After being delayed by a
5 specified magnitude by a delay circuit 643, the clock is supplied to a data output buffer 644. The data output buffer 644 outputs data read from a writing data register 640 synchronously with a timing signal supplied from the
10 delay circuit 743. The timing signal is delayed by a magnitude equal to the magnitude of a delay occurring in the data output buffer 644 by means of a dummy output buffer 649, and then input to a current mirror 645. An
15 output of the current mirror 645 passes through a driver 646, and is then input to a phase comparison circuit 647. An output of the driver 646 is also input to the phase comparison circuit 647, whereby the phase of the output is compared with the phase of the clock. Based on the
20 result of the comparison, a delay control circuit 648 specifies the magnitude of a delay to be produced by the delay circuit 643. Thus, the writing data Write-Data is phased with the clock R/W-CLK that is the writing clock.

As described so far, according to the present invention, a signal output from an actual circuit is
25 compared with an external clock, and a magnitude of a delay is adjusted so that the output signal has a given phase relationship relative to the external clock. Despite a difference in characteristic of one
30 semiconductor device from another, a change in temperature, a fluctuation in supply voltage, or the like, the phase relationship of the output signal relative to the external clock can be retained accurately at a given value.

Furthermore, a dummy input circuit and dummy output
35 circuit are included. A signal to be compared with the external clock is a signal resembling the actual output signal. The phase of the output signal can be adjusted

accurately.

Furthermore, the phase of rising output data and the phase of falling output data are adjusted. A phase error from the external clock can be minimized.

5 Furthermore, even when a dummy circuit is
manufactured to be analogous to a circuit actually in
charge of output, there is a difference between the dummy
circuit and the actual output circuit. Moreover, a load
10 actually connected to an output terminal is
unpredictable. It is unavoidable that an anticipated
dummy load becomes different from the actual load. Such a
difference leads to an error in adjusted phase. According
to the present invention, the error is taken into account
in adjusting the phase of an output. The error can
15 therefore be further reduced.

Furthermore, even when the amplitude or waveform of
an external clock is different from that of an output of
a dummy output circuit, the phase of the output can be
accurately set to a given phase.

20 Using such a semiconductor device, a semiconductor
system capable of operating at a high speed can be
realized.

CLAIMS:

1. A semiconductor device, comprising:

an input circuit for inputting an external input signal and outputting a reference signal;

5 an output circuit for receiving an output timing signal and outputting an output signal according to the timing of the output timing signal; and

an output timing control circuit for controlling the output timing of the output signal sent from said output circuit so that the output signal exhibits a given phase relative to the external input signal,

10 wherein said output timing control circuit includes:

a delay circuit for which a magnitude of a delay can be specified, and which delays the reference signal by a specified magnitude, and applies a resultant signal as the output timing signal to said output circuit;

20 a phase comparison circuit for comparing the phase of a signal responsive to the output timing signal with the phase of the reference signal; and

a delay control circuit for specifying the magnitude of a delay to be produced by said delay circuit according to the result of comparison performed by said phase comparison circuit.

25 2. A semiconductor device according to claim 1, further comprising a dummy input circuit for inputting the signal responsive to the output timing signal and delaying the output timing signal by a magnitude equal to the magnitude of a delay occurring in said input circuit, wherein said phase comparison circuit compares the phase of an output signal of said dummy input circuit with the phase of said reference signal.

35 3. A semiconductor device according to claim 2, further comprising a dummy output circuit for inputting the output timing signal and delaying the output timing signal by a magnitude equal to the magnitude of a delay occurring in said output circuit, wherein the output

timing signal delayed by said dummy output circuit is input to said dummy input circuit.

4. A semiconductor device according to claim 3, further comprising a dummy load circuit including a given load to be driven by said dummy output circuit, wherein an output of said dummy load circuit is input to said dummy input circuit.

5. A semiconductor device according to claim 1, further comprising a dummy output circuit for inputting the output timing signal and delaying the output timing signal by a magnitude equal to the magnitude of delay occurring in said output circuit, wherein said phase comparison circuit compares the phase of a signal responsive to an output signal of said dummy output circuit with the phase of the reference signal.

6. A semiconductor device according to claim 5, further comprising a dummy load circuit including a given load to be driven by said dummy output circuit, wherein said phase comparison circuit compares the phase of a signal responsive to an output signal of said dummy load circuit with the phase of the reference signal.

7. A semiconductor device according to claim 5 or 6, wherein said output circuit can change the driving characteristic thereof in response to a switching signal, and said dummy output circuit can also change the driving characteristic thereof in response to the switching signal.

8. A semiconductor device according to claim 6, or claim 7 when appended to claim 6, wherein said output circuit can change the driving characteristic thereof in response to a switching signal, and said dummy output circuit can also change the driving characteristic thereof in response to the switching signal.

9. A semiconductor device according to claim 8, wherein said load in said load circuit can be switched in response to the switching signal.

10. A semiconductor device according to any one of claims 5 to 9, wherein a driving power supply for said output circuit is a power supply to which power is supplied externally differently from an internal power supply of said semiconductor device, and a driving power supply for said dummy output circuit is the same as said power supply for said output circuit.

11. A semiconductor device according to claim 1, wherein said delay circuit includes first and second delay circuits; when the output signal is driven high, said output circuit outputs the output signal according to the timing of an output timing signal output from said first delay circuit; when the output signal is driven low, said output circuit outputs the output signal according to the timing of an output timing signal output from said second delay circuit; and said delay control circuit specifies the magnitude of a delay to be produced by said first delay circuit according to the result of comparison performed by said phase comparison circuit when the output signal is driven high, and specifies the magnitude of a delay to be produced by said second delay circuit according to the result of comparison performed by said phase comparison circuit when the output signal is driven low.

12. A semiconductor device according to claim 1, wherein said phase comparison circuit detects the value of an output signal of said output circuit attained when the output signal exhibits a given phase relative to the reference signal, and also detects the values of the output signal of said output circuit attained before and after the output signal exhibits the given phase;

when the values attained before and after the output signal exhibits the given phase are the same as each other, said phase comparison circuit does not carry out a judging operation; and when the values attained before and after the output signal exhibits

the given phase are mutually different, said phase comparison circuit compares phases on the basis of the values attained before and after, and when the output signal exhibits the given phase; and

5 when said phase comparison circuit does not carry out a judging operation, said delay control circuit gives control so that an ongoing magnitude of a delay can be retained; and when said phase comparison circuit carries out the judging operation, said delay control
10 circuit changes the magnitude of a delay according to the result of the judgment.

13. A semiconductor device according to claim 1, further comprising:

15 a dummy data generation circuit for outputting dummy data that makes a state transition at intervals of a given cycle; and

20 an output data switching circuit for switching a signal to be output from said output circuit between a normal data signal and the dummy data output from said dummy data generation circuit,

 wherein during initialization of said semiconductor device, said output circuit outputs the dummy data; and during a normal operation, said output circuit outputs a normal data signal.

25 14. A semiconductor device according to claim 13, wherein said phase comparison circuit detects the value of the output signal of said output circuit attained when the output signal exhibits a given phase relative to the reference signal, and the value of the output
30 signal of said output circuit attained before the output signal exhibits the given phase, compares phases on the basis of the values attained before and when the output signal exhibits the given phase; and

35 during initialization, said delay control circuit changes the magnitude of a delay according to the result of judgment performed by said phase comparison circuit; and after the initialization is completed, said delay control circuit gives control so that said

magnitude of a delay can be retained.

15. A semiconductor device according to any one of claims 5 to 9, further comprising a dummy data generation circuit for generating dummy data that makes
5 a state transition at intervals of a given cycle, wherein said dummy output circuit outputs said dummy data.

16. A semiconductor device according to claim 15, wherein said phase comparison circuit detects the value
10 of the output signal of said output circuit attained when the output signal exhibits a given phase relative to the reference signal, and the value of the output signal of said output circuit attained before the
15 output signal exhibits the given phase, and compares phases on the basis of the values attained before and when the output signal exhibits the given phase.

17. A semiconductor device according to claim 1, further comprising a half phase-shift circuit for
20 generating a half-shifted clock, which has a phase shift of a half cycle relative to the reference signal, from the reference signal output from said input circuit.

18. A semiconductor device according to any one of claims 5 to 9, wherein said input circuit (13)
25 includes a one-Nth frequency divider for generating a one-Nth frequency signal that is a signal whose frequency is one-Nth (where N is an integer) of the frequency of the reference signal and that is in phase with the reference signal, further comprising a dummy
30 delay circuit which inputs an output of said one-Nth frequency divider, for which a magnitude of a delay equal to the magnitude of a delay produced by said delay circuit is specified by said delay control
35 circuit, and which outputs a dummy output timing signal to said dummy output circuit, wherein said dummy output circuit receives a dummy output timing signal sent from said dummy delay circuit on behalf of an output timing signal sent from said delay circuit.

19. A semiconductor device according to claim 18, further comprising a dummy signal line, linking said dummy delay circuit and said dummy output circuit, on which the dummy output timing signal output from said
5 dummy delay circuit is delayed by a magnitude equal to the magnitude of a delay occurring on a signal line linking said delay circuit and said output circuit.

20. A semiconductor device according to claim 18 or 19, wherein said delay circuit includes first and
10 second delay circuits;

said dummy delay circuit includes first and second dummy delay circuits;

when the output signal is high, said output circuit outputs the output signal according to the
15 timing of an output timing signal output from said first delay circuit; and when the output signal is low, said output circuit outputs the output signal according to the timing of an output timing signal output from said second delay circuit;

20 for outputting a high-level signal, said dummy output circuit outputs a dummy output signal according to the timing of a dummy output timing signal output from said first dummy delay circuit; and for outputting a low-level signal, said dummy output circuit outputs a
25 dummy output signal according to the timing of a dummy output timing signal output from said second dummy delay circuit; and

when the dummy output signal is high, said delay control circuit specifies the magnitudes of delays to
30 be produced by said first delay circuit and first dummy delay circuit according to the result of comparison performed by said phase comparison circuit; and when the dummy output signal is low, said delay control circuit specifies the magnitudes of delays to be
35 produced by said second delay circuit and second dummy delay circuit according to the result of comparison performed by said phase comparison circuit.

21. A semiconductor device according to claim 18,

19 or 20, further comprising a dummy data generation circuit for generating dummy data that makes a state transition at intervals of a given cycle, wherein said dummy output circuit outputs the dummy data.

5 22. A semiconductor device according to claim 21, wherein said dummy data is a signal having a duty cycle of 50%.

10 23. A semiconductor device according to claim 21, or 22, wherein said phase comparison circuit detects the value of the output signal of said output circuit attained when the output signal exhibits a given phase relative to the reference signal, and the value of the output signal of said output circuit attained before the output signal exhibits the given phase, and
15 compares phases on the basis of the values attained before and when the output signal exhibits the given phase.

20 24. A semiconductor device according to any one of claims 5 to 9, further comprising:

 a second phase comparison circuit for comparing the phase of a third timing signal with the phase of the reference signal;

25 a second delay control circuit for specifying the magnitude of a delay to be produced by said delay circuit according to the result of comparison performed by said second phase comparison circuit;

30 a switching circuit for switching a signal to be supplied as the third timing signal to said second phase comparison circuit between an output of said output circuit and the dummy output signal; and

 a dummy data generation circuit for generating dummy data used to compare phases,

35 wherein said switching circuit switches the output of said output circuit and the dummy output signal, so that said switching circuit supplies the output of said output circuit to said second phase comparison circuit during initialization of said semiconductor device; and supplies the dummy output signal to said second phase

comparison circuit after the initialization is completed.

25. A semiconductor device according to claim 24,
wherein said output circuit outputs the dummy data
5 during the initialization.

26. A semiconductor device according to claim 25,
wherein said dummy output circuit outputs the dummy
data during the initialization, and outputs data output
from said output circuit after the initialization is
10 completed.

27. A semiconductor device according to claim 25,
wherein said dummy output circuit normally outputs the
dummy data.

28. A semiconductor device according to claim 1,
15 further comprising a dummy input waveform conversion
circuit for converting the output signal to be input to
said output timing control circuit to a dummy input
signal having the same amplitude or waveform as the
external input signal.

29. A semiconductor device according to claim 28,
20 wherein said dummy input waveform conversion circuit
includes a first conversion circuit for outputting a
signal having a large amplitude when the external input
signal is a signal having a large amplitude, and a
25 second conversion circuit for outputting a signal
having a small amplitude when the external input signal
is a signal having a small amplitude.

30. A semiconductor device according to claim 29,
wherein whichever of said first conversion circuit and
30 second conversion circuit should be activated is
determined with an interface judgment signal generated
internally by said semiconductor device.

31. A semiconductor device according to claim 29,
wherein said first conversion circuit is a transfer
35 gate composed of a p-channel transistor and an
n-channel transistor, the output signal is input to one
transistor of said transfer gate, and the dummy input
signal is output from the other transistor thereof.

32. A semiconductor device according to claim 29, wherein said second conversion circuit is composed of a p-channel transistor and n-channel transistor which are connected in series, the output signal is input to one of the transistors, and the dummy input signal is output from the other transistor.

33. A semiconductor device according to claim 32, further comprising a level adjustment circuit for adjusting the gate levels of said p-channel transistor and n-channel transistor.

34. A semiconductor device according to claim 33, wherein said level adjustment circuit has an output terminal through which a potential equal to or lower than $|V_{IL}| - |\text{threshold voltage of p-channel transistor}|$ is developed at the gate of said p-channel transistor of said second conversion circuit, and a potential equal to or higher than $|V_{IH}| - |\text{threshold voltage of n-channel transistor}|$ is developed at the gate of said n-channel transistor thereof.

35. A semiconductor device according to any one of claims 29 to 34, further comprising an input waveform detection circuit for detecting the amplitude or slope of the external input signal and judging whether the external input signal is a signal having a large amplitude or small amplitude, wherein either of said first conversion circuit and second conversion circuit is activated according to the result of the judgment.

36. A semiconductor device according to claim 35, wherein said input waveform detection circuit has at least two reference levels set therein.

37. A semiconductor device according to claim 35, wherein said input waveform detection circuit includes a high-potential latch unit including at least one first latch for latching the result of detecting the high level of the input external input signal.

38. A semiconductor device according to claim 37, wherein said input waveform detection circuit includes

an adjustment latching timing control circuit for adjusting the timing of a latching operation performed by said high-potential latch unit.

5 39. A semiconductor device according to claim 38, wherein said adjustment latching timing control circuit operates responsively to a signal synchronous with the external input signal.

10 40. A semiconductor device according to claim 39, wherein said adjustment latching timing control circuit outputs a first pulse generated at the leading edge of the external input signal and a second pulse generated at the trailing edge of the external input signal, said high-potential latch unit carries out a latching operation synchronously with the first pulse, and said low-potential latch unit carries out a latching operation synchronously with the second pulse.

15 41. A semiconductor device according to claim 35, wherein said input waveform detection circuit includes a low-potential latch unit including at least one second latch for latching the result of detecting the low level of the input external input signal.

20 42. A semiconductor device according to claim 41, wherein said input waveform detection circuit includes an adjustment latching timing control circuit for adjusting the timing of a latching operation performed by said low-potential latch unit.

25 43. A semiconductor device according to claim 28, wherein said dummy input waveform conversion circuit produces a delay equivalent to a delay caused by resistors lying on a signal path within an ESD circuit, interposed between said input terminal and input circuit, for improving a withstanding voltage against static electricity.

30 44. A semiconductor device according to claim 43, wherein said first conversion circuit is a transfer gate composed of a p-channel transistor and n-channel transistor, the output signal is input to one transistor of said transfer gate, the dummy input

signal is output from the other transistor thereof, and the resistance of said transfer gate is set to be equal to a resistance occurring on the signal path within said ESD circuit.

5 45. A semiconductor device according to claim 43, wherein said second conversion circuit is composed of a p-channel transistor and n-channel transistor which are connected in series, the output signal is input to one of the transistors, the dummy input signal is output
10 from the other transistor, and a sum of the resistances of said p-channel transistor and the n-channel transistor is set to equal to a resistance occurring on the signal path within said ESD circuit.

15 46. A semiconductor device according to claim 1, wherein said external input signal is a clock whose rise and fall are 180° out of phase, said semiconductor device fetches data synchronously with one of the rise and fall of the external input signal, and output of
20 the output signal from said output circuit is controlled to be synchronized with one of the leading and trailing edges of the external input signal.

25 47. A semiconductor device according to claim 1, wherein a plurality of said output circuits are included, and the same magnitude of a delay occurs on signal paths along which the reference signal is
transmitted from said input circuit to said output circuits.

30 48. A semiconductor device according to claim 47, wherein signal paths along which the reference signal is transmitted from said input circuit to said plurality of output circuits constitute an equidistant wiring.

35 49. A semiconductor device according to claim 1, wherein a plurality of said output circuits are included, and said timing control circuit is associated with each output circuit.

50. A semiconductor device according to claim 1, wherein said semiconductor device is a synchronous

semiconductor memory.

51. A semiconductor device for inputting or outputting data synchronously with an external clock whose rise and fall are 180° out of phase, comprising:

5 a data output circuit for outputting data synchronously with one of the rise and fall; and
 a data input circuit for fetching data synchronously with the other one of the rise and fall.

52. A semiconductor device according to claim 51, further comprising a timing signal generation circuit for generating an output timing signal and input timing signal from the external clock, wherein said data output circuit outputs data according to the output timing signal, and said data input circuit inputs data according to the input timing signal.

53. A semiconductor device according to claim 52, wherein said timing signal generation circuit includes a delay circuit for delaying the output timing signal, and a timing comparison circuit for comparing the output timing signal with the external clock; and based on the result of the comparison performed by said timing comparison circuit, the magnitude of a delay to be produced by said delay circuit is controlled so that output of data from said data output circuit can be synchronized with one of the rise and fall.

54. A semiconductor system, having a plurality of semiconductor devices interconnected, for outputting data synchronously with a first external signal and inputting data synchronously with a second external signal,

30 wherein a line over which data items output from said semiconductor devices are transmitted, and a line over which the first external signal is transmitted are arranged in parallel with each other, and the
35 transmission direction of the output data items and the transmission direction of the first external signal are the same.

55. A semiconductor system according to claim 54,

wherein a line over which data input to said semiconductor devices is transmitted and a line over which the second external signal is transmitted are arranged in parallel with each other, and the transmission direction of the input data and the transmission direction of the second external signal are the same.

56. A digital delay circuit comprising a delay line which has a plurality of signal paths connected in series and for which a magnitude of a delay can be specified by selectively outputting a signal along part of said plurality of signal paths, and a delay control circuit for specifying the magnitude of a delay to be produced by said delay line, said magnitude of a delay being changed stepwise,

wherein said delay control circuit includes:

a shift register in which complementary signals are output by each stage, one complementary signal is output by each stage ending with a certain stage, reversed complementary signals are output by stages succeeding the certain stage, and the position of a stage for outputting the reversed complementary signals first is shifted; and

gates each calculating the logic function of one of the complementary signals output from one stage of said shift register and the other of the complementary signals output from an adjoining stage thereof, said delay line being selectively activated on the basis of the outputs of said gates,

wherein said gates each output a signal for activating said delay line when one of the complementary signals output from said shift register, which makes a state transition slowly, represents an original logical stage.

57. A digital delay circuit, comprising:

a delay line which has a plurality of signal paths connected in series and for which a magnitude of a delay can be specified by selectively activating part

of said plurality of signal paths; and

a delay control circuit for specifying the magnitude of a delay to be produced by said delay line, the magnitude of a delay being changed stepwise,

5 wherein said delay control circuit activates at least two adjoining signal paths within said delay line.

10 58. A synchronous DRAM substantially as hereinbefore described with reference to Figures 9 to 25, Figure 26, Figure 27, Figure 28, Figures 29 to 32, Figures 34 to 39, Figures 40 to 47, Figure 48, Figures 49 to 53, Figures 54 and 55, Figure 56 or Figure 80 of the accompanying drawings.

15 59. An output timing control circuit substantially as hereinbefore described with reference to Figures 65 to 69, Figure 71, Figures 72A, 72B and 73, or Figures 74 to 79 of the accompanying drawings.

20 60. A semiconductor system substantially as hereinbefore described with reference to Figures 83 and 84, Figures 85 and 86, Figures 87 and 88, or Figures 89 and 90 of the accompanying drawings.



Application No: GB 9715131.0
Claims searched: 1-50

Examiner: Brian Ede
Date of search: 29 September 1997

Patents Act 1977
Search Report under Section 17

Databases searched:

UK Patent Office collections, including GB, EP, WO & US patent specifications, in:

UK Cl (Ed.O): G4C(C700T, C800T, C11407T) H3A(ASX, AXE)

Int Cl (Ed.6): G11C 7/00 8/00 11/407 H03L 7/081

Other: Online: WPI

Documents considered to be relevant:

Category	Identity of document and relevant passage	Relevant to claims
X	GB 2129634 A (CONTROL DATA CORPORATION) see Fig 4	1 at least
X	GB 1338776 (INTERNATIONAL STANDARD ELECTRIC) see Fig 1	1 at least
X	EP 0463641 A2 (HITACHI) see Fig 1	1 at least
X	EP 0445574 A2 (THINKING MACHINES CORPORATION) see Fig 1	1 at least
E X	US 5610543 (MOTOROLA) see Fig 3	1 at least
X	US 5544203 (TEXAS) see Fig 2	1 at least
X	US 5514990 (TOSHIBA) see Fig 1	1 at least
X	US 5355037 (TEXAS) see Fig 1	1 at least

X	Document indicating lack of novelty or inventive step	A	Document indicating technological background and/or state of the art.
Y	Document indicating lack of inventive step if combined with one or more other documents of same category.	P	Document published on or after the declared priority date but before the filing date of this invention.
&	Member of the same patent family	E	Patent document published on or after, but with priority date earlier than, the filing date of this application.



Application No: GB 9715131.0
Claims searched: 51-53

Examiner: Brian Ede
Date of search: 13 January 1998

Patents Act 1977
Further Search Report under Section 17

Databases searched:

UK Patent Office collections, including GB, EP, WO & US patent specifications, in:
UK Cl (Ed.P): G4A(AFT) G4C(C700B4, C700BX, C700T, C800T, C11407T)
H3A(ARR, ARX, ASD, ASX) H4P(PSEX)
Int Cl (Ed.6): G06F 1/04 1/06 1/10 1/12 G11C 7/00 8/00 11/407 H04L 7/00
Other: Online: WPI

Documents considered to be relevant:

Category	Identity of document and relevant passage	Relevant to claims
X	GB 2246004 A (SAMSUNG) see Figs 1 and 8	51
A	GB 2243060 A (APPLE COMPUTER INC) see Figs 2 and 8	51
X	US 4100541 (THE USA AS REPRESENTED BY THE SECRETARY OF STATE OF THE NAVY) see Figs 1 and 3	51

X	Document indicating lack of novelty or inventive step	A	Document indicating technological background and/or state of the art.
Y	Document indicating lack of inventive step if combined with one or more other documents of same category.	P	Document published on or after the declared priority date but before the filing date of this invention.
&	Member of the same patent family	E	Patent document published on or after, but with priority date earlier than, the filing date of this application.



Application No: GB 9715131.0
Claims searched: 54 and 55

Examiner: Brian Ede
Date of search: 13 January 1998

Patents Act 1977
Further Search Report under Section 17

Databases searched:

UK Patent Office collections, including GB, EP, WO & US patent specifications, in:

UK Cl (Ed.P): G4C(C700B5, C804)

Int Cl (Ed.6): G11C 7/00 8/04

Other: Online: WPI

Documents considered to be relevant:

Category	Identity of document and relevant passage	Relevant to claims
P A	GB 2304435 A (FUJITSU) 19.03.97 see Fig 4	54
A	EP 0127508 A2 (ANOLOGIC) whole document relevant	54
A	WO94/29870A1 (MICROUNITY SYSTEMS) see Fig 2	54
X	US 5060145 (UNISYS) see Fig 1, 3A and 3B	54 and 55

X	Document indicating lack of novelty or inventive step	A	Document indicating technological background and/or state of the art.
Y	Document indicating lack of inventive step if combined with one or more other documents of same category.	P	Document published on or after the declared priority date but before the filing date of this invention.
&	Member of the same patent family	E	Patent document published on or after, but with priority date earlier than, the filing date of this application.



Application No: GB 9715131.0
Claims searched: 56

Examiner: Brian Ede
Date of search: 13 January 1998

Patents Act 1977
Further Search Report under Section 17

Databases searched:

UK Patent Office collections, including GB, EP, WO & US patent specifications, in:

UK Cl (Ed.P): G4C(C700T, C800T) H3A(AXE) H3P(PPMD, PPMP)

Int Cl (Ed.6): G11C 7/00 8/00 H03K 5/13 5/135 H03L 7/081

Other: Online: WPI

Documents considered to be relevant:

Category	Identity of document and relevant passage	Relevant to claims
X	GB 2251994 A (SONY) see Figs 1, 2 and 7	56
X	EP 0639003 A1 (ADVANCED MICRO DEVICES INC) see Figs 2 and 7	56
X	US 5554949 (US PHILIPS) see Fig 1	56
X	US 5528200 (NIPPONDENSO) see Fig 3	56
X	US 5287025 (MATSUSHITA) see Fig 1	56

X Document indicating lack of novelty or inventive step
Y Document indicating lack of inventive step if combined with one or more other documents of same category.

& Member of the same patent family

A Document indicating technological background and/or state of the art.
P Document published on or after the declared priority date but before the filing date of this invention.
E Patent document published on or after, but with priority date earlier than, the filing date of this application.



Application No: GB 9715131.0
Claims searched: 57

Examiner: Brian Ede
Date of search: 13 January 1998

Patents Act 1977
Further Search Report under Section 17

Databases searched:

UK Patent Office collections, including-GB, EP, WO & US patent specifications, in:

UK Cl (Ed.P): G4C(700T, 800T) H3A(AXE) H3P(PPMD, PPMP)

Int Cl (Ed.6): G11C 7/00 8/00 H03K 5/13 5/135 H03L 7/081

Other: Online: WPI

Documents considered to be relevant:

Category	Identity of document and relevant passage	Relevant to claims
X	EP 0647025 A1 (ADVANCED MICRO DEVICES INC) whole document relevant	57
X	EP 0639003 A1 (ADVANCED MICRO DEVICES INC) see Figs 2 and 7	57
X	US 5554949 (US PHILIPS) see Fig 1	57
X	US 5528200 (NIPPONDENSO) see Fig 3	57
X	US 5287025 (MATSUSHITA) see Fig 1	57

X	Document indicating lack of novelty or inventive step	A	Document indicating technological background and/or state of the art.
Y	Document indicating lack of inventive step if combined with one or more other documents of same category.	P	Document published on or after the declared priority date but before the filing date of this invention.
&	Member of the same patent family	E	Patent document published on or after, but with priority date earlier than, the filing date of this application.

**This Page is Inserted by IFW Indexing and Scanning
Operations and is not part of the Official Record**

BEST AVAILABLE IMAGES

Defective images within this document are accurate representations of the original documents submitted by the applicant.

Defects in the images include but are not limited to the items checked:

- ☒ **BLACK BORDERS**
- ☐ **IMAGE CUT OFF AT TOP, BOTTOM OR SIDES**
- ☒ **FADED TEXT OR DRAWING**
- ☐ **BLURRED OR ILLEGIBLE TEXT OR DRAWING**
- ☐ **SKEWED/SLANTED IMAGES**
- ☐ **COLOR OR BLACK AND WHITE PHOTOGRAPHS**
- ☐ **GRAY SCALE DOCUMENTS**
- ☐ **LINES OR MARKS ON ORIGINAL DOCUMENT**
- ☐ **REFERENCE(S) OR EXHIBIT(S) SUBMITTED ARE POOR QUALITY**
- ☐ **OTHER:** _____

IMAGES ARE BEST AVAILABLE COPY.

As rescanning these documents will not correct the image problems checked, please do not report these problems to the IFW Image Problem Mailbox.